

# Femtosecond Laser Nanostructuring of Semiconductors and Metals

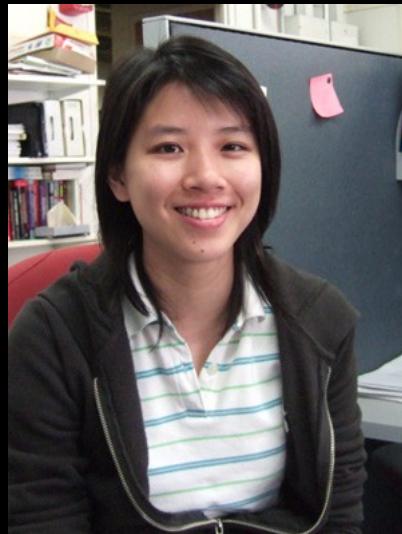


13th International LPM Symposium  
The Catholic University of America  
Washington, DC, 14 June 2012





Renee Sher



Yu-Ting Lin



Kasey Phillips



Ben Franta



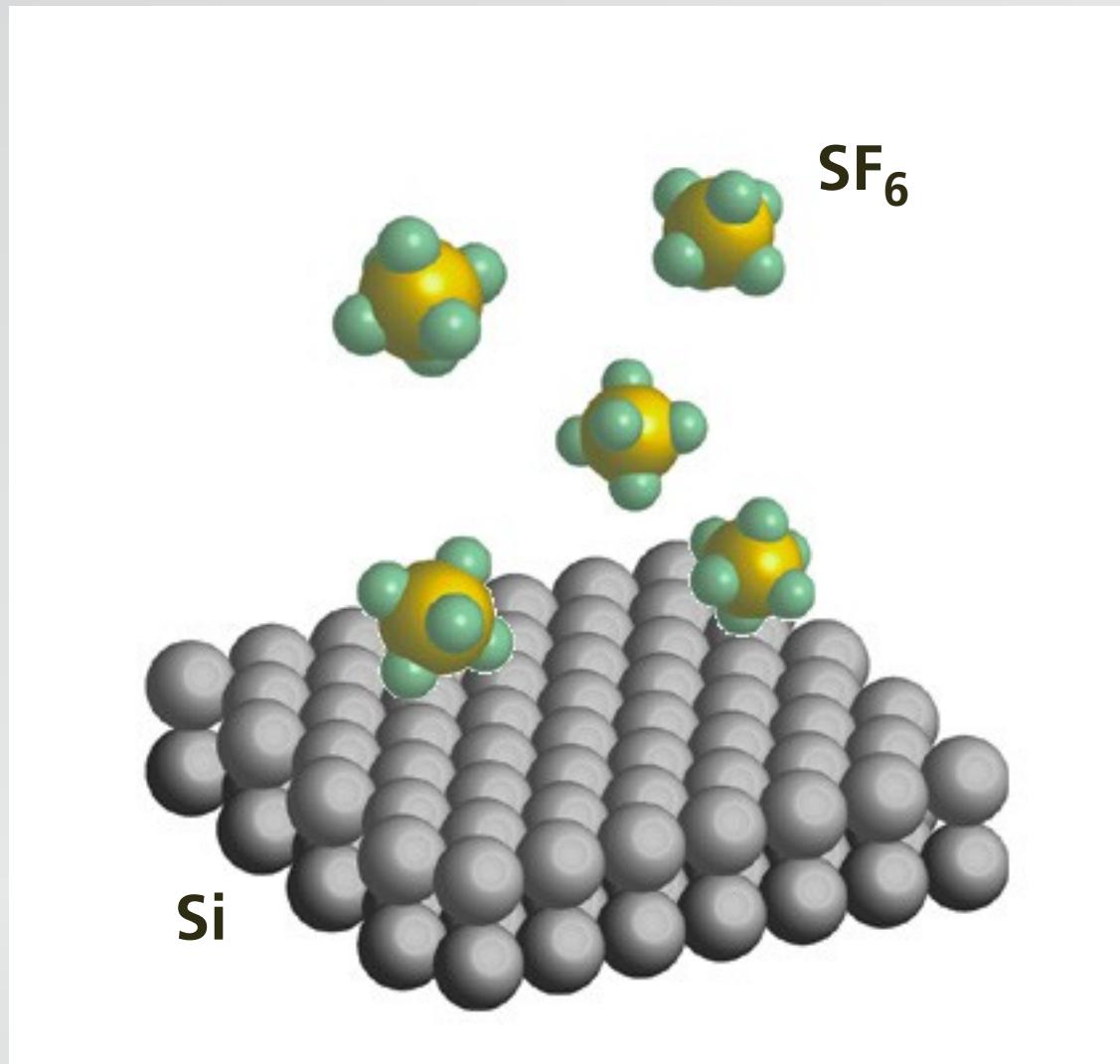
eric\_mazur

and also....

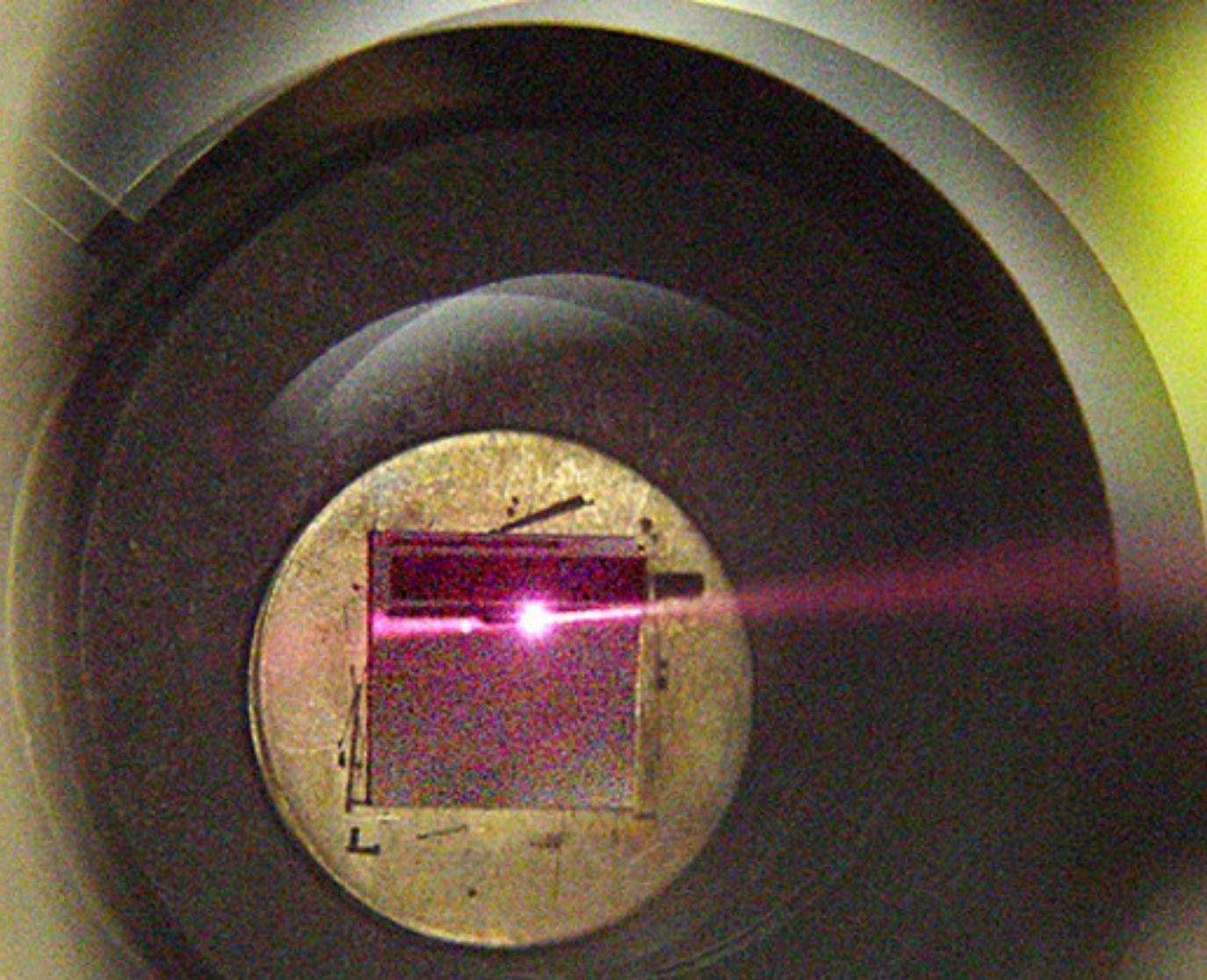
**Marc Winkler**  
**Eric Diebold**  
**Haifei Albert Zhang**  
**William Whitney**  
**Dr. Brian Tull**  
**Dr. Jim Carey**  
**Prof. Tsing-Hua Her**  
**Dr. Shrenik Deliwala**  
**Dr. Richard Finlay**  
**Dr. Michael Sheehy**  
**Dr. Claudia Wu**  
**Dr. Rebecca Younkin**  
**Prof. Catherine Crouch**  
**Prof. Mengyan Shen**  
**Prof. Li Zhao**  
  
**Dr. Elizabeth Landis**  
**Dr. John Chervinsky**  
**Dr. Joshua Levinson**  
  
**Prof. Michael Aziz**  
**Prof. Cynthia Friend**  
**Prof. Howard Stone**

**Prof. Tonio Buonassisi (MIT)**  
**Prof. Silvija Gradecak (MIT)**  
**Dr. Bonna Newman (MIT)**  
**Joe Sullivan (MIT)**  
**Matthew Smith (MIT)**  
  
**Prof. Augustinus Asenbaum (Vienna)**  
  
**Dr. François Génin (LLNL)**  
**Mark Wall (LLNL)**  
  
**Dr. Richard Farrell (RMD)**  
**Dr. Arieh Karger (RMD)**  
**Dr. Richard Meyers (RMD)**  
  
**Dr. Pat Maloney (NVSED)**  
  
**Dr. Jeffrey Warrander (ARDEC)**

...and the people at SiOnyx

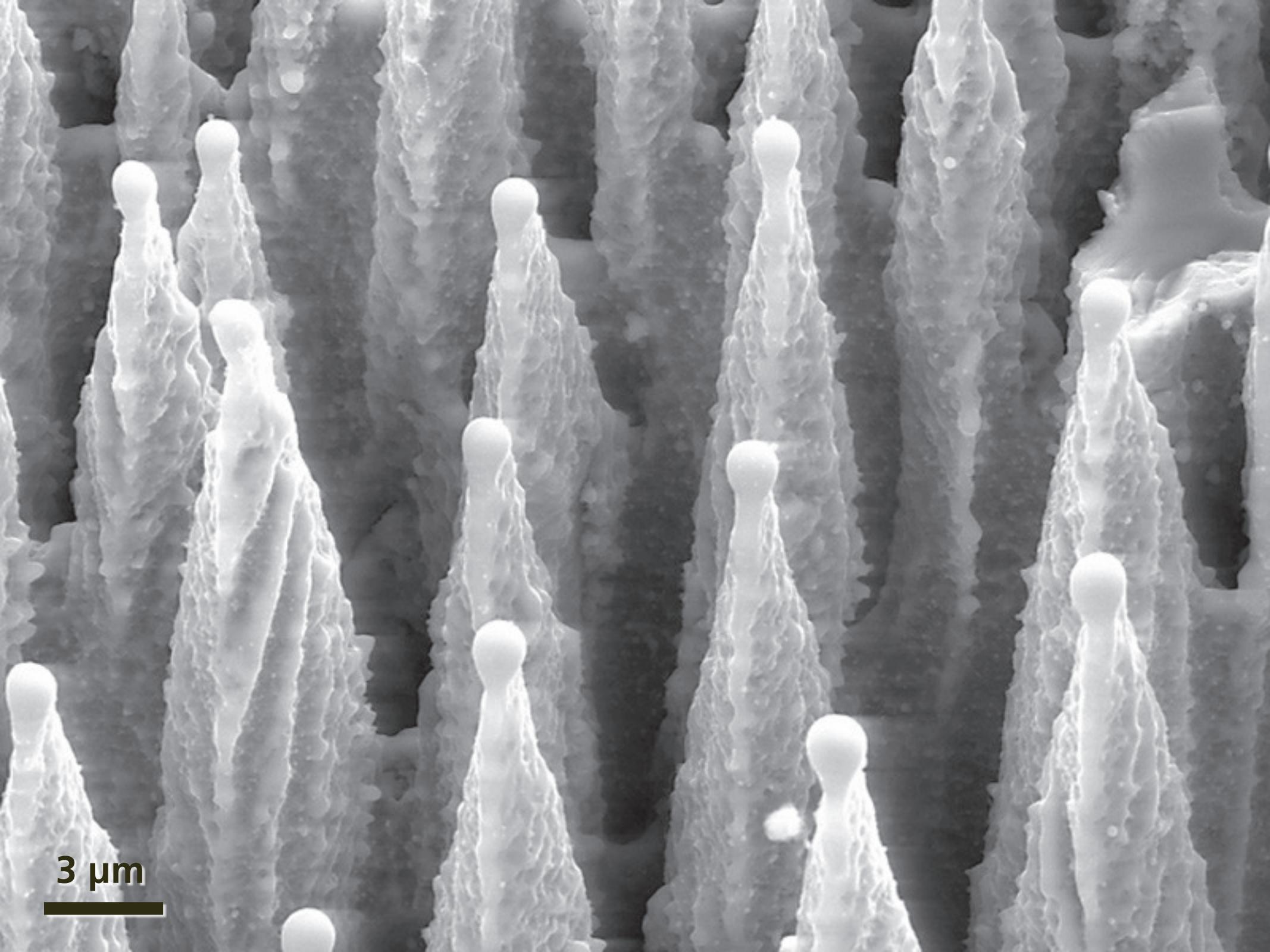


**irradiate with 100-fs 10 kJ/m<sup>2</sup> pulses**



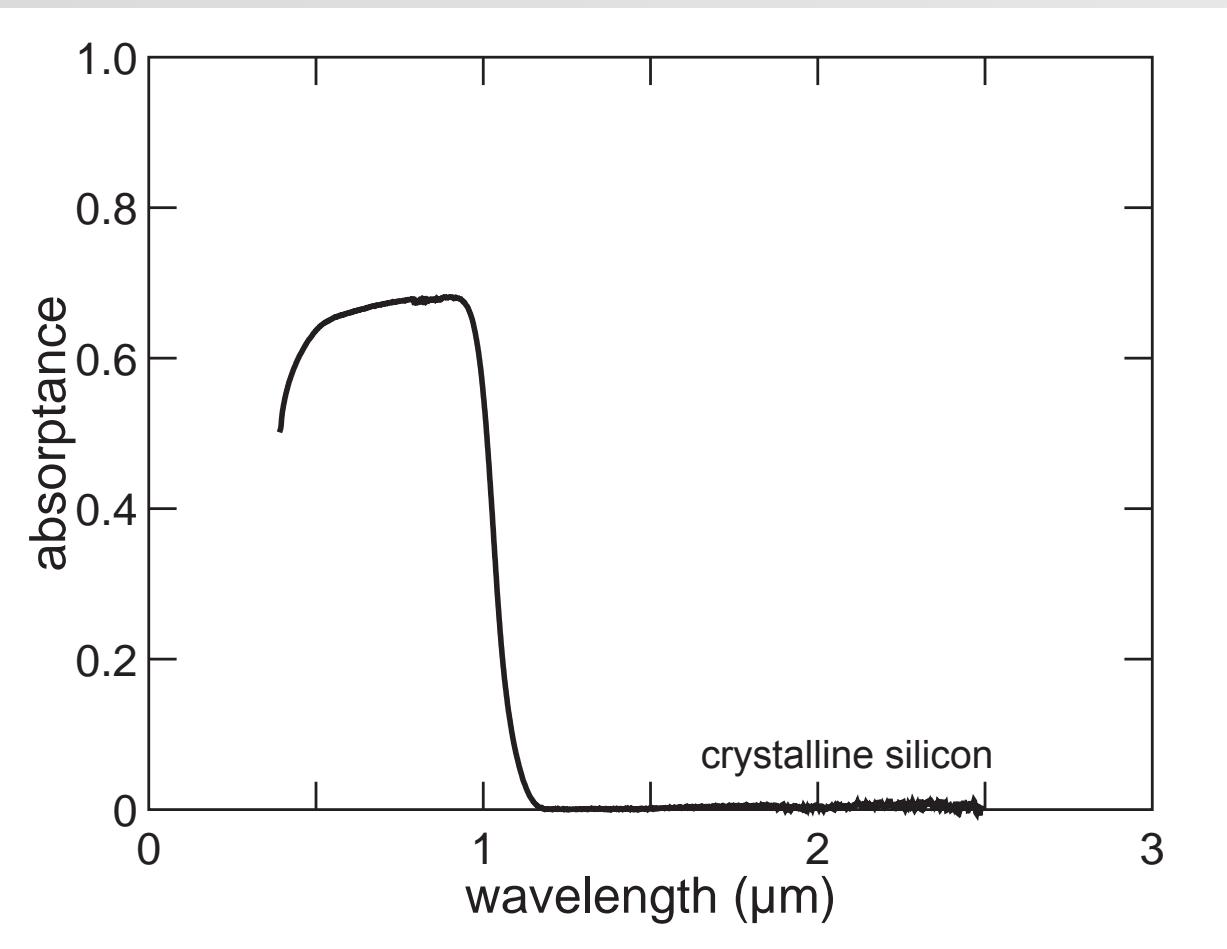


**"black silicon"**

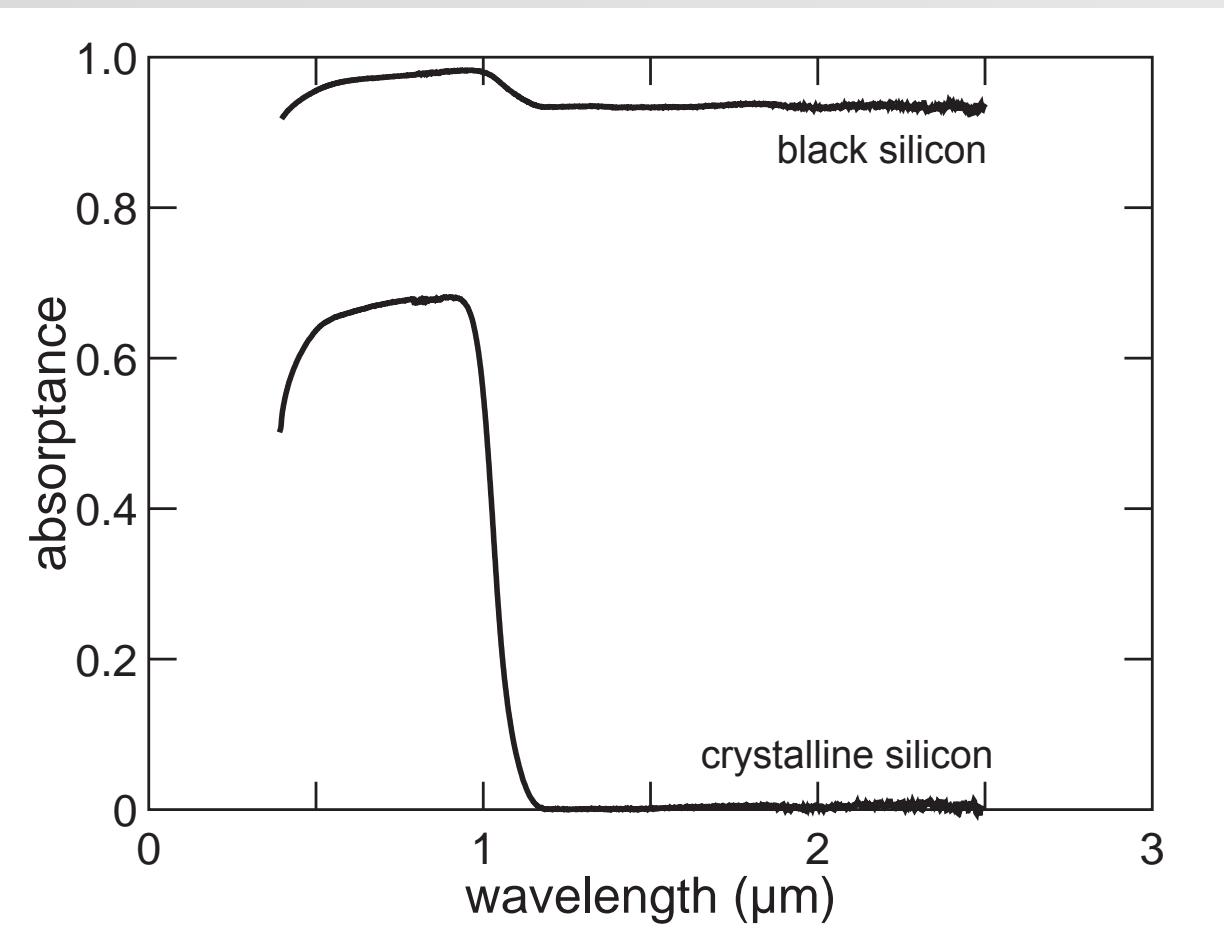


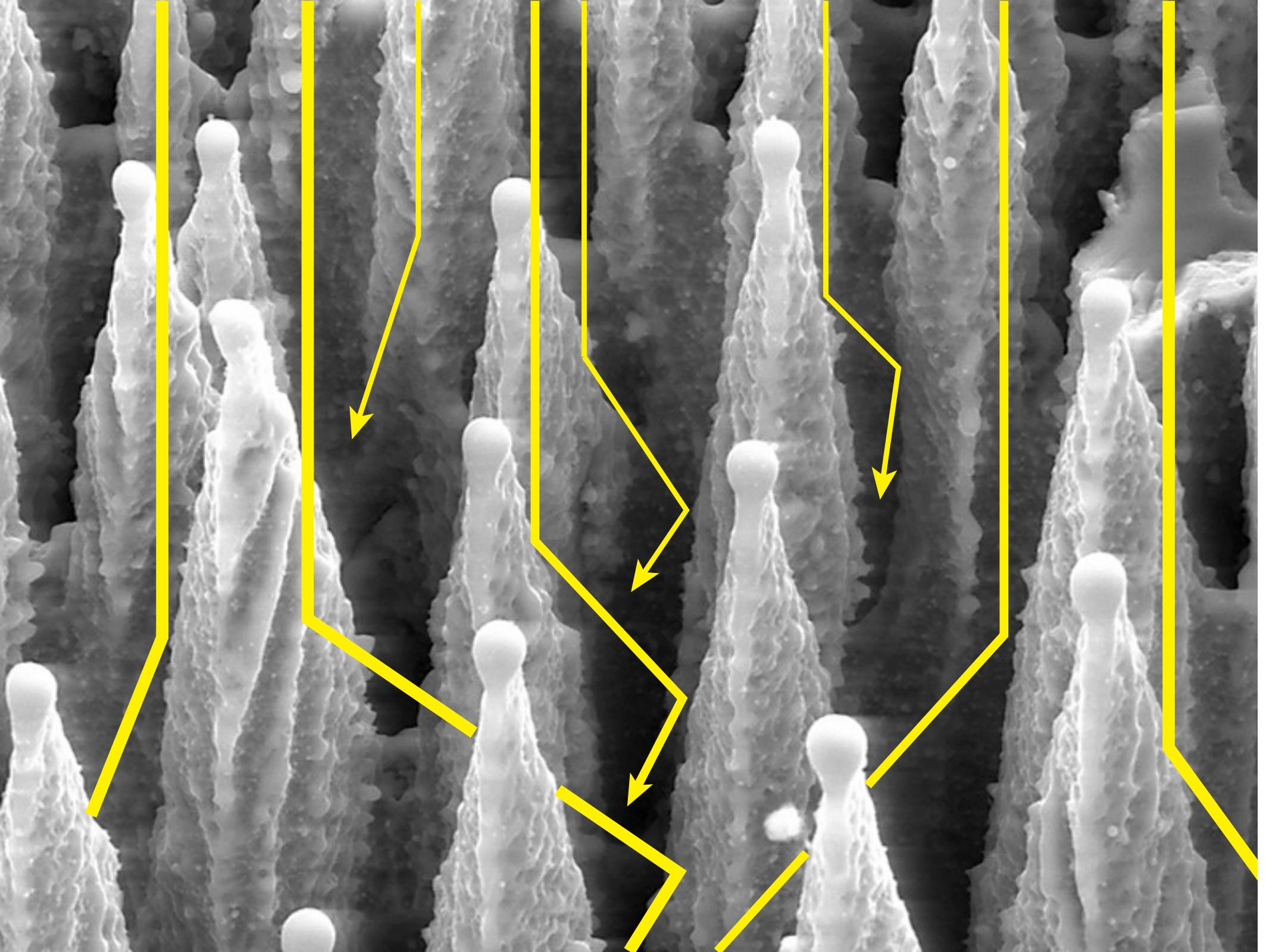
3  $\mu\text{m}$

**absorptance ( $1 - R_{int} - T_{int}$ )**

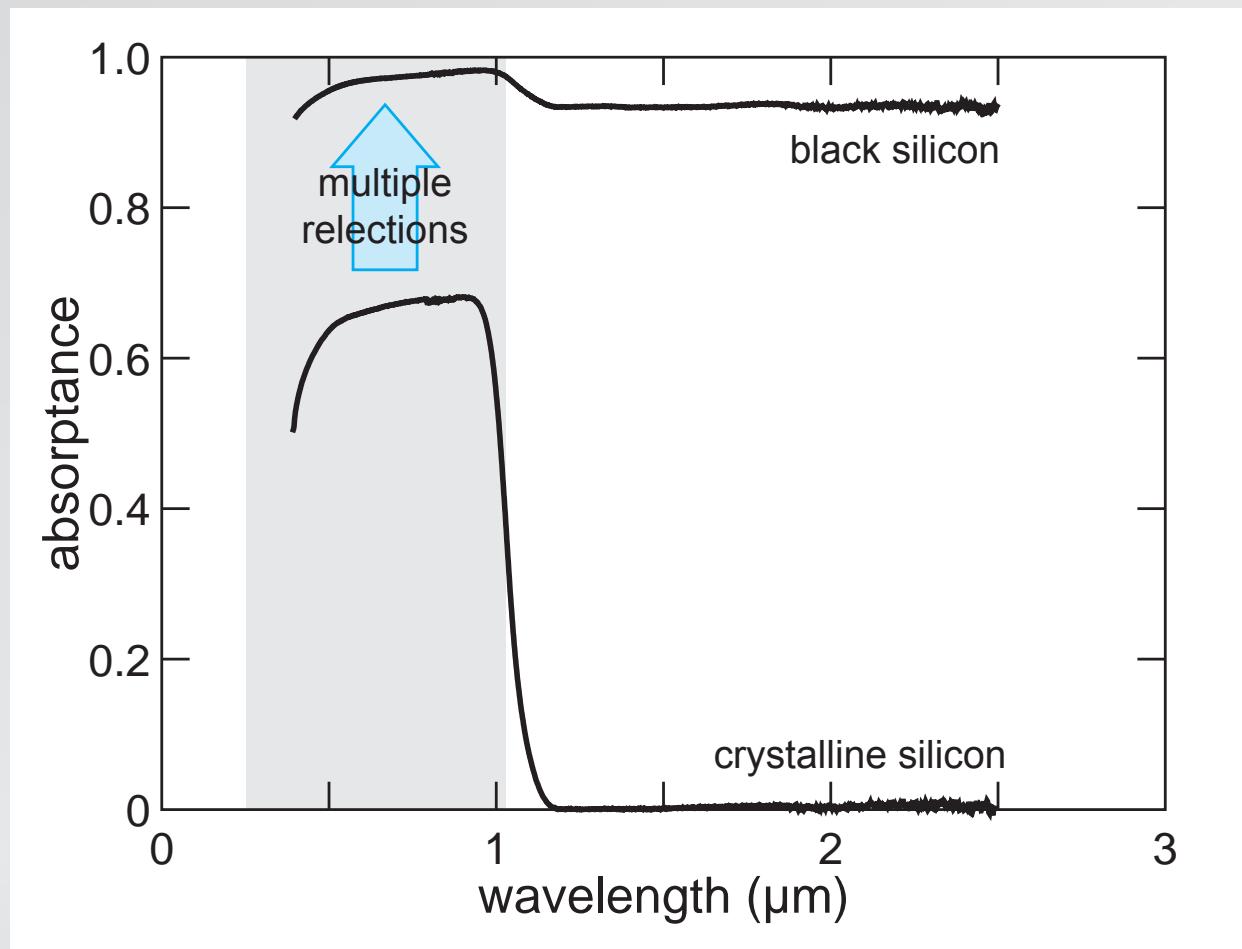


**absorptance ( $1 - R_{int} - T_{int}$ )**

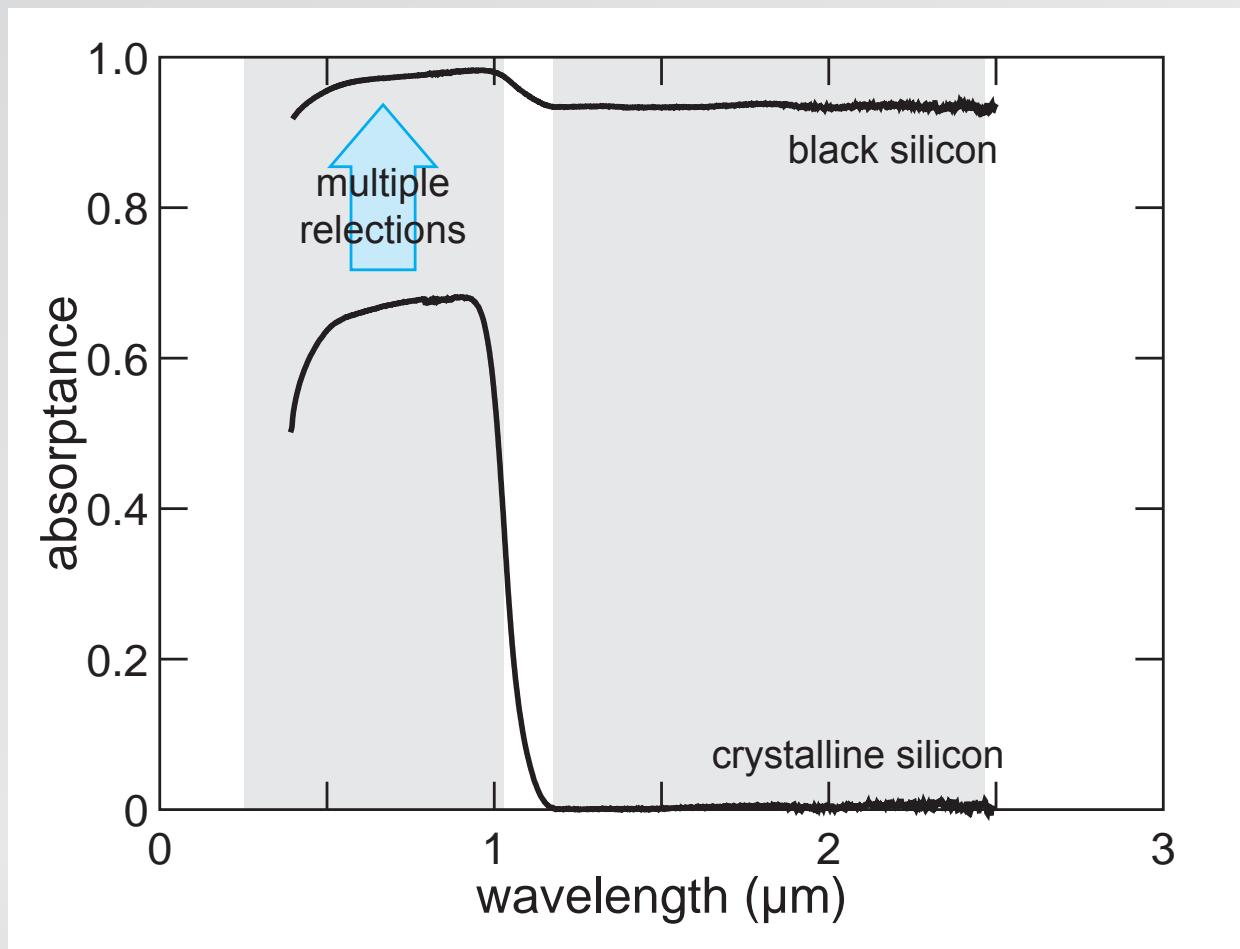




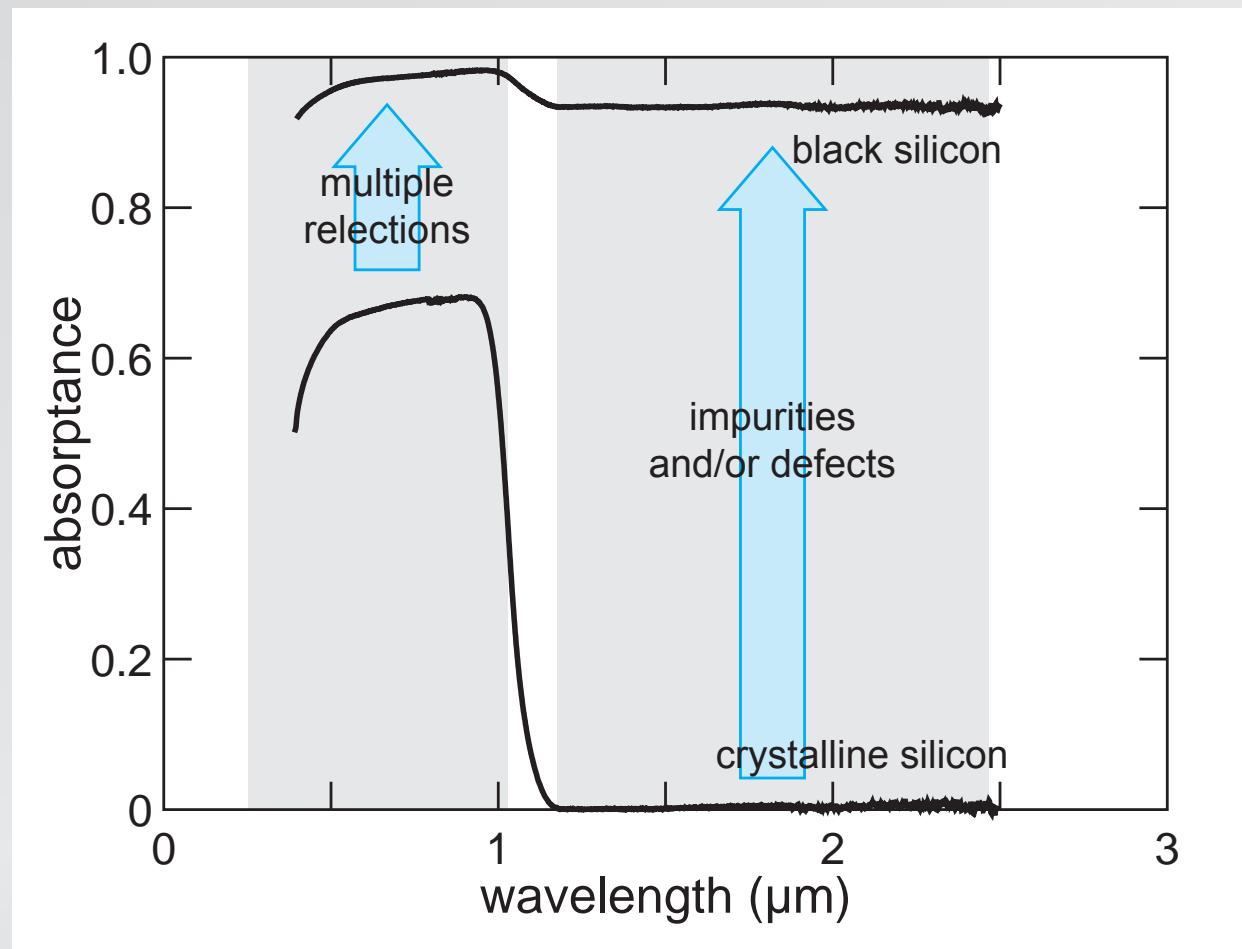
## absorptance ( $1 - R_{int} - T_{int}$ )



## absorptance ( $1 - R_{int} - T_{int}$ )



## absorptance ( $1 - R_{int} - T_{int}$ )



**laser treatment causes:**

- **surface structuring**
- **inclusion of dopants**

# substrate/dopant combinations

dopants:

I	II													VIII			
H	Be													He			
Li	Mg																
Na																	
K	Ca	Sc	Ti	V	Cr	Mn	Fe	Co	Ni	Cu	Zn	Ga	Ge	As	Se	Br	Kr
Rb	Sr	Y	Zr	Nb	Mo	Tc	Ru	Rh	Pd	Ag	Cd	In	Sn	Sb	Te	I	Xe

substrates:

Si

# substrate/dopant combinations

## dopants:

I	II	III	IV	V	VI	VII	VIII											
H	Be	B	C	N	O	F	He											
Li	Mg	Al	Si	P	S	Cl	Ar											
Na	K	Ca	Sc	Ti	V	Cr	Mn	Fe	Co	Ni	Cu	Zn	Ga	Ge	As	Se	Br	Kr
Rb	Sr	Y	Zr	Nb	Mo	Tc	Ru	Rh	Pd	Ag	Cd	In	Sn	Sb	Te	I	Xe	

## **substrates:**

Si

# substrate/dopant combinations

dopants:

I															VIII
H	II														He
Li	Be														B
Na	Mg														C
K	Ca	Sc	Ti	V	Cr	Mn	Fe	Co	Ni	Cu	Zn	Ga	Ge	As	N
Rb	Sr	Y	Zr	Nb	Mo	Tc	Ru	Rh	Pd	Ag	Cd	In	Sn	Sb	O
														Te	F
														I	Ne
															Ar
															Kr
															Xe

substrates:

Si

# substrate/dopant combinations

## dopants:

I	II	III	IV	V	VI	VII	VIII										
H	Be	B	C	N	O	F	He										
Li	Mg	Al	Si	P	S	Cl	Ne										
Na		Ga	Ge	As	Se	Br	Ar										
K	Ca	Sc	Ti	V	Cr	Mn	Fe	Co	Ni	Cu	Zn	Ga	Ge	As	Se	Br	Kr
Rb	Sr	Y	Zr	Nb	Mo	Tc	Ru	Rh	Pd	Ag	Cd	In	Sn	Sb	Te	I	Xe

## substrates:

Si      Ge      ZnO    InP    GaAs

Ti      Ag      Al      Cu      Pd      Rh      Ta      Pt      TiO<sub>2</sub>

# substrate/dopant combinations

## dopants:

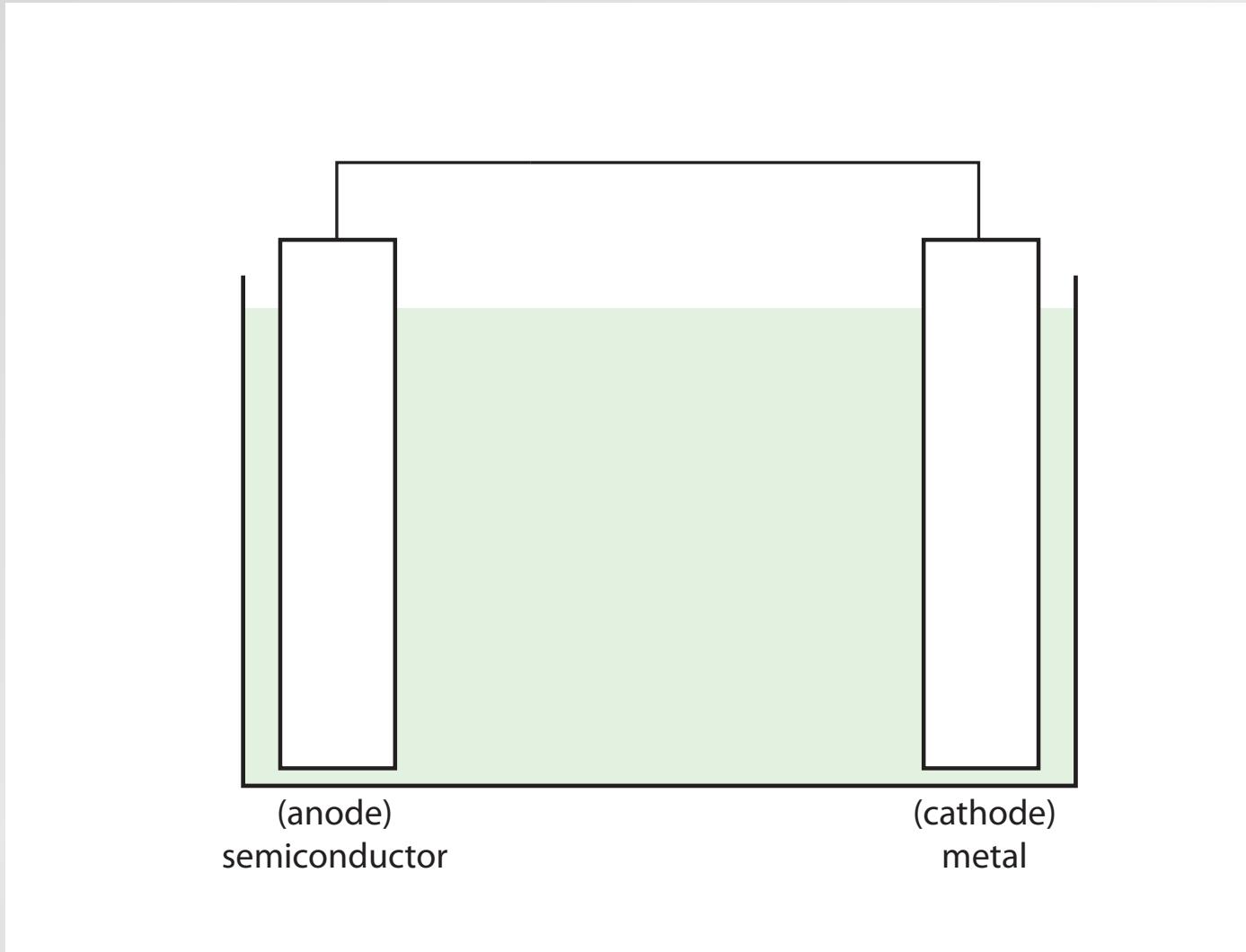
I	II	III	IV	V	VI	VII	VIII										
H	Be	B	C	N	O	F	He										
Li	Mg	Al	Si	P	S	Cl	Ne										
Na		Ga	Ge	As	Se	Br	Ar										
K	Ca	Sc	Ti	V	Cr	Mn	Fe	Co	Ni	Cu	Zn	Ga	Ge	As	Se	Br	Kr
Rb	Sr	Y	Zr	Nb	Mo	Tc	Ru	Rh	Pd	Ag	Cd	In	Sn	Sb	Te	I	Xe

## substrates:

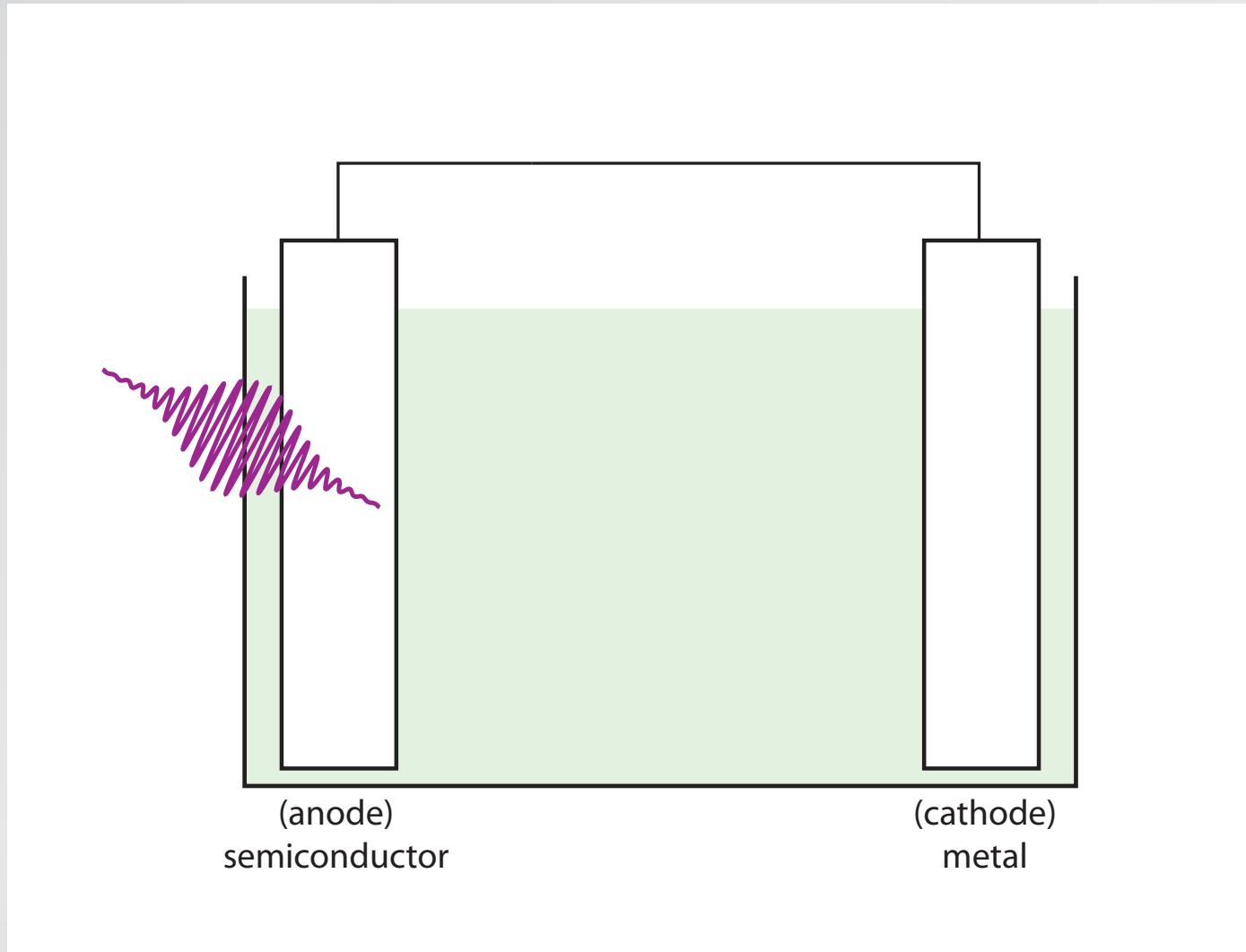
Si      Ge      ZnO    InP    GaAs

Ti      Ag      Al      Cu      Pd      Rh      Ta      Pt      **TiO<sub>2</sub>**

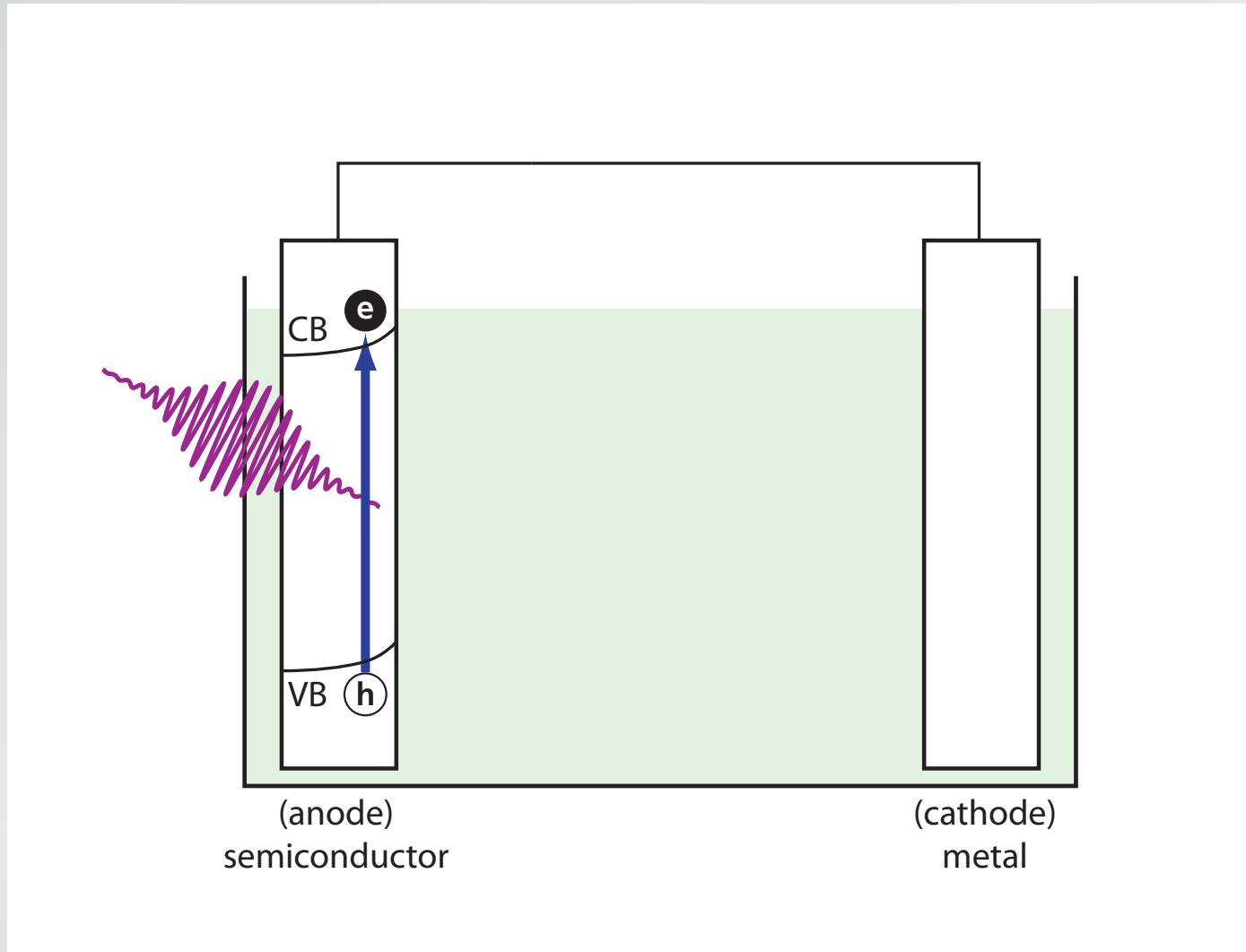
# water splitting



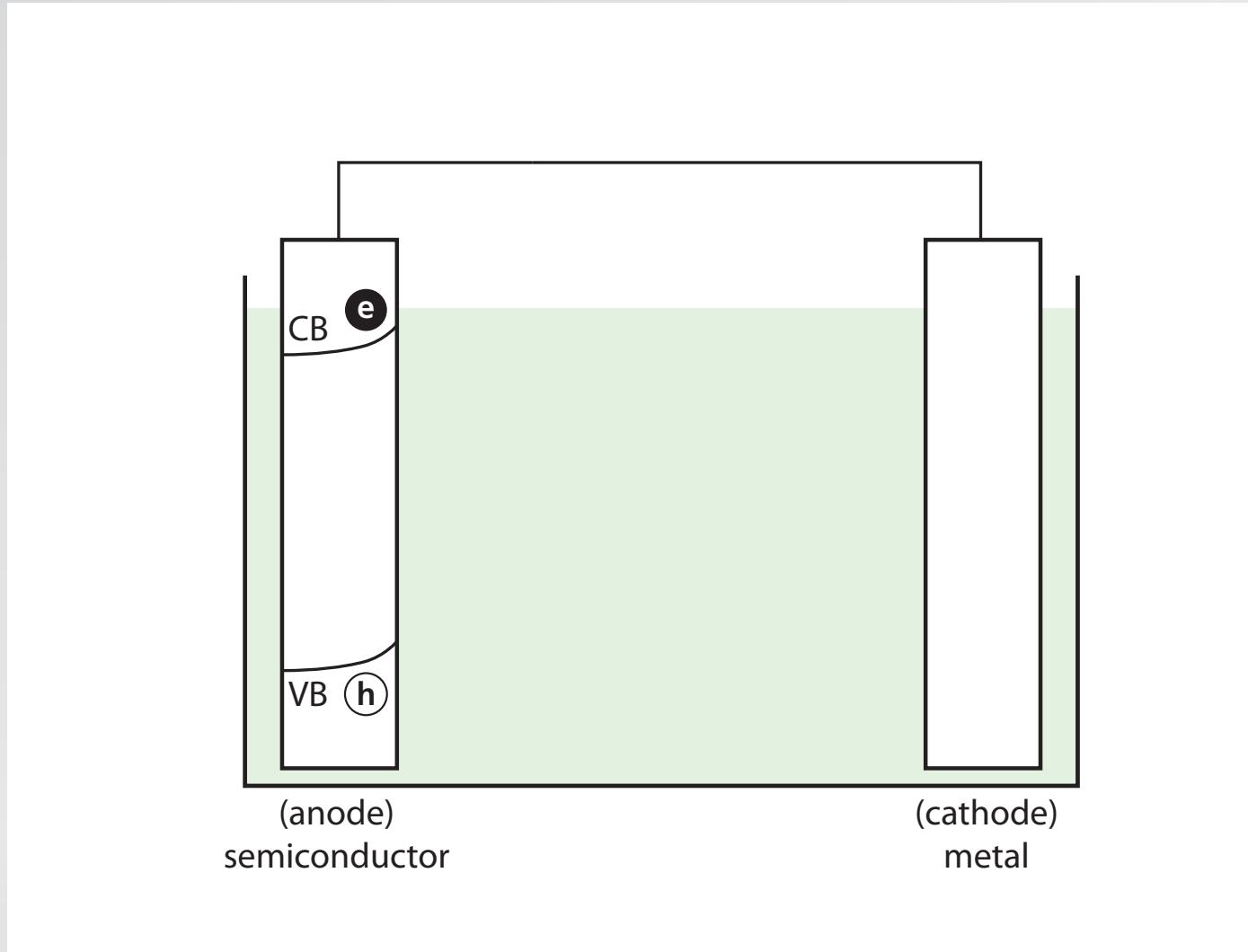
# water splitting



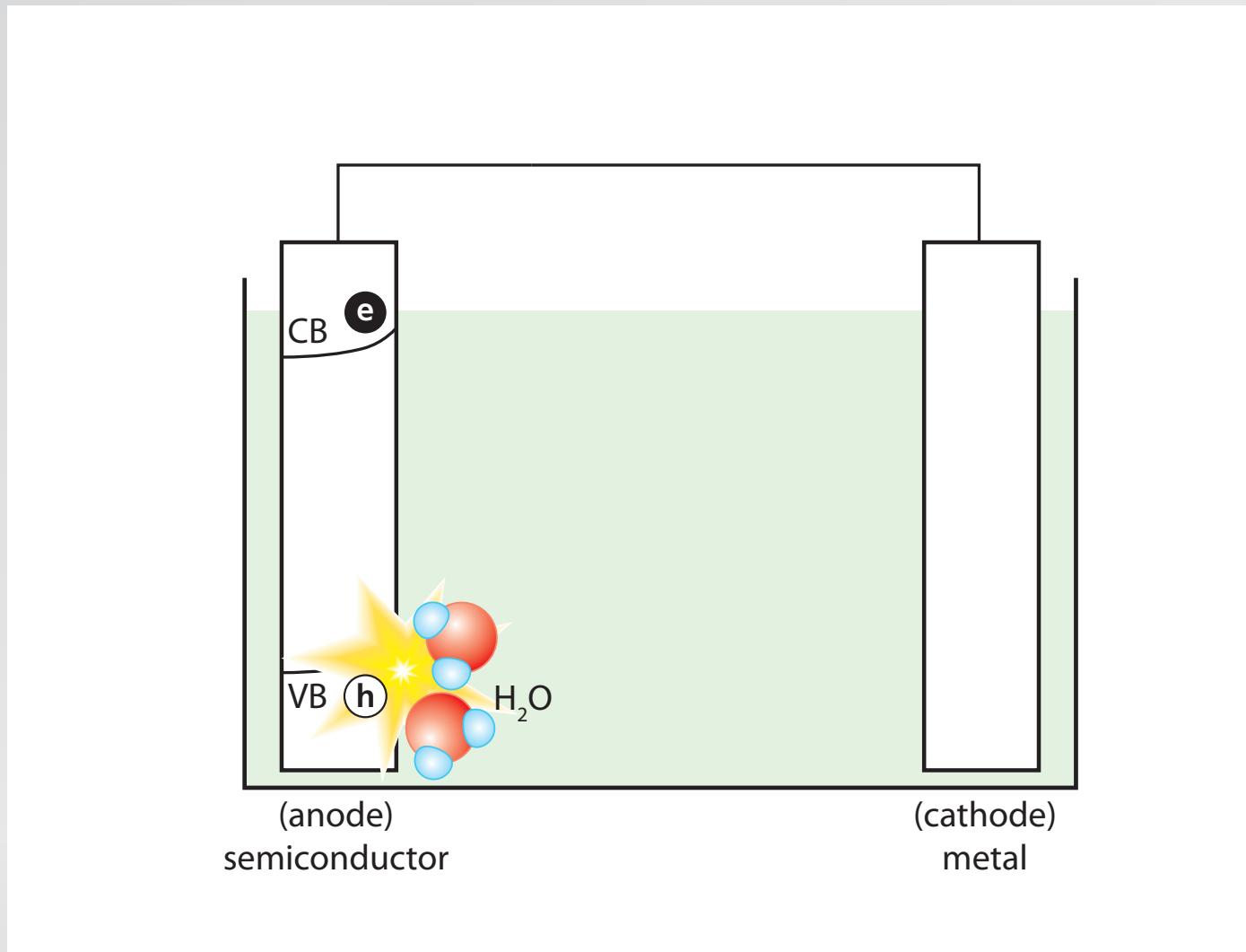
# water splitting



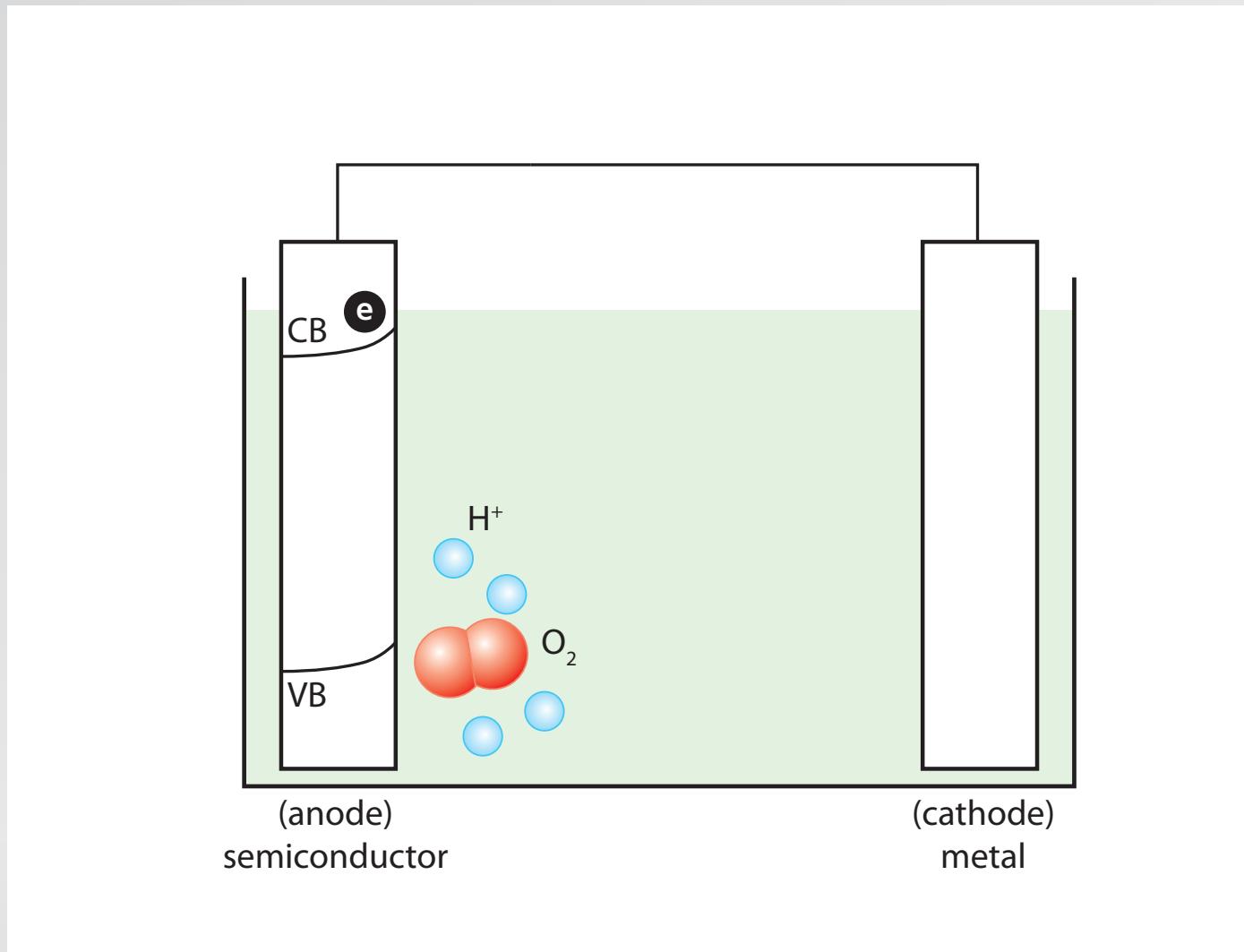
# water splitting



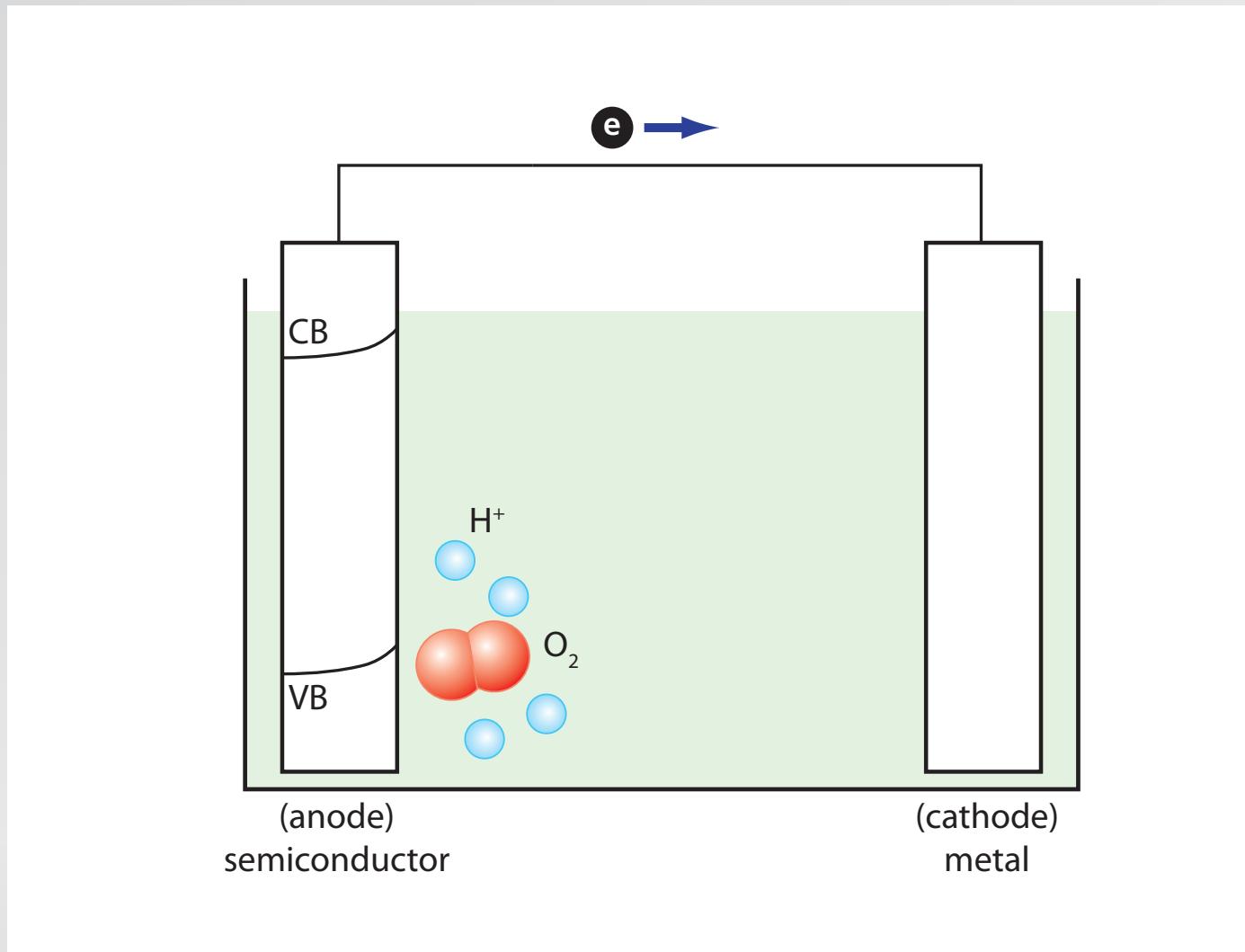
# water splitting



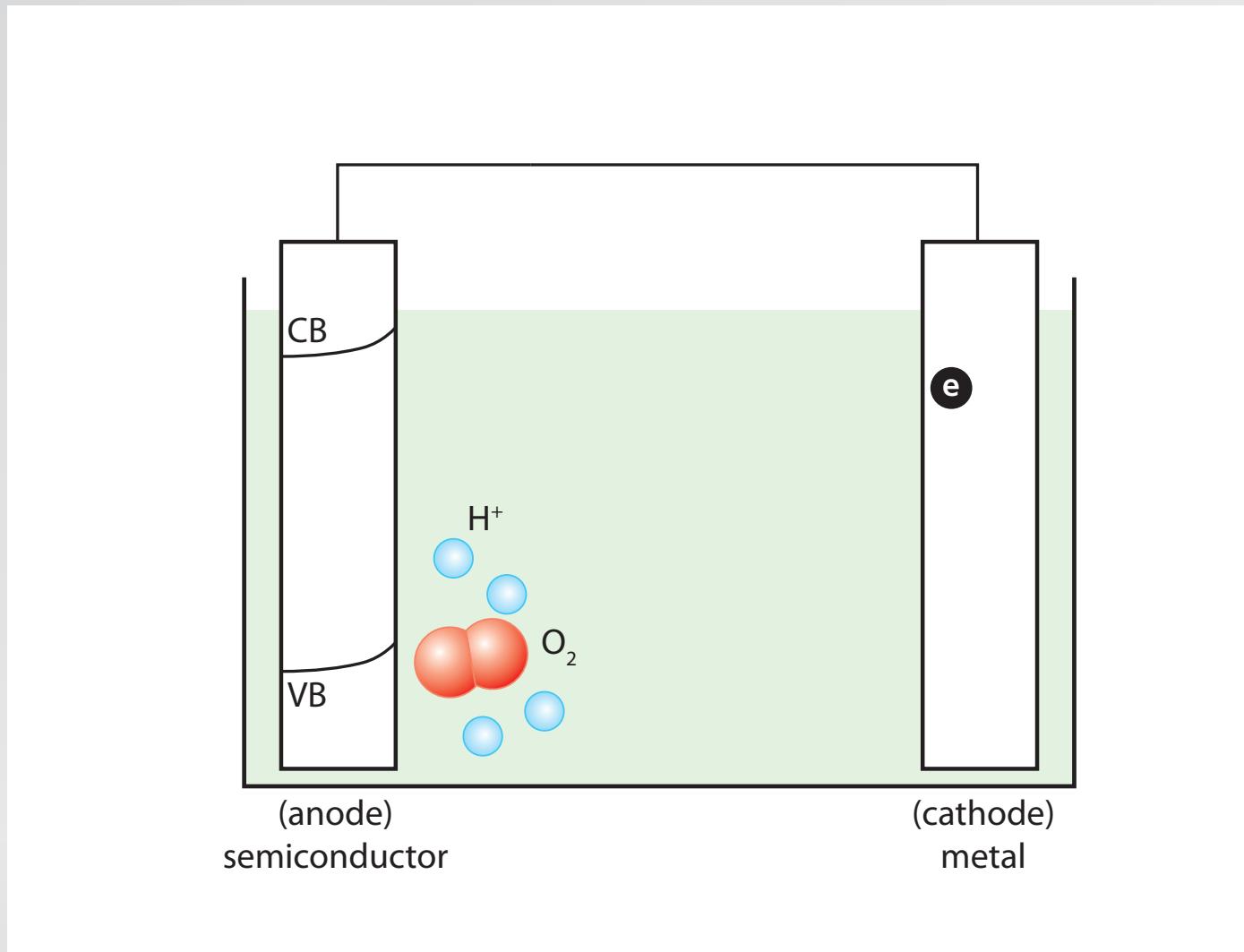
# water splitting



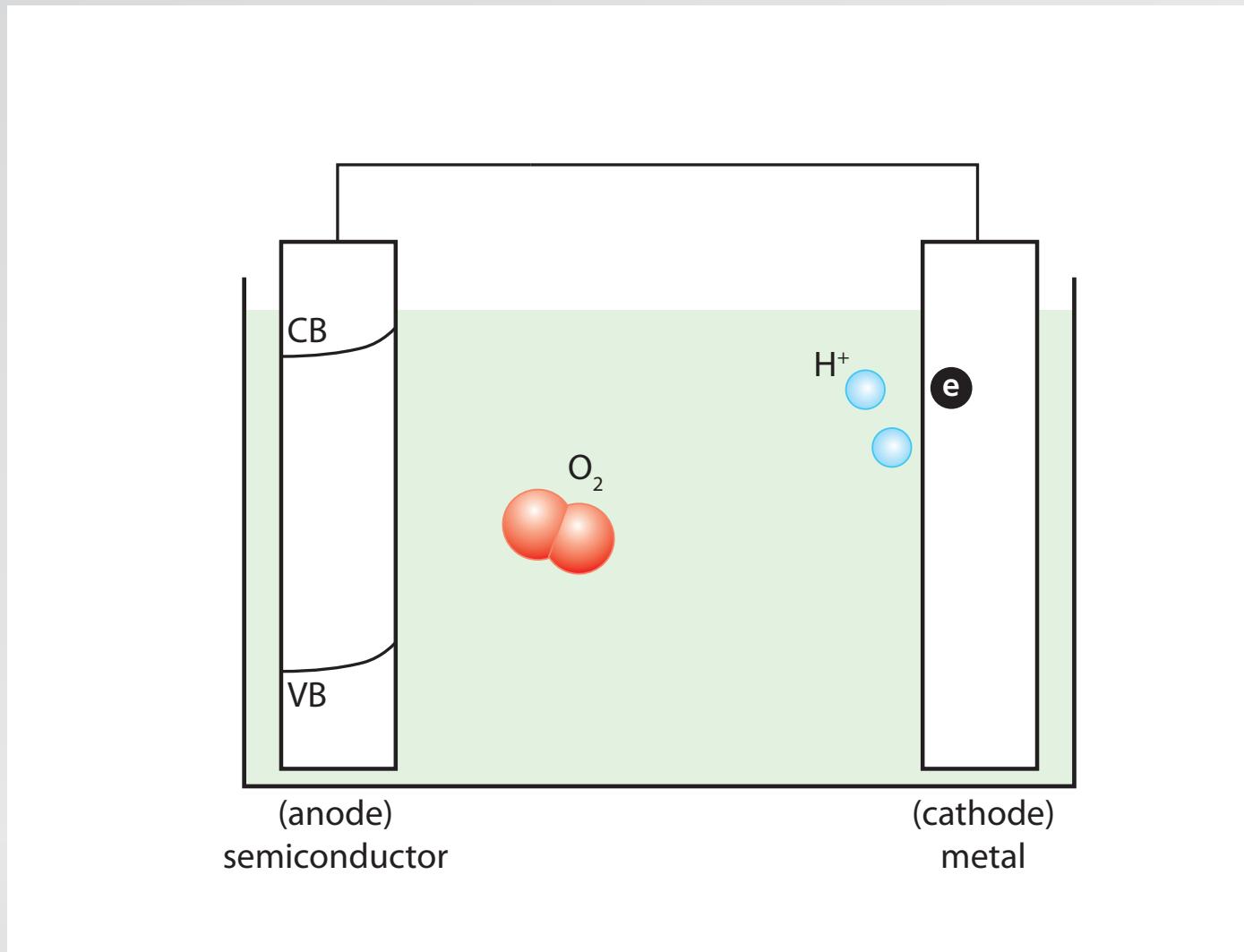
# water splitting



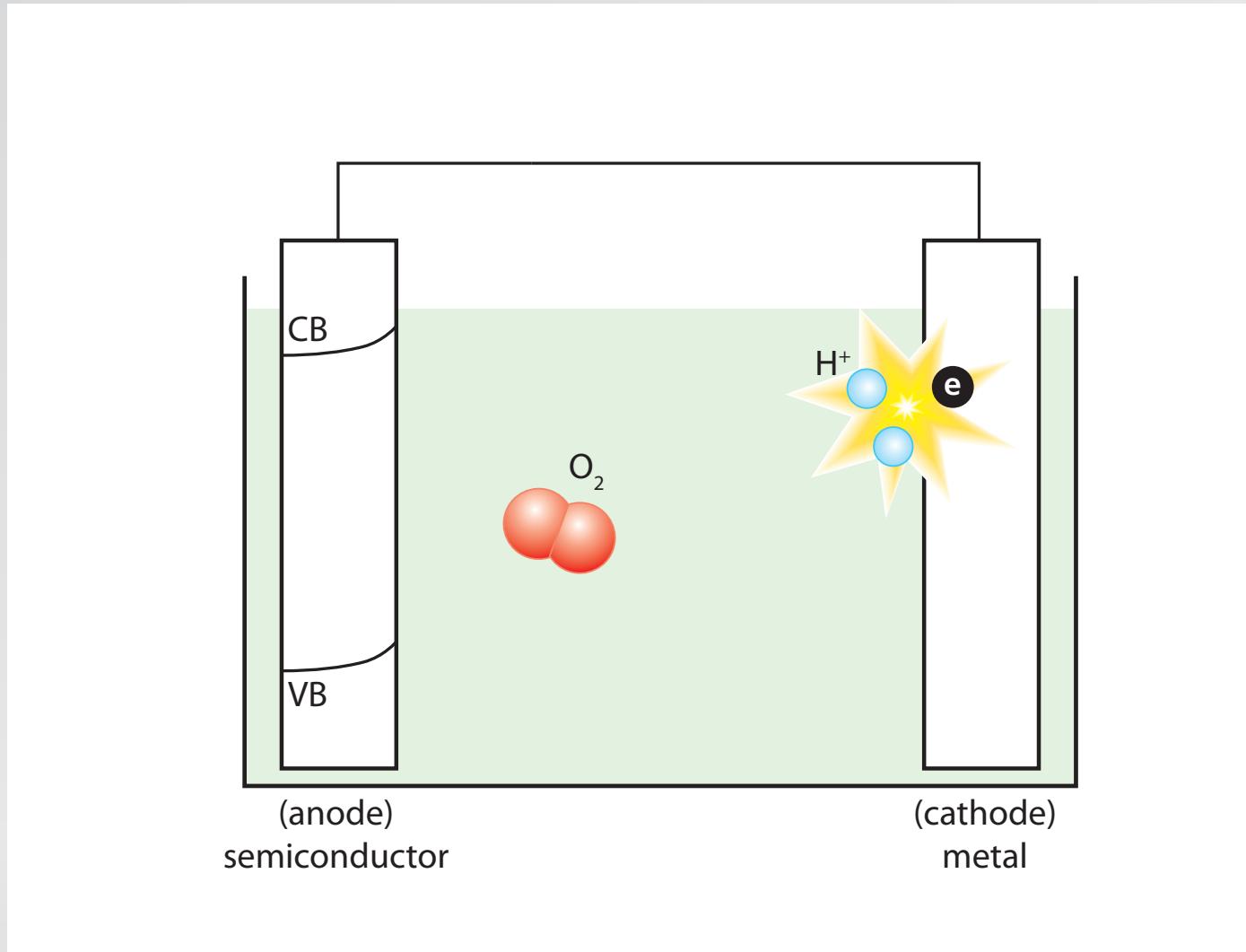
# water splitting



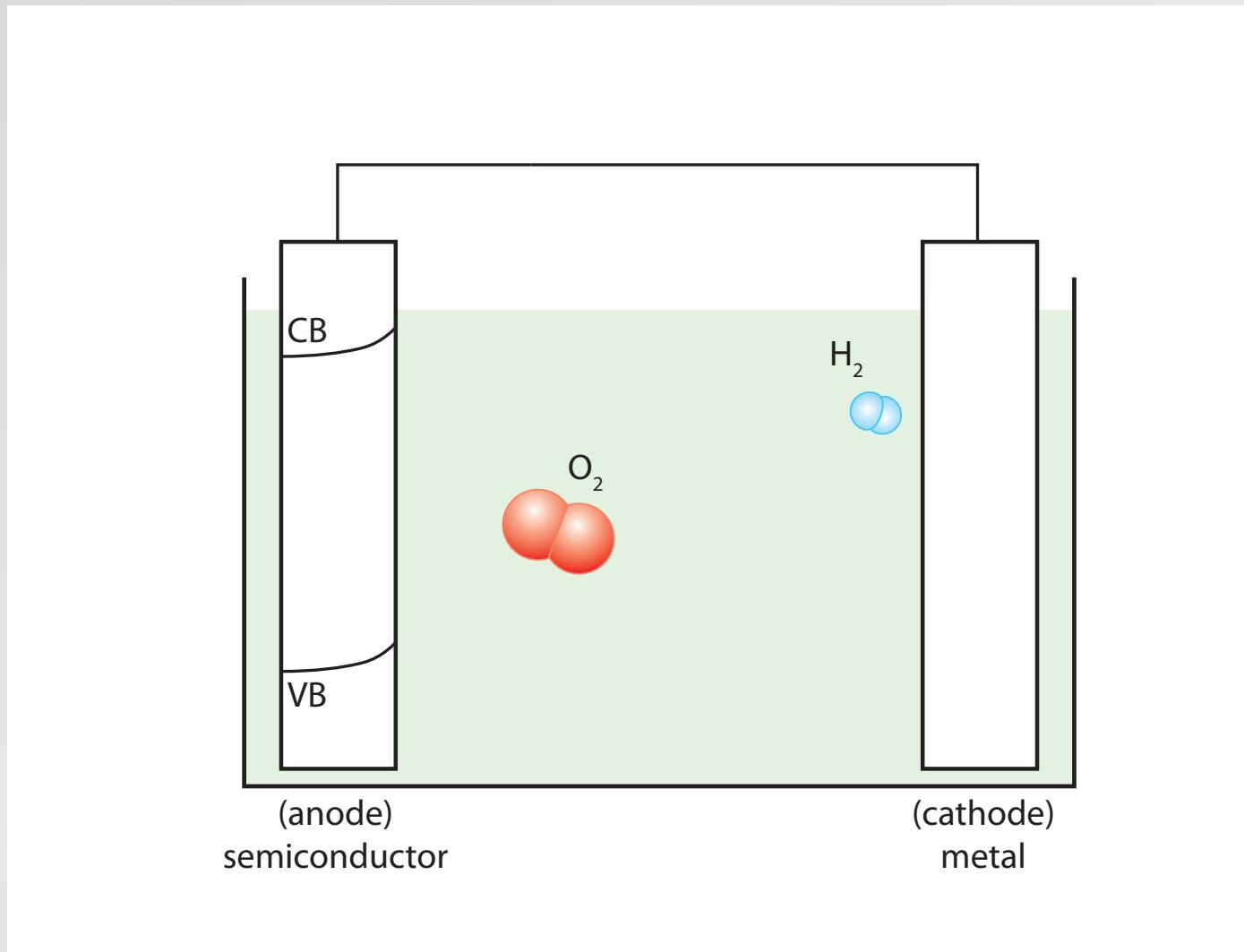
# water splitting



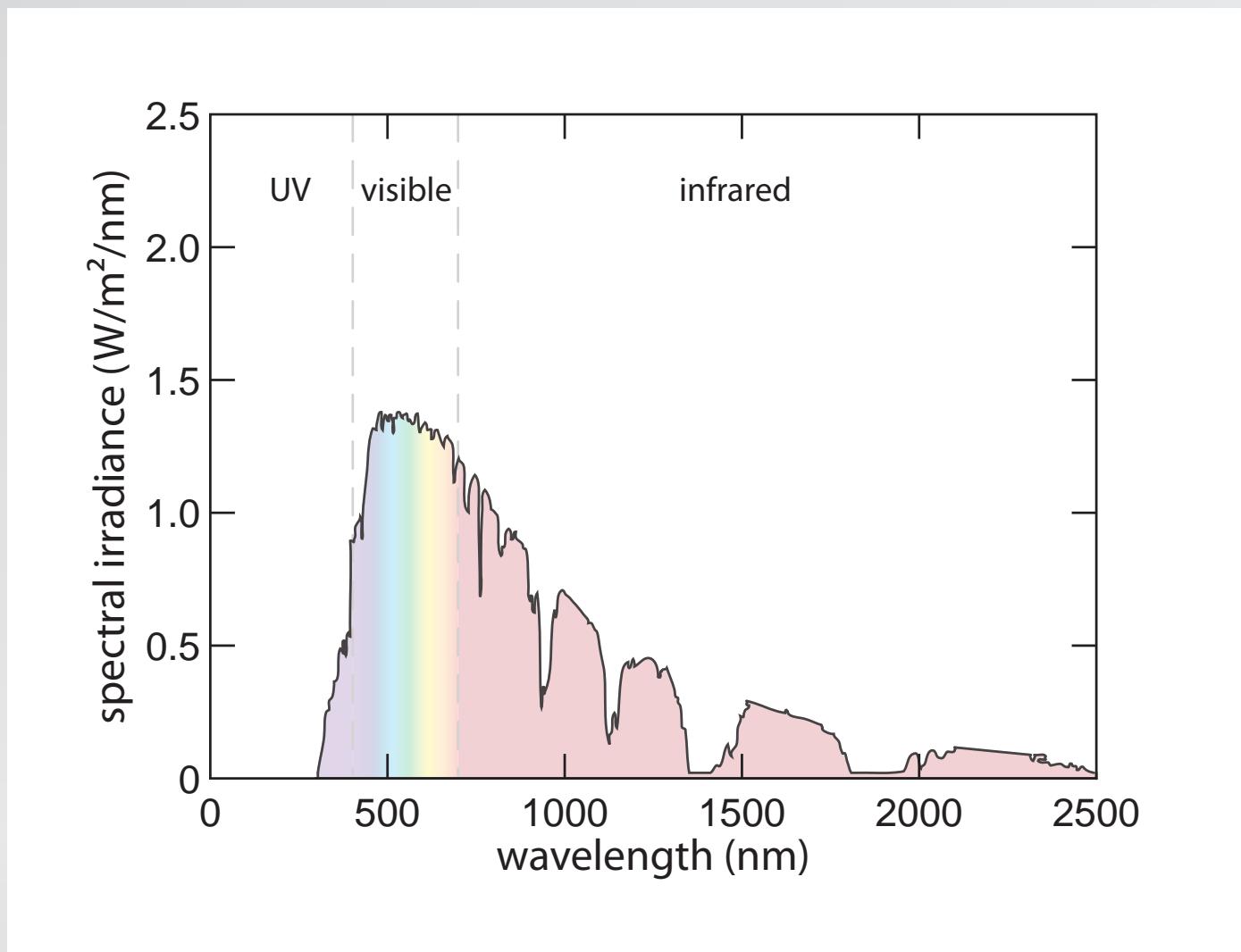
# water splitting



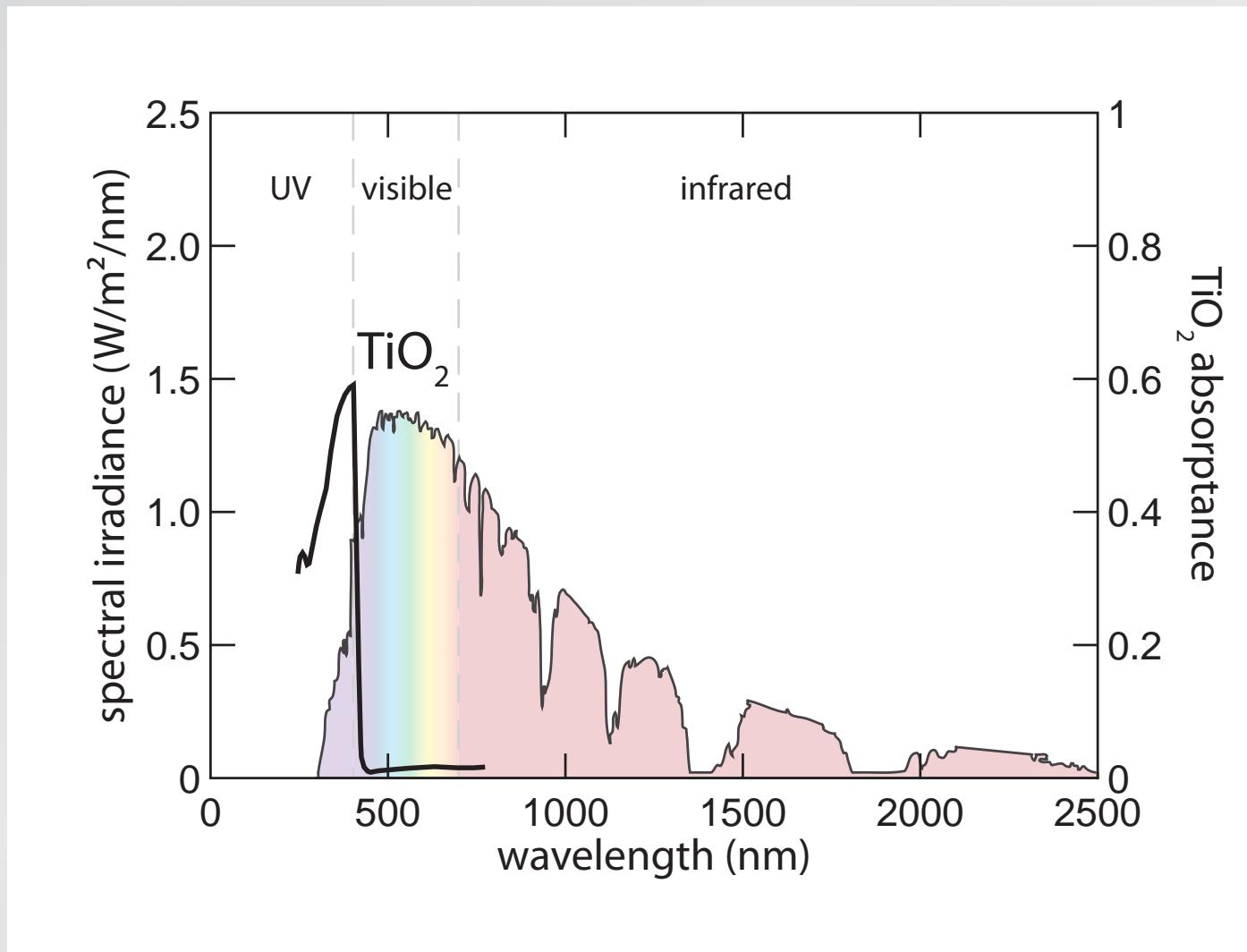
# water splitting



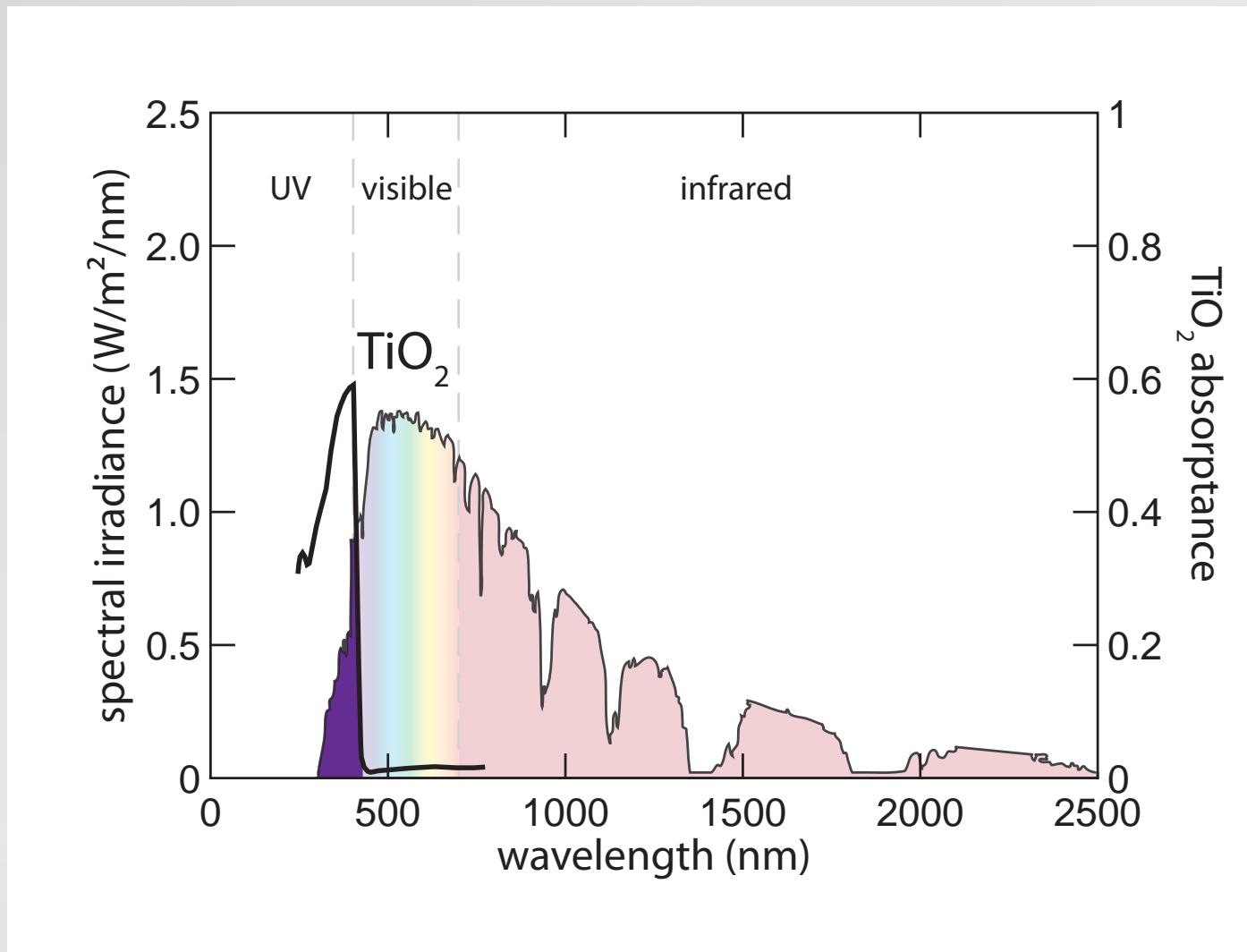
# solar radiation spectrum



# solar radiation spectrum

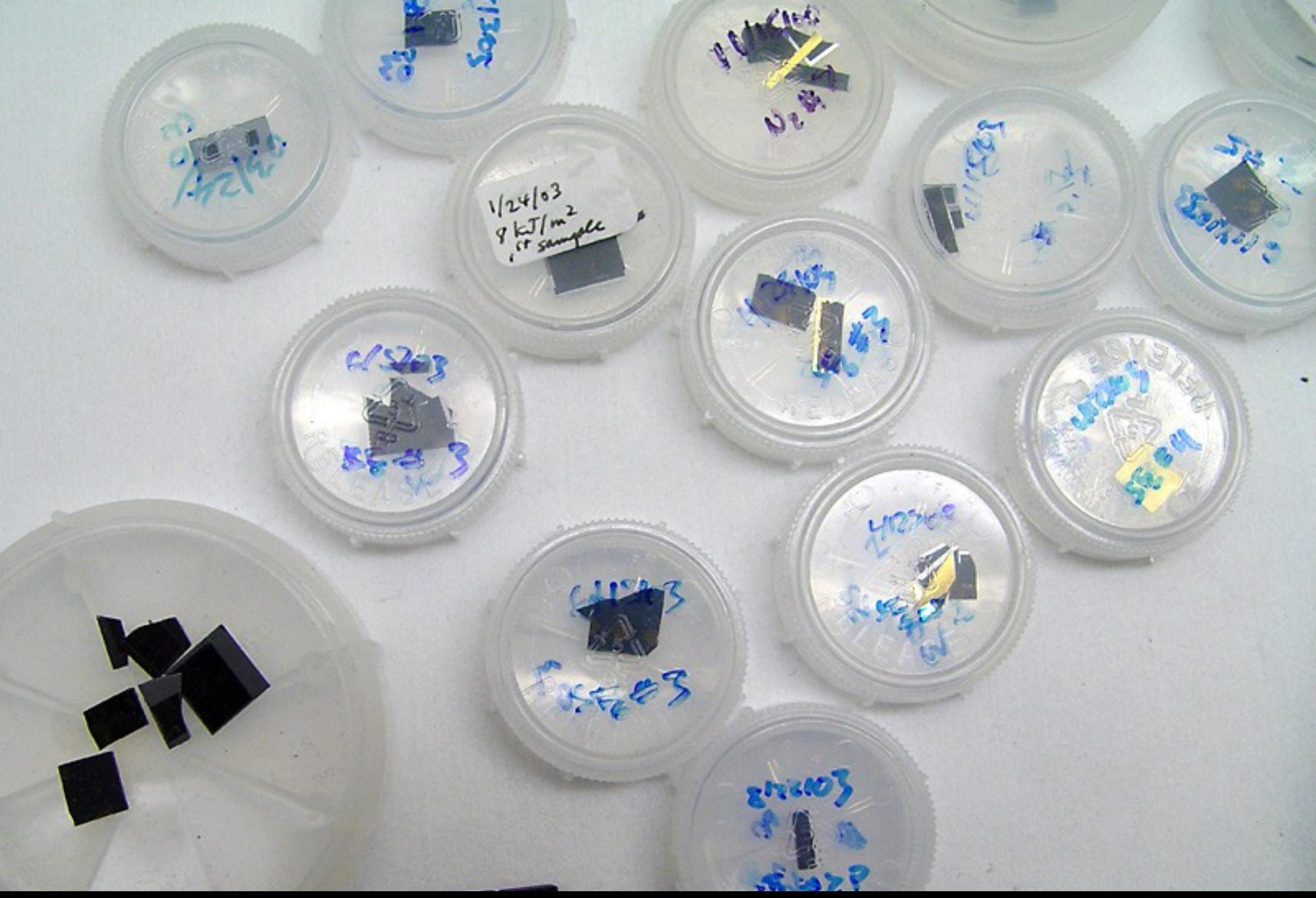


# solar radiation spectrum

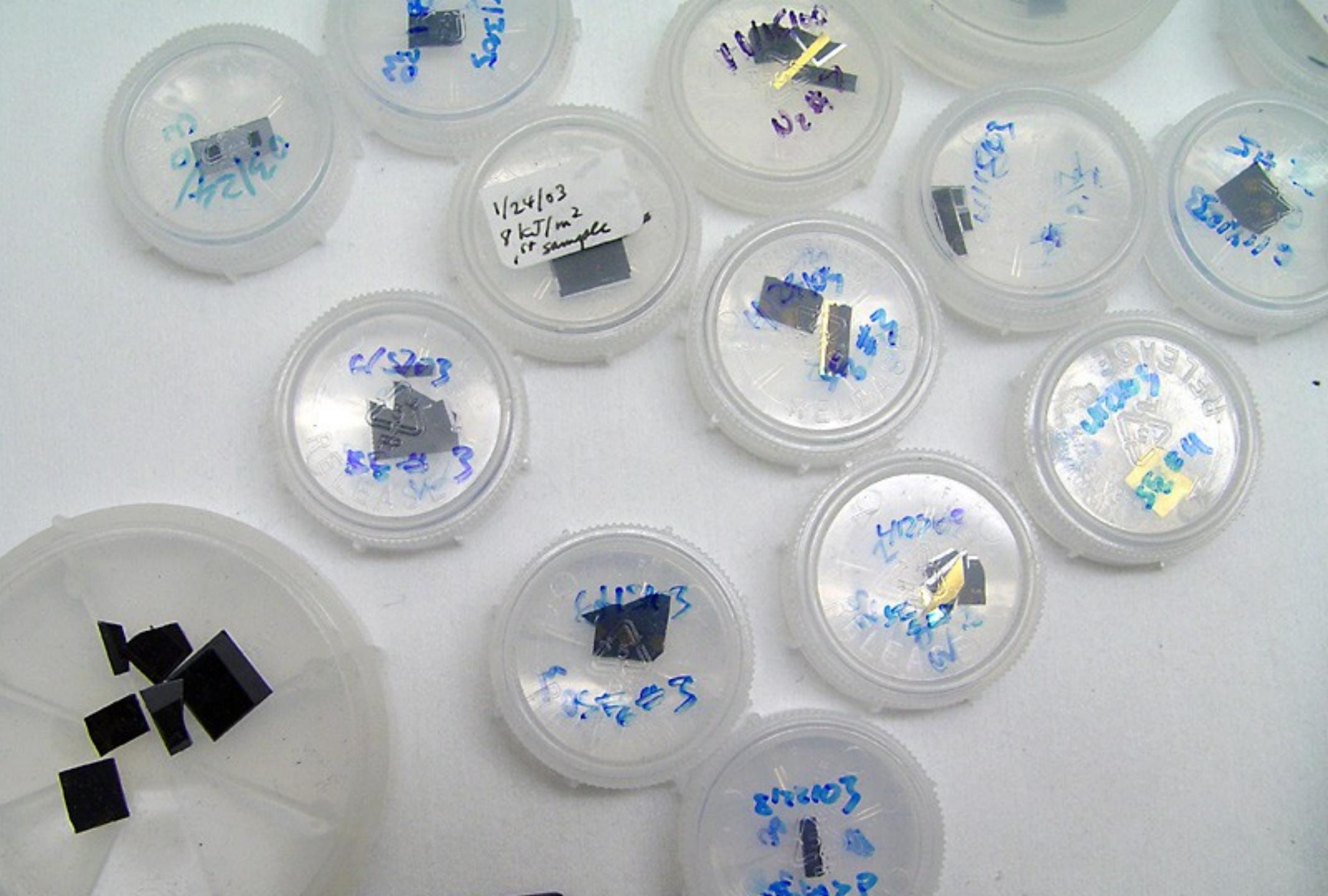


**increase efficiency by:**

- increasing surface area
- shifting band edge

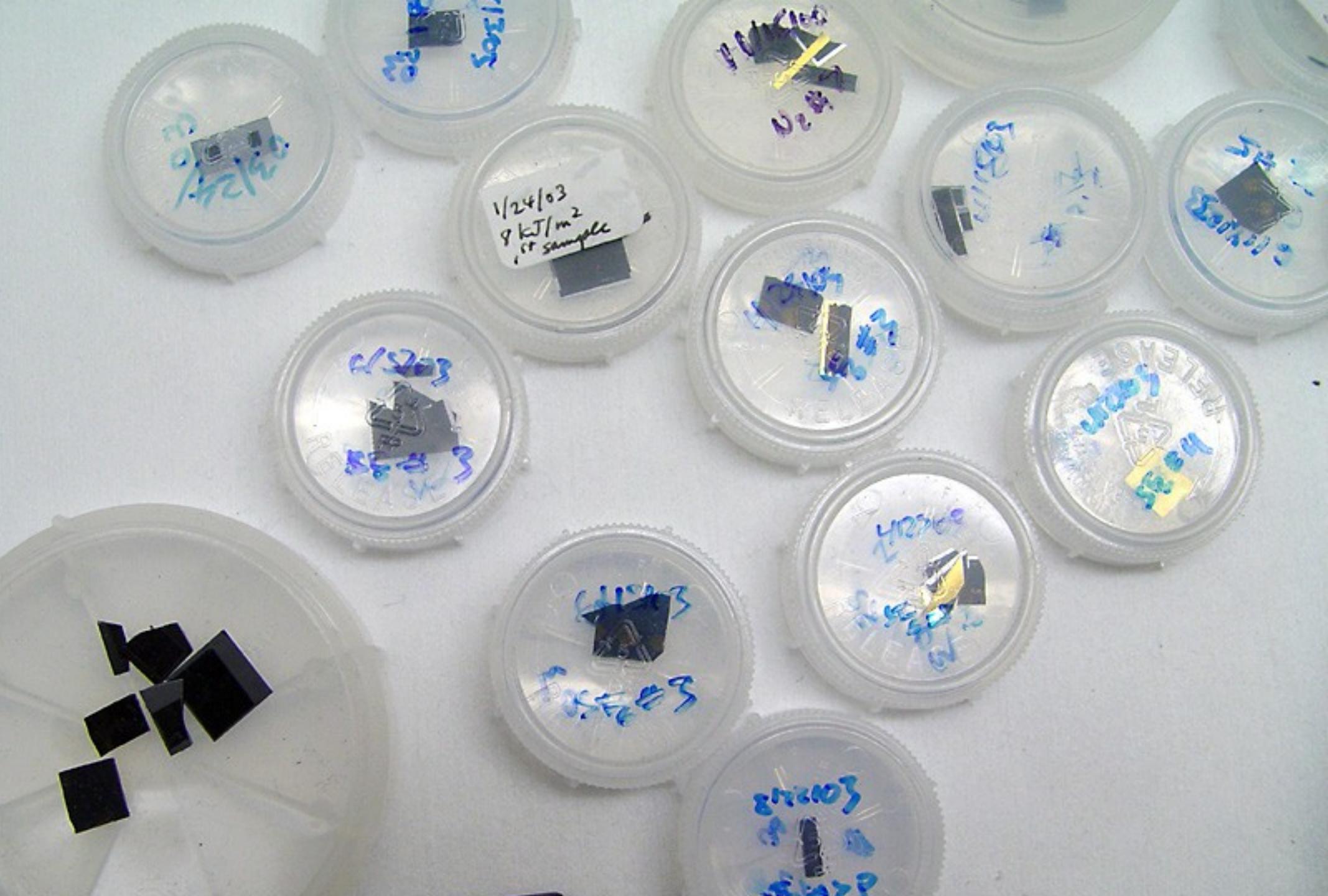


1 texturing



① texturing

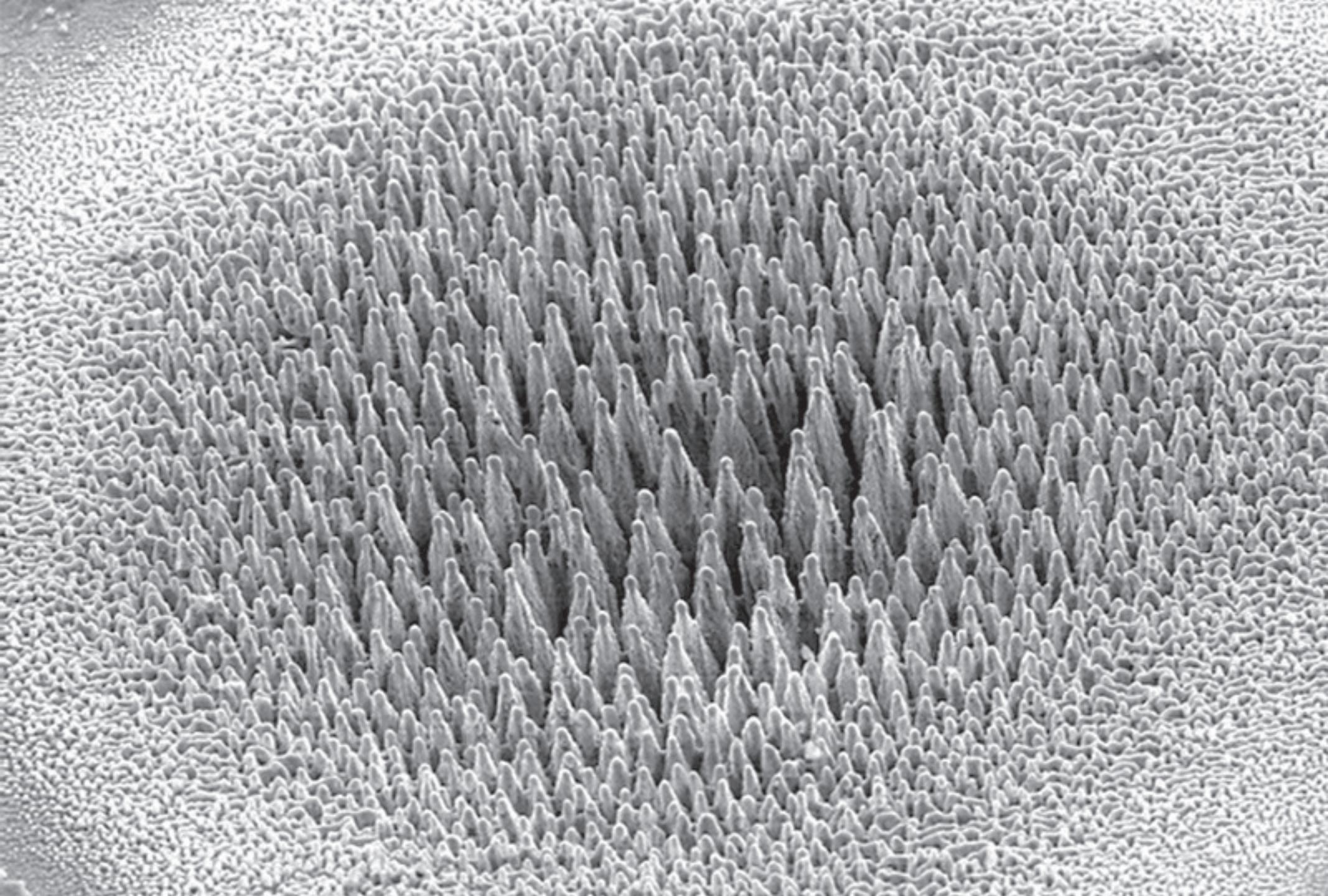
② doping



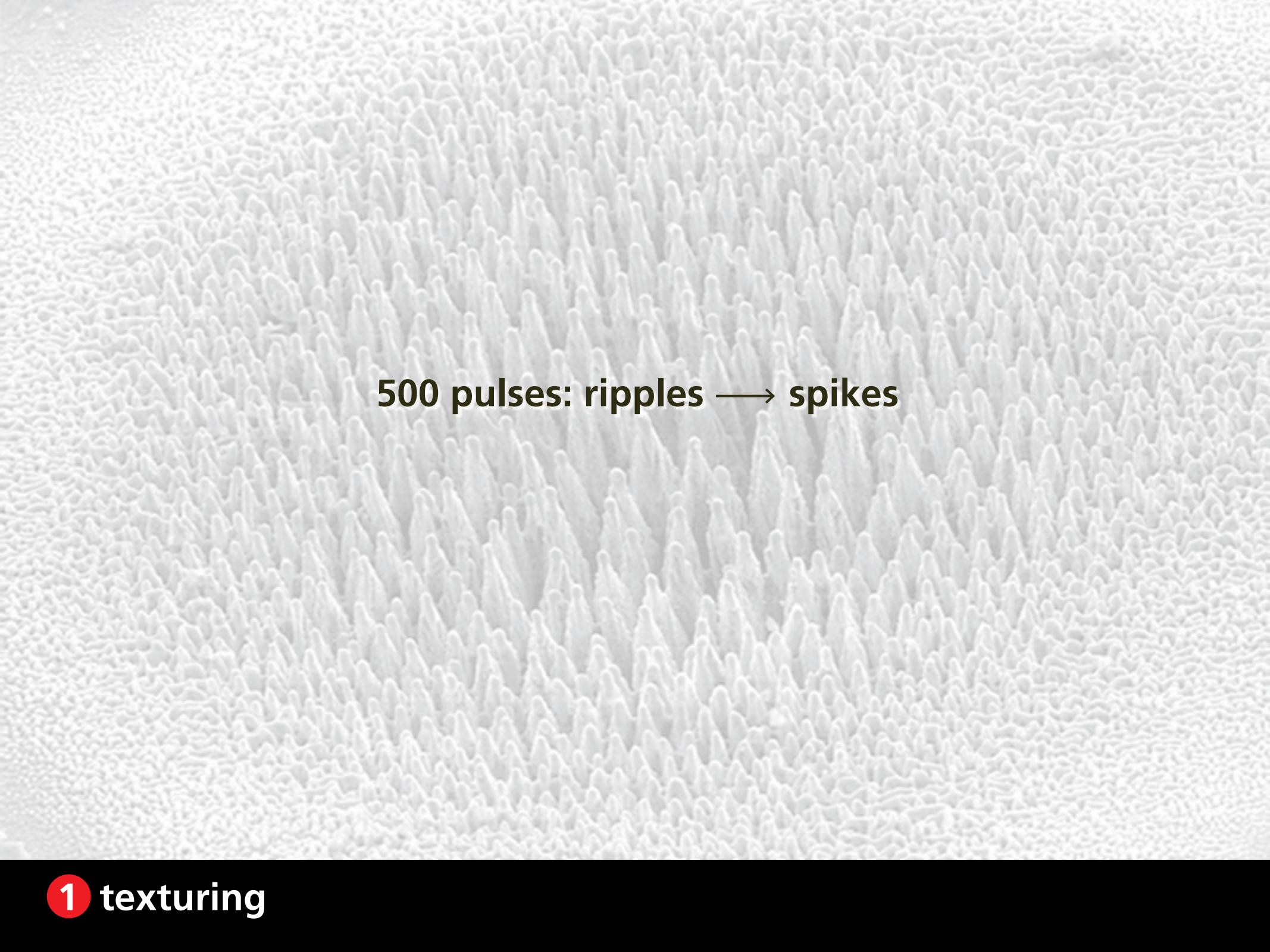
① texturing

② doping

③ X:TiO<sub>2</sub>

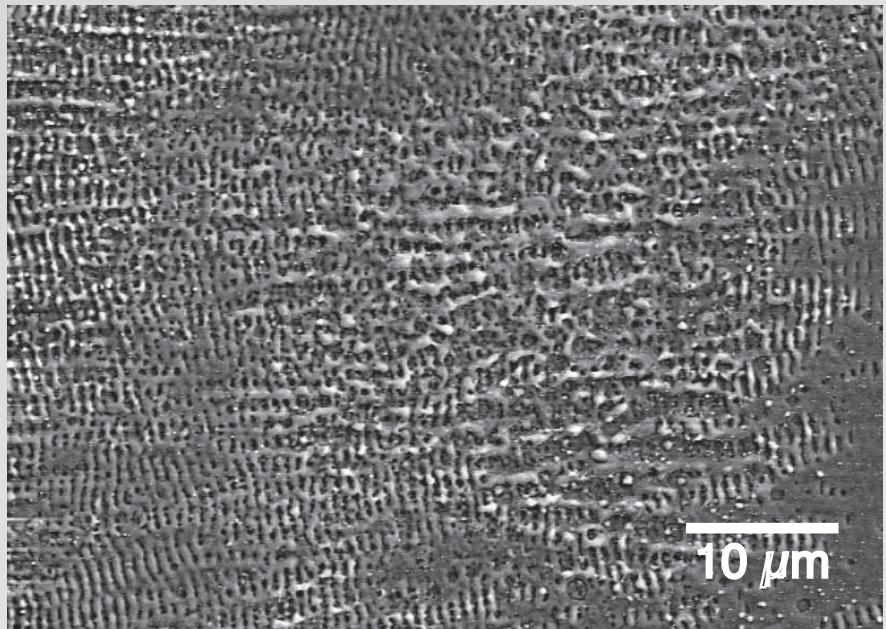


1 texturing

The background of the slide features a grayscale 3D surface plot. It starts with a relatively smooth, wavy texture at the top, representing 'ripples'. As the surface descends towards the bottom of the frame, it becomes increasingly jagged and spiky, representing 'spikes'. This visual metaphor illustrates the progression from a general, low-frequency pattern to a highly detailed, high-frequency pattern.

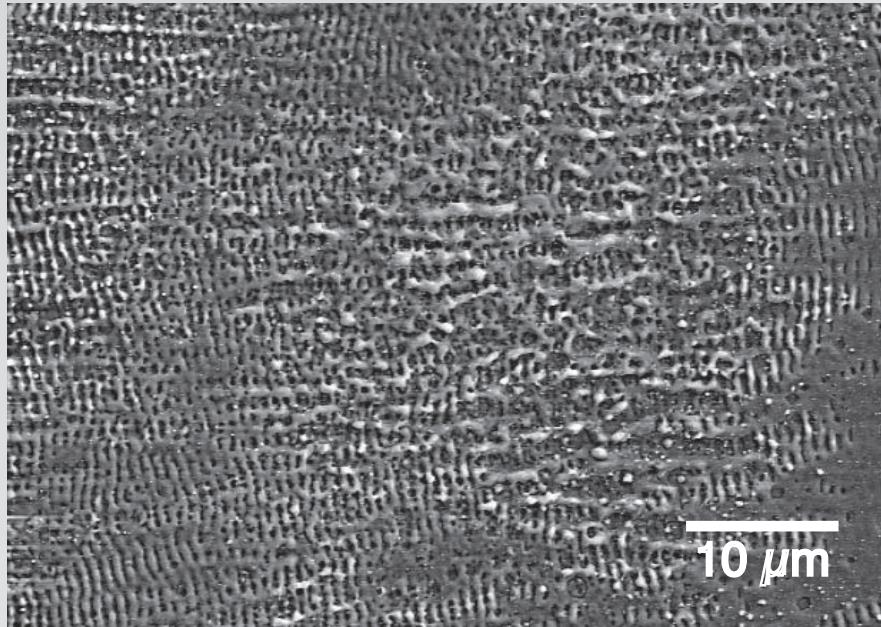
**500 pulses: ripples → spikes**

**2 pulses**



**1 texturing**

**2 pulses**



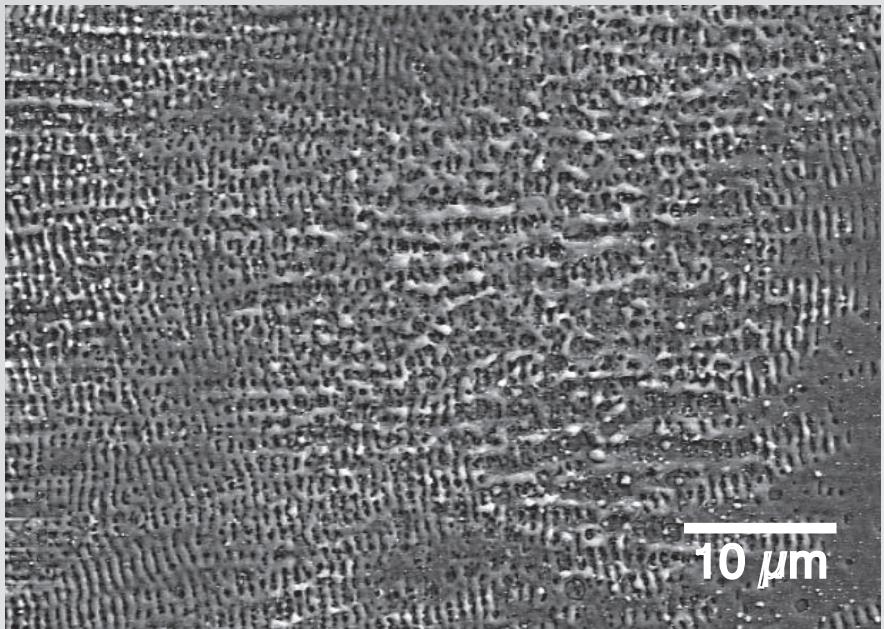
**polarization**



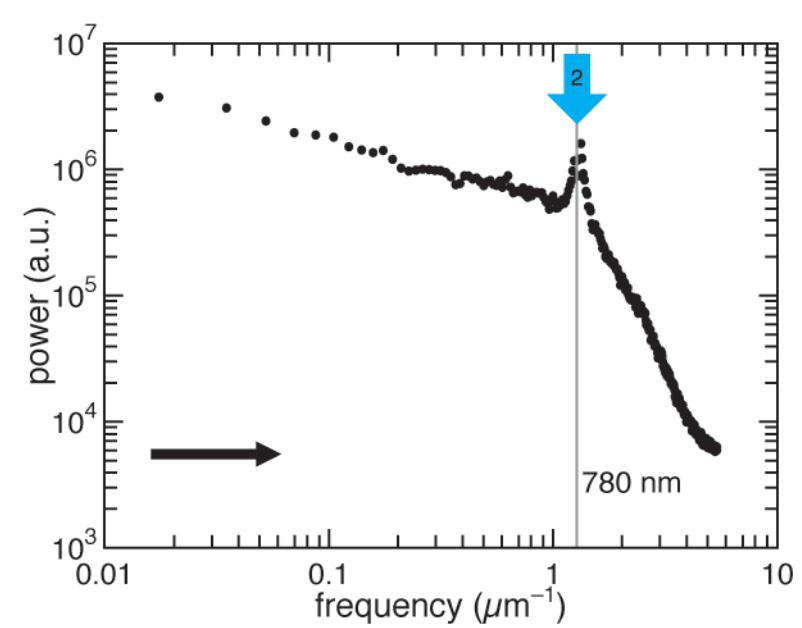
**1 texturing**

**1** texturing

polarization  
→

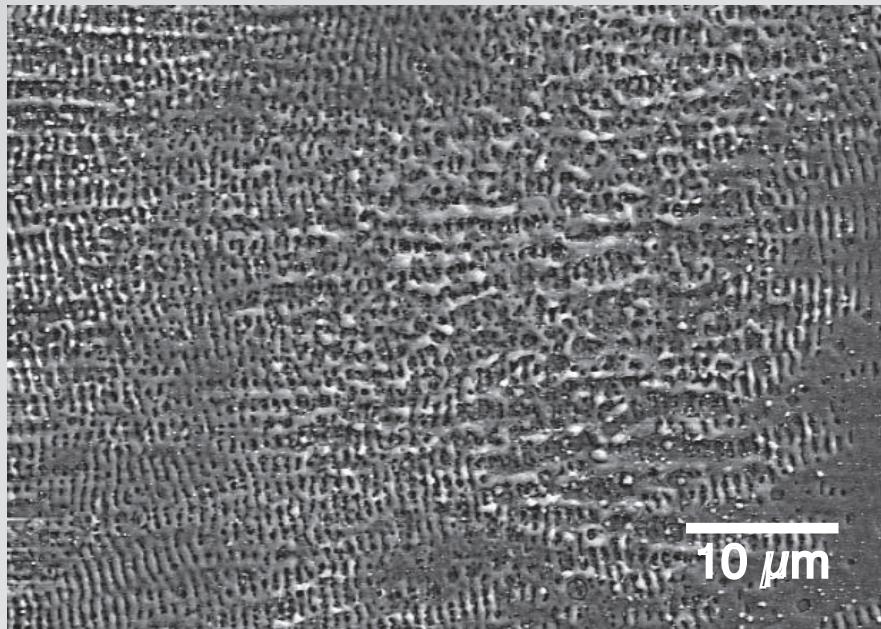


**2 pulses**

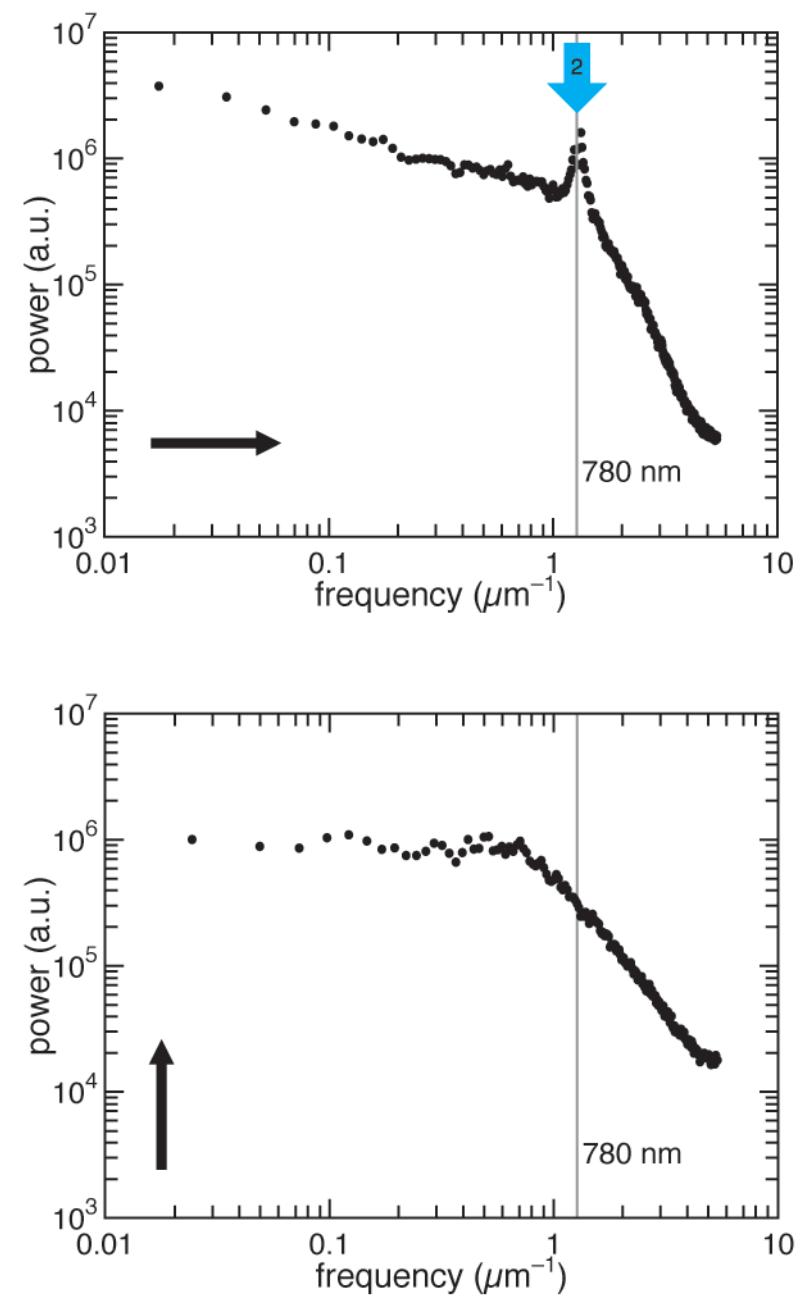


**1** texturing

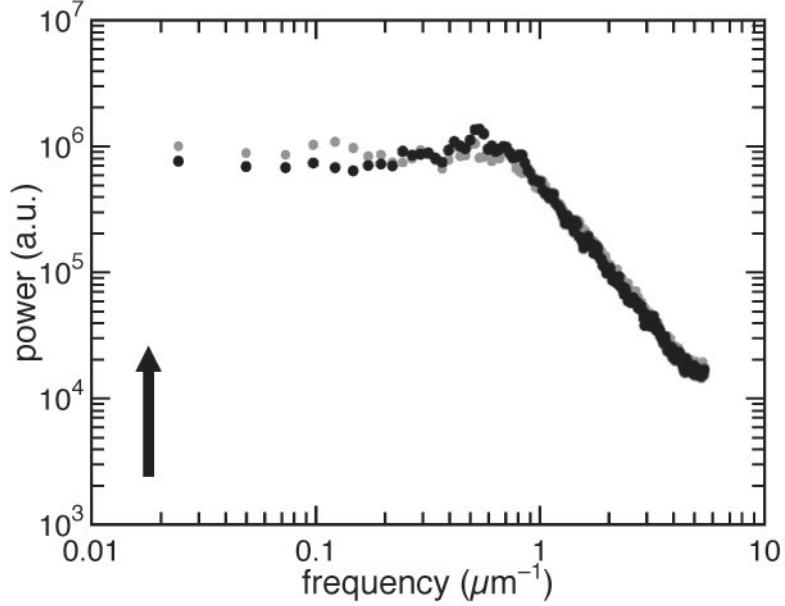
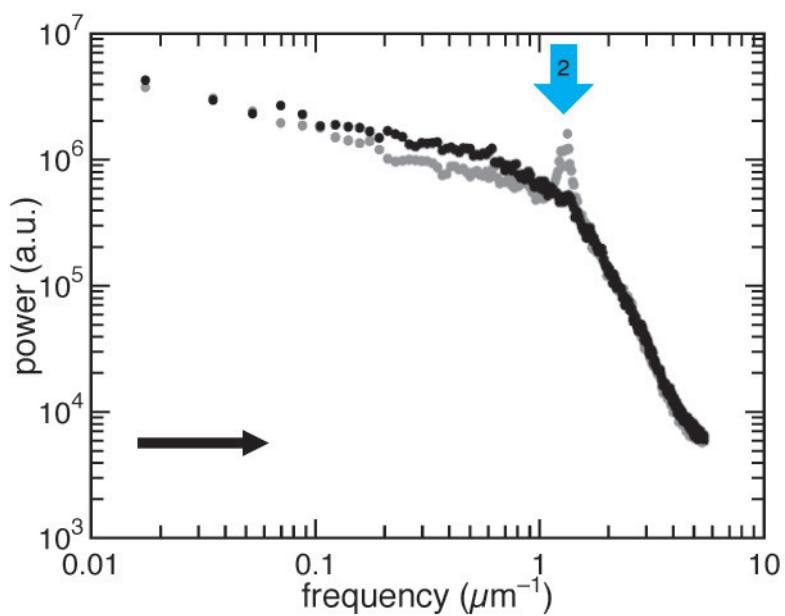
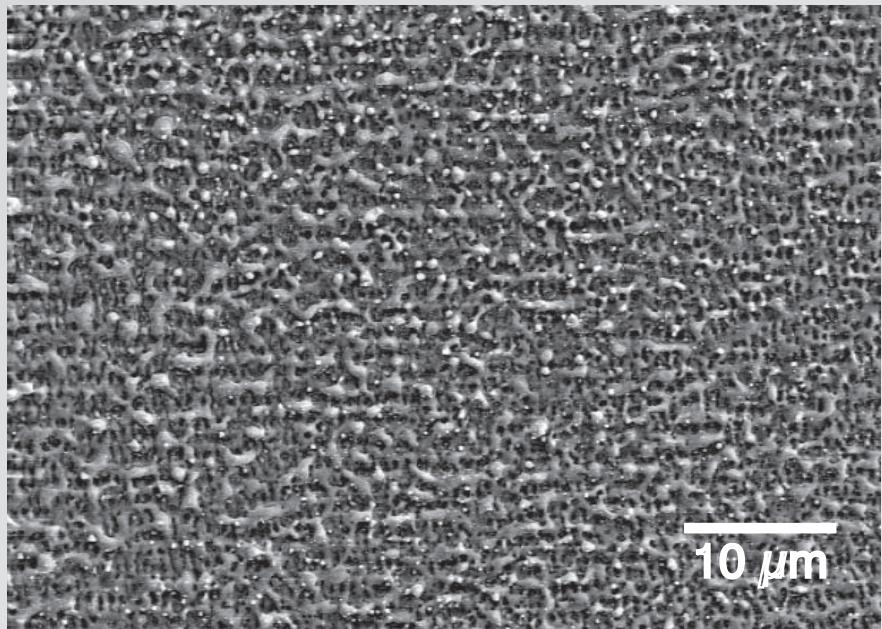
polarization  
→



2 pulses



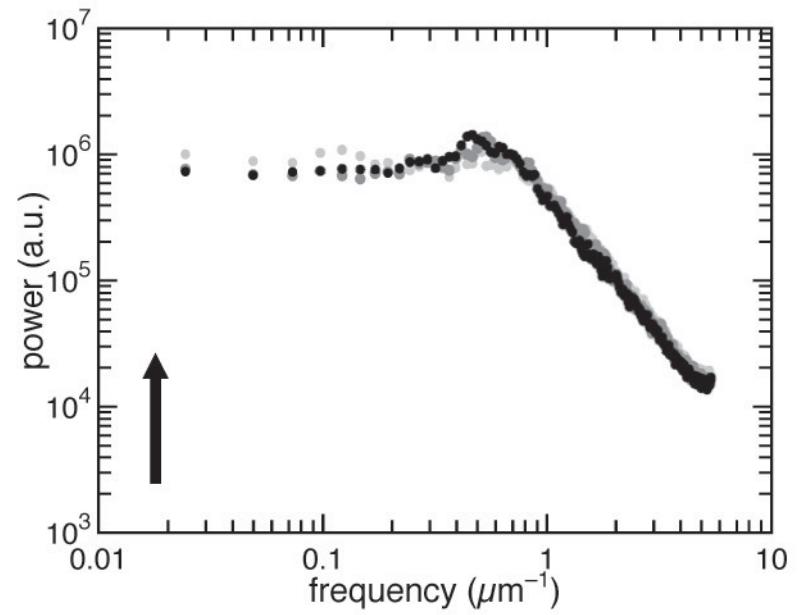
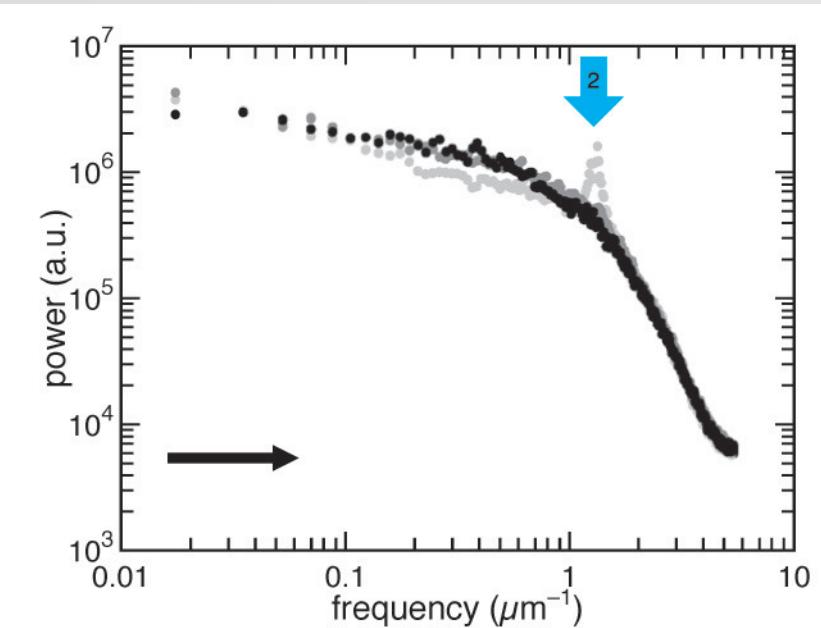
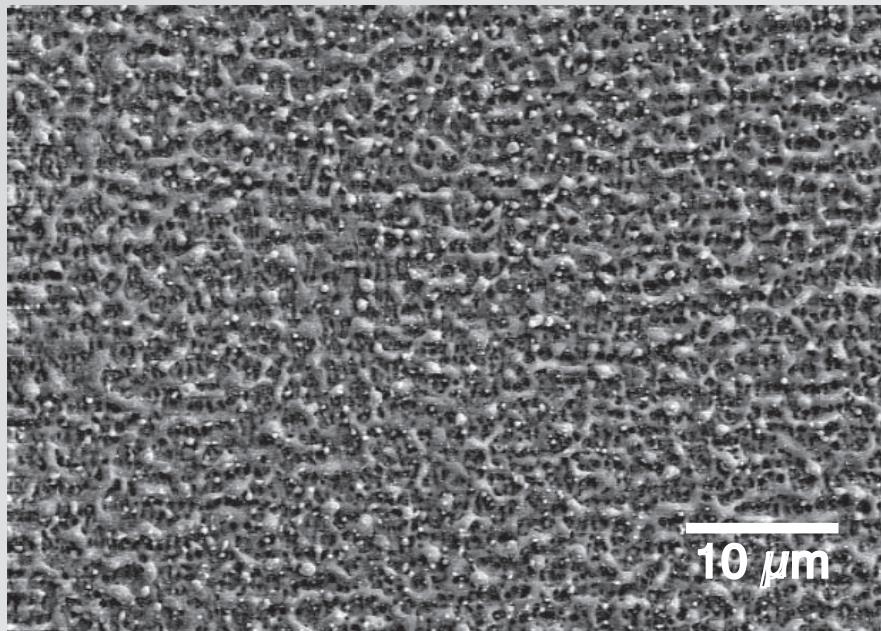
**3 pulses**



**1 texturing**

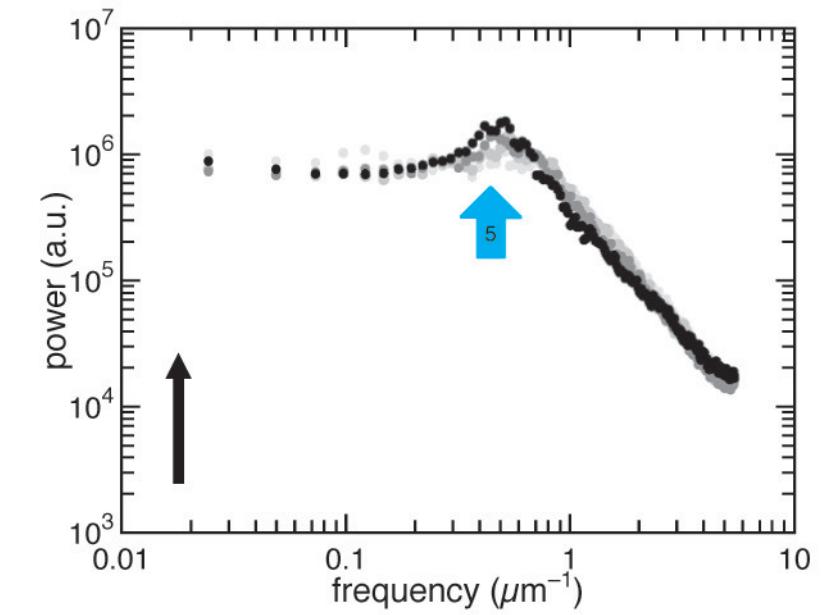
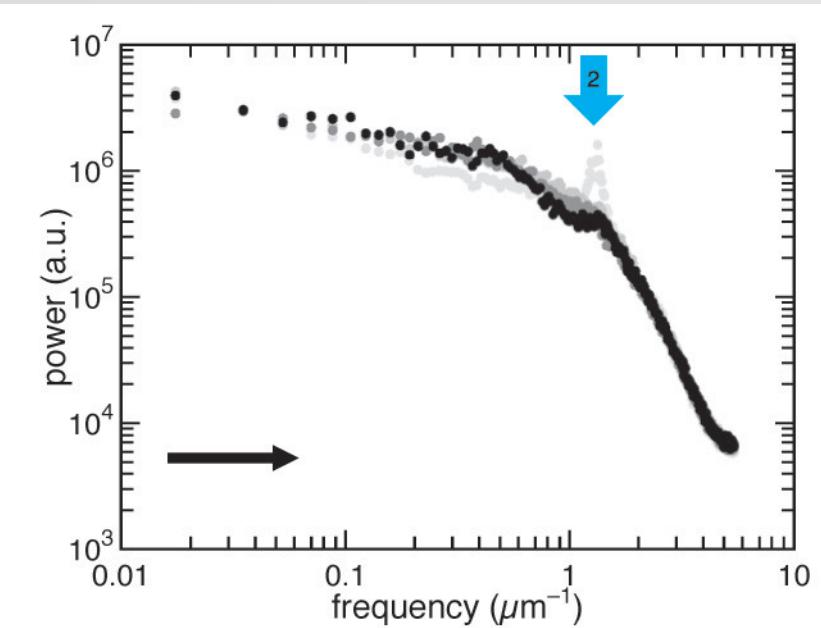
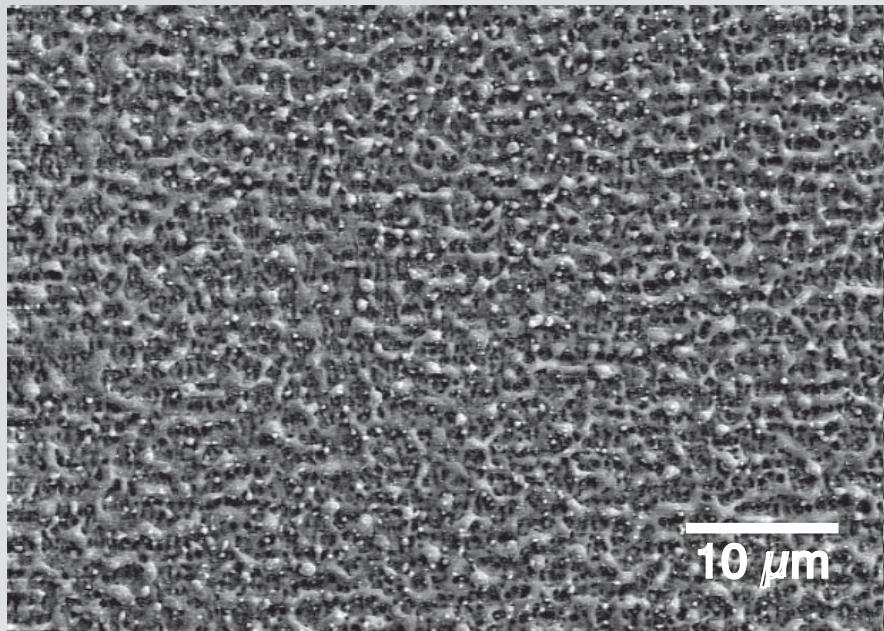
# 1 texturing

4 pulses



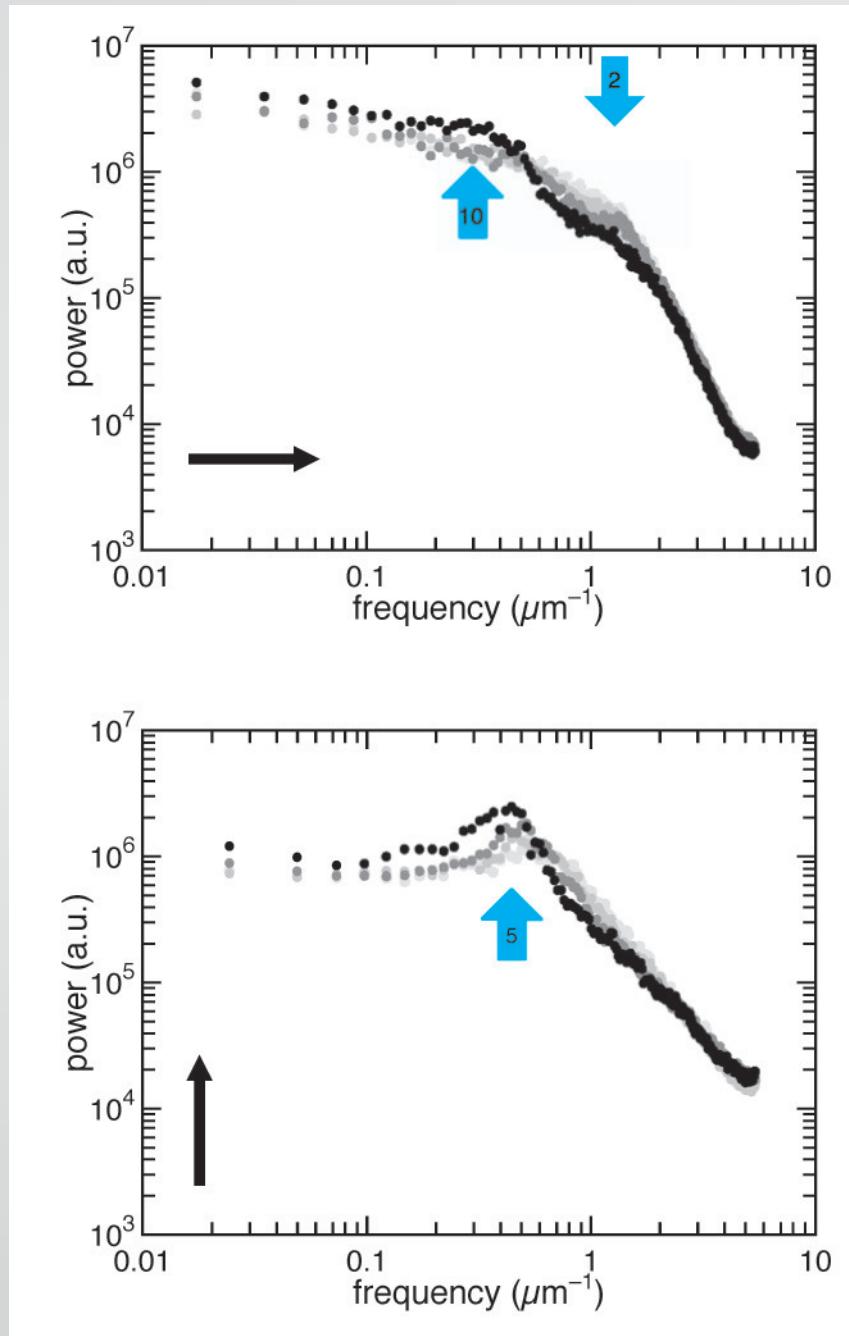
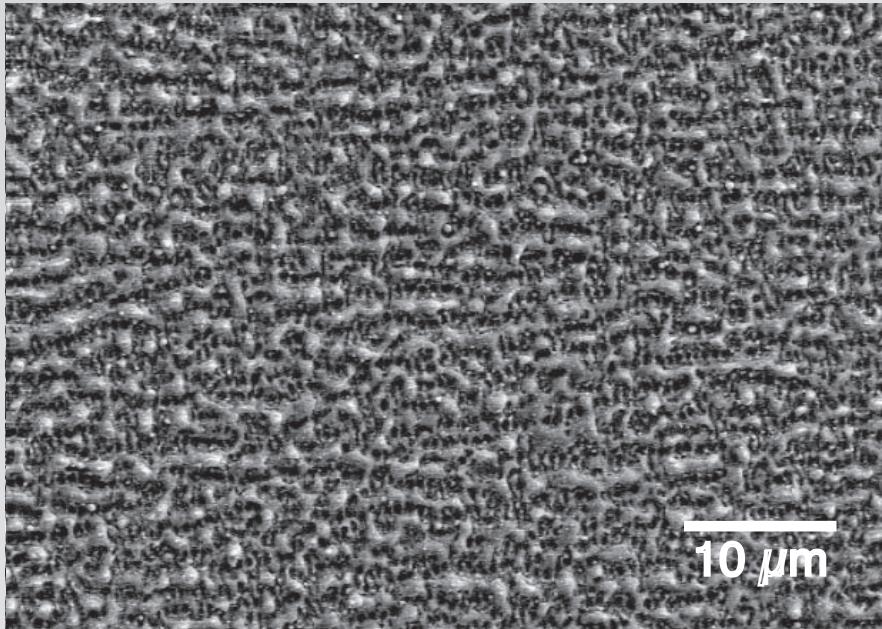
# 1 texturing

5 pulses

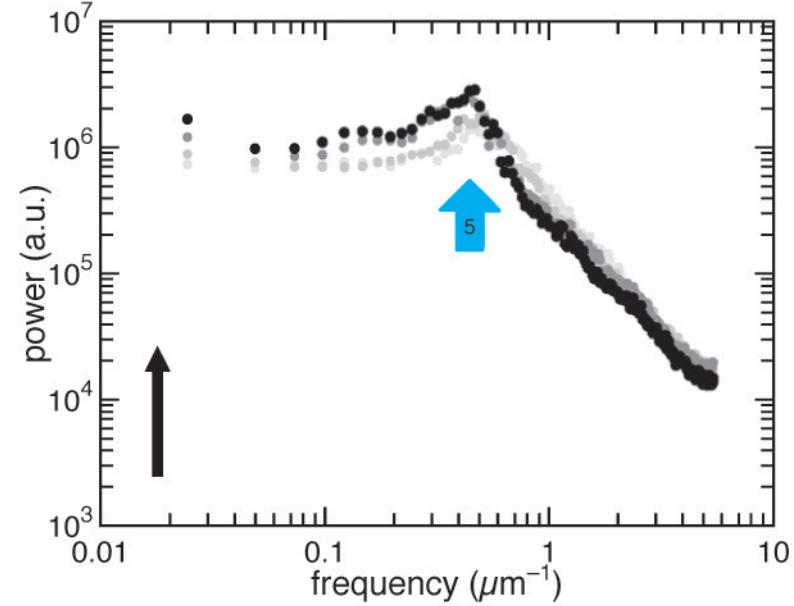
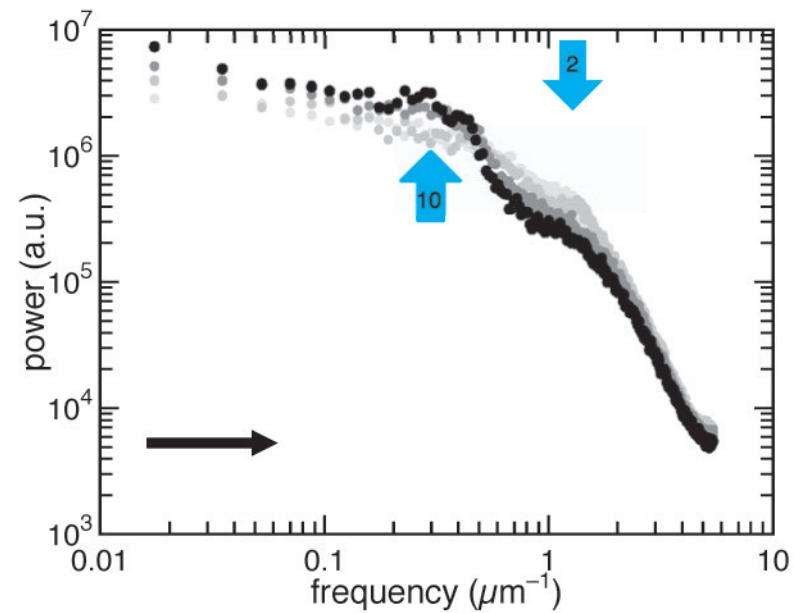
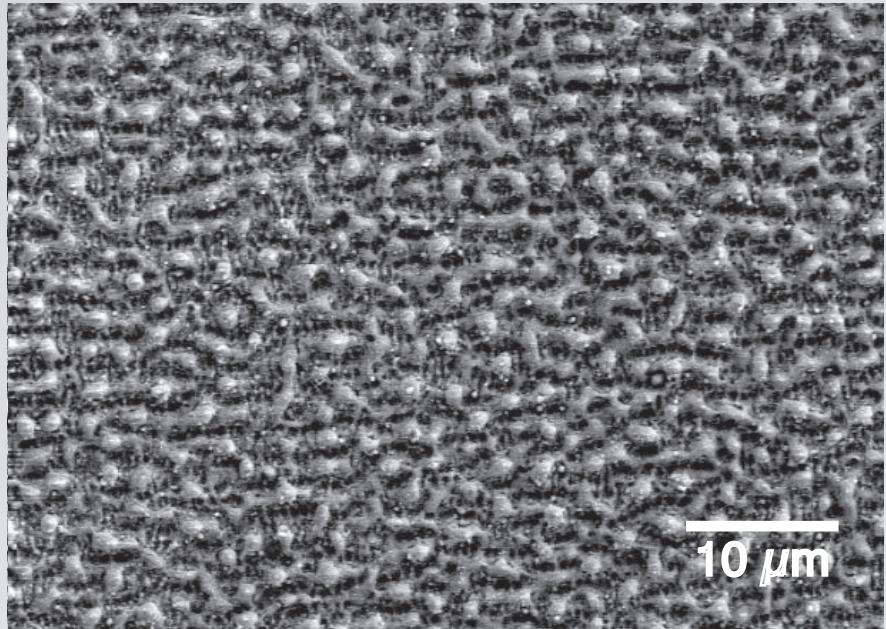


# 1 texturing

10 pulses

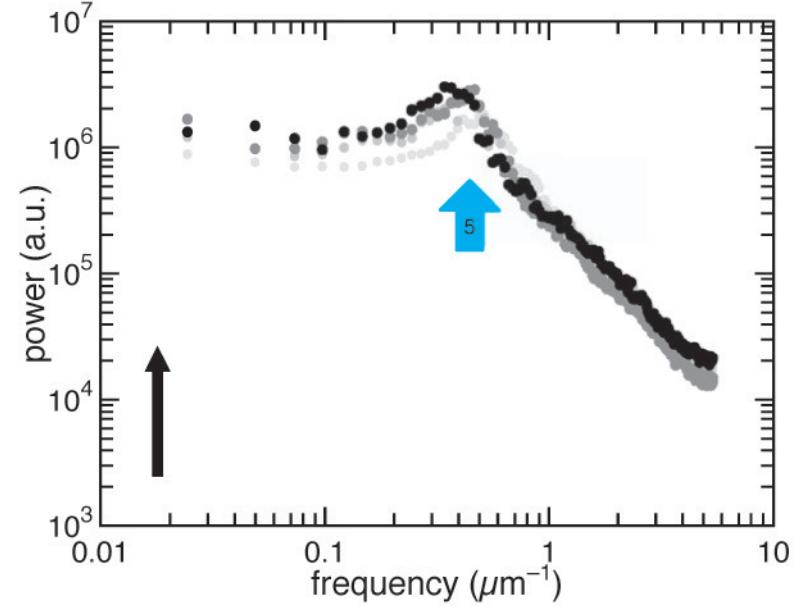
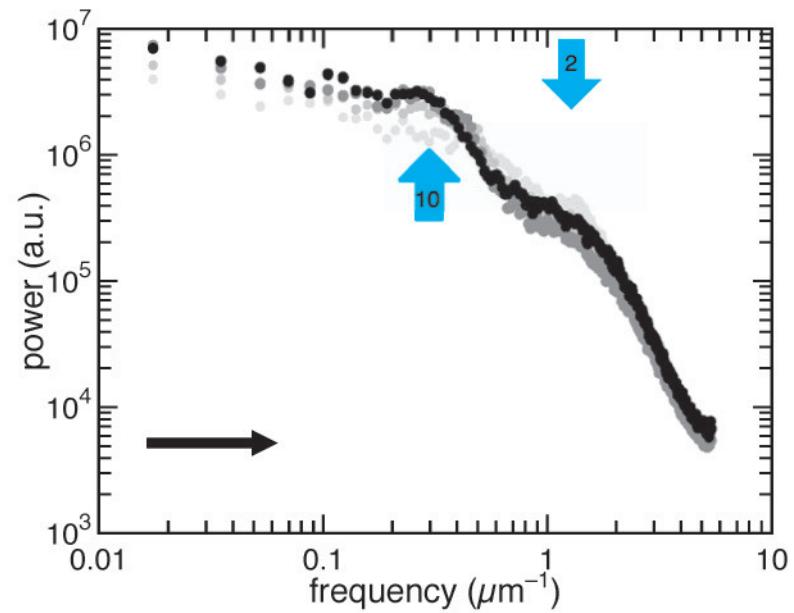
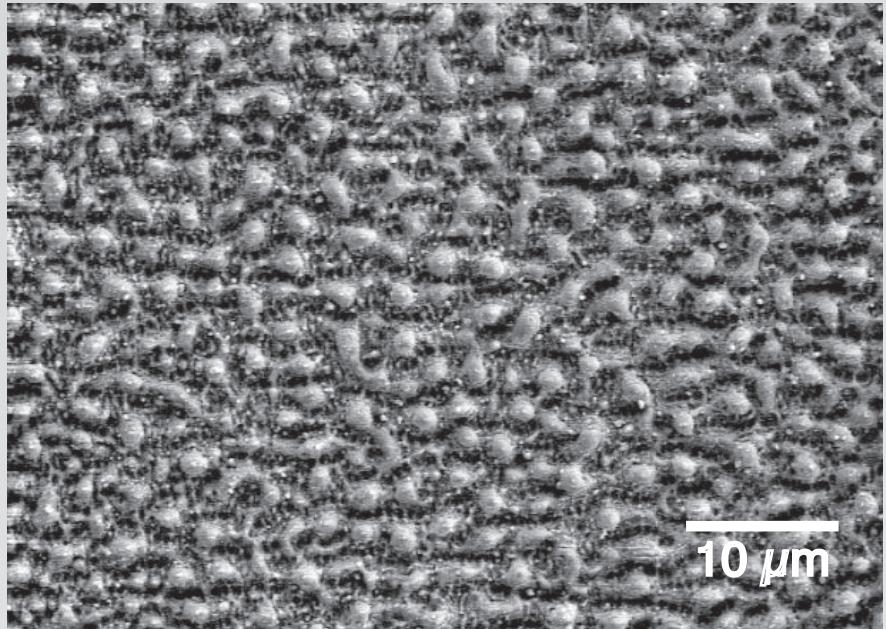


**15 pulses**



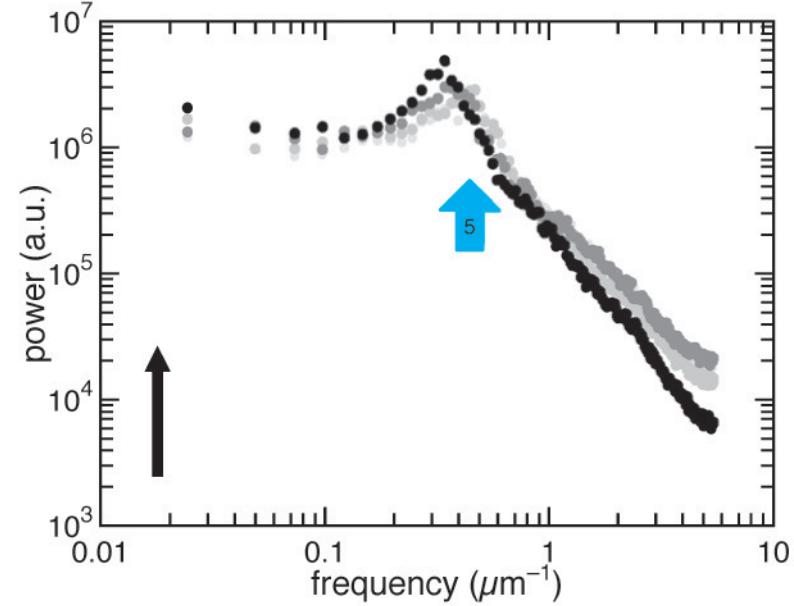
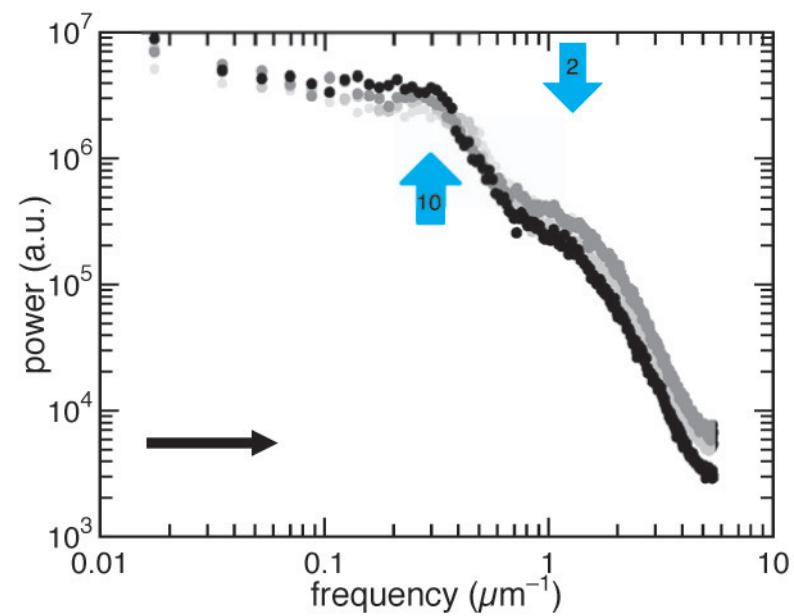
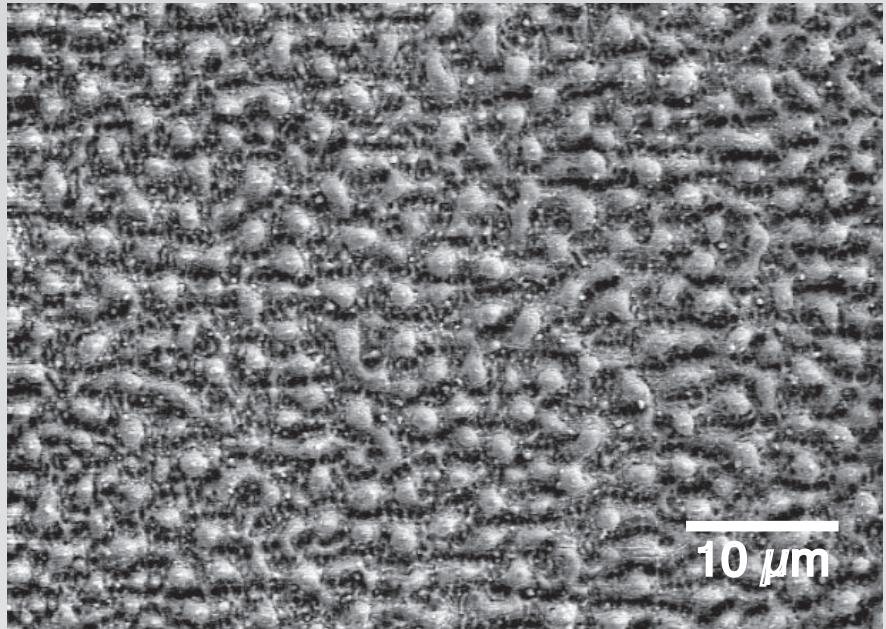
**1** texturing

**20 pulses**



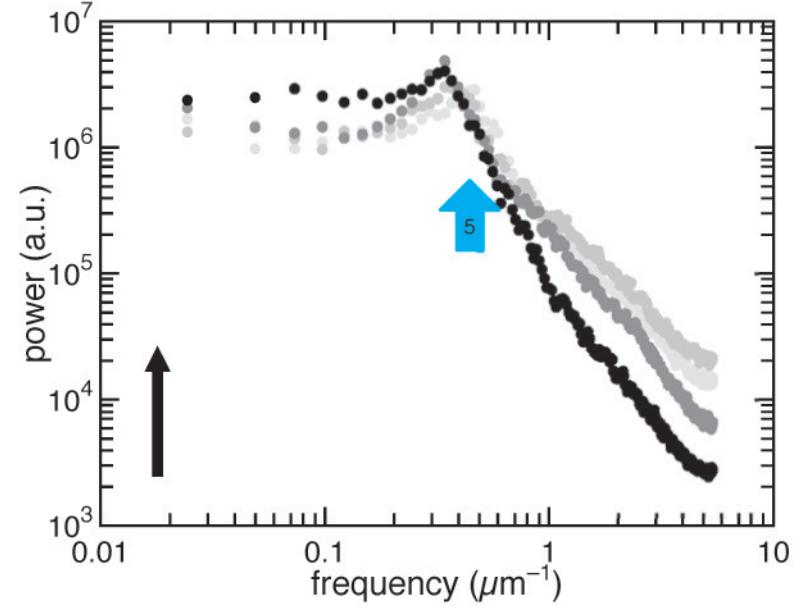
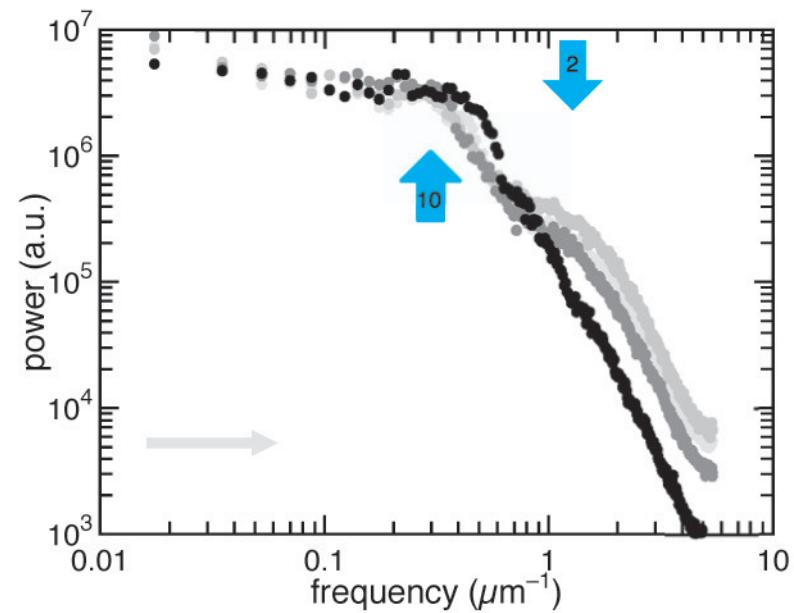
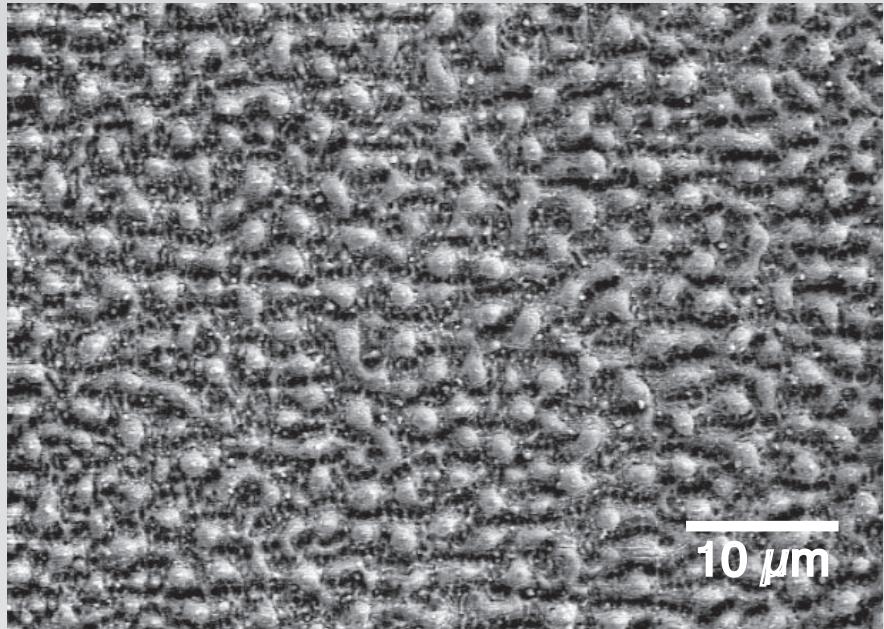
**1** texturing

**50 pulses**



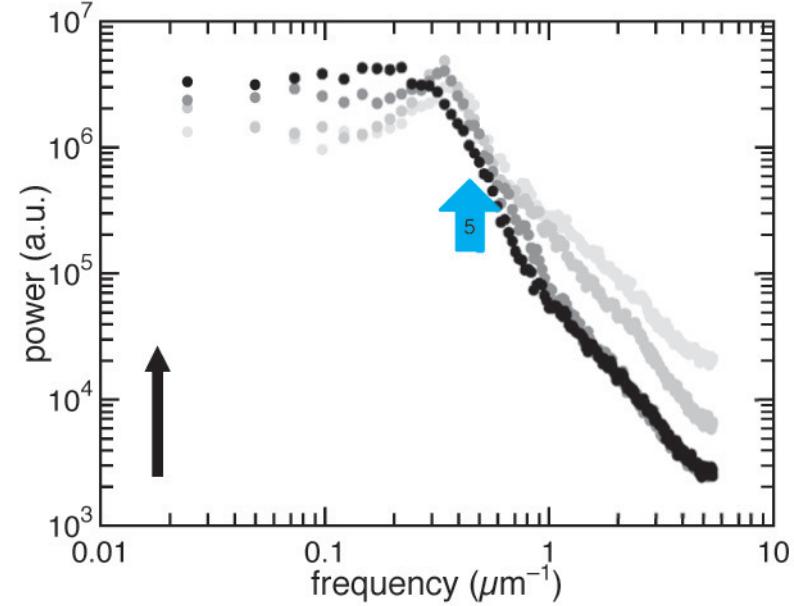
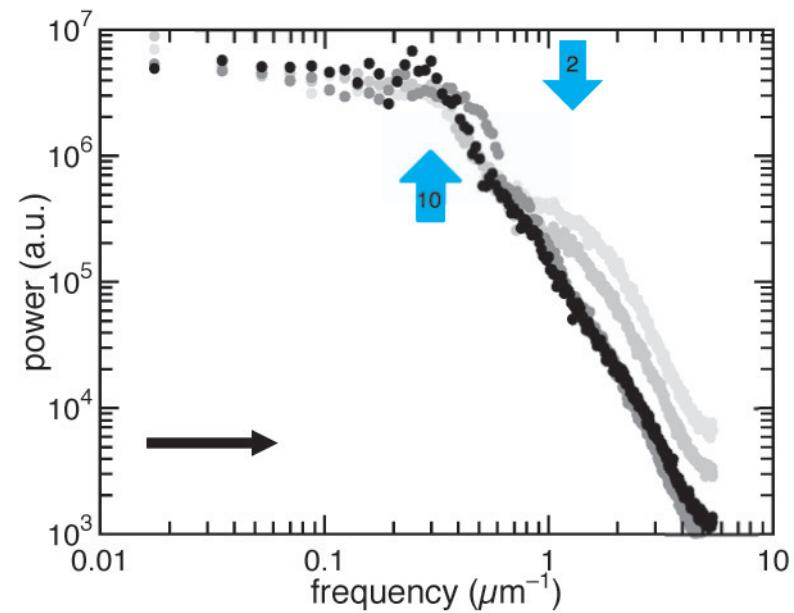
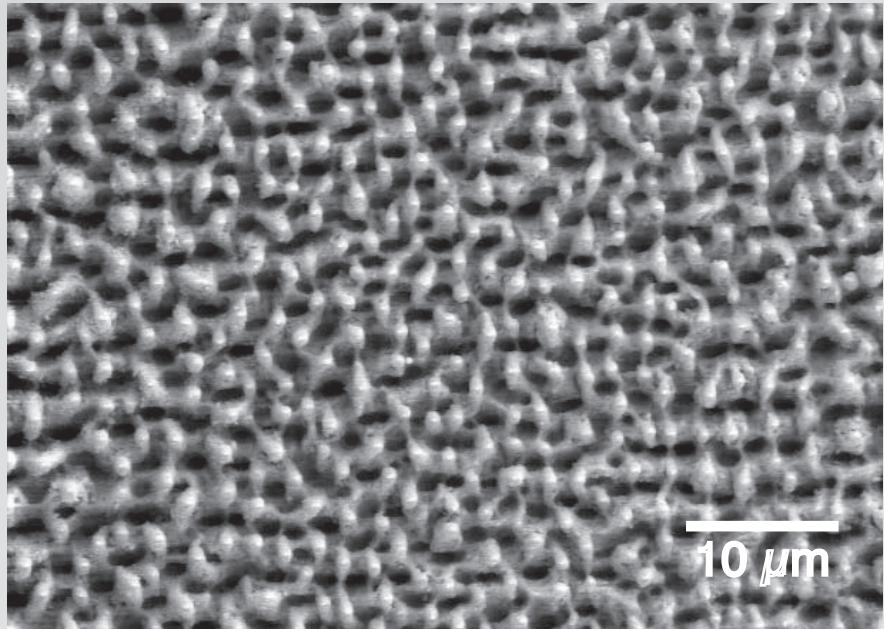
**1** texturing

**200 pulses**

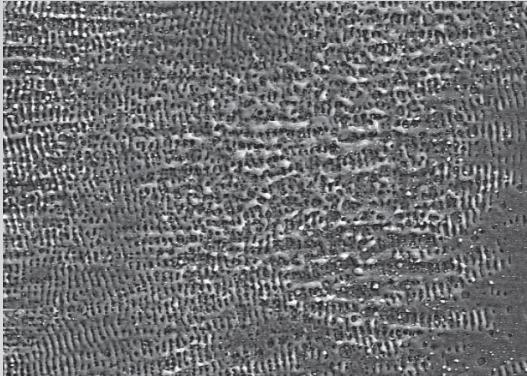


**1** texturing

**500 pulses**

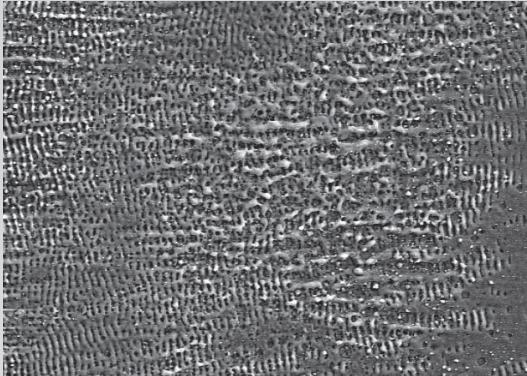


**1** texturing



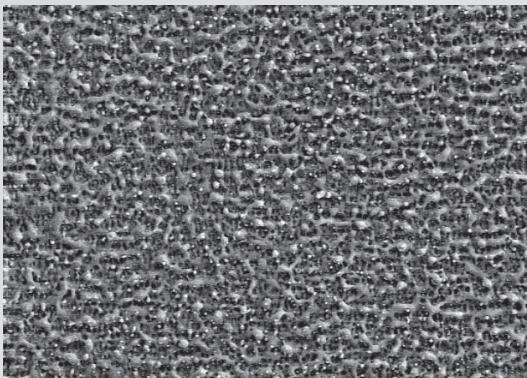
$N = 2$

interference ripples  
(perpendicular to polarization)



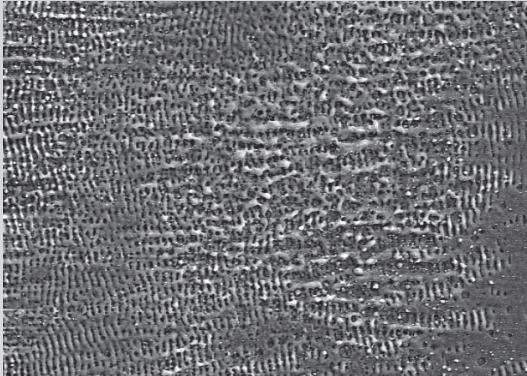
$N = 2$

interference ripples  
(perpendicular to polarization)



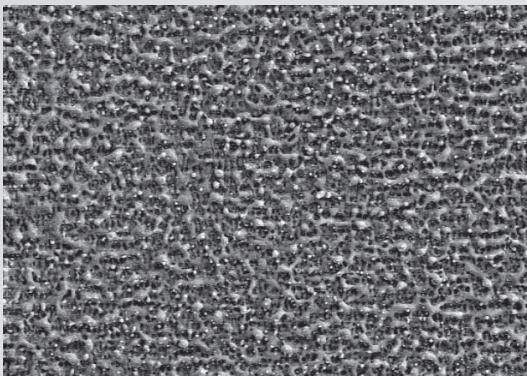
$N = 5$

coarsened ridges  
(perpendicular to ripples)



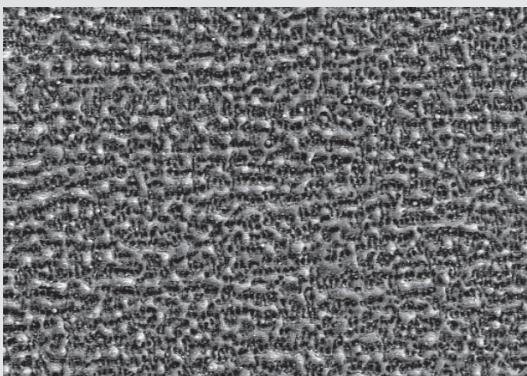
$N = 2$

interference ripples  
(perpendicular to polarization)



$N = 5$

coarsened ridges  
(perpendicular to ripples)



$N = 10$

beads sharpening into spikes  
(isotropic)

**2 distinct length scales:**

- ripples
- ridges/spikes

**2 distinct length scales:**

- ripples (laser wavelength)
- ridges/spikes

**2 distinct length scales:**

- **ripples (laser wavelength)**
- **ridges/spikes (longest capillary wave)**

**melt depth  $d$  and melt duration  $\tau$  limit capillary wavelength**

$$\lambda = \left[ \frac{\sigma d}{\rho} \right]^{\frac{1}{4}} \sqrt{2\pi\tau}$$

**melt depth  $d$  and melt duration  $\tau$  limit capillary wavelength**

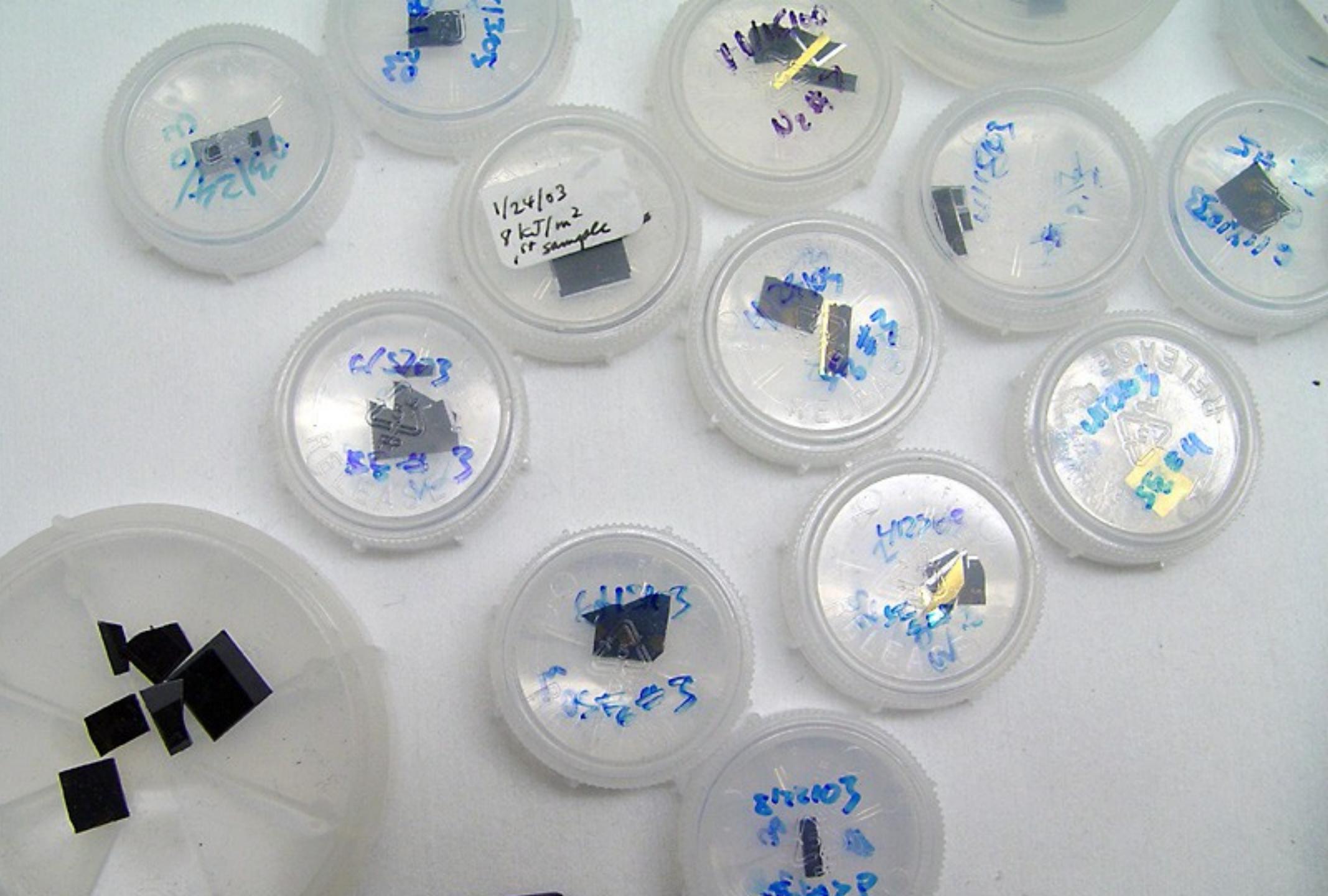
$$\lambda = \left[ \frac{\sigma d}{\rho} \right]^{\frac{1}{4}} \sqrt{2\pi\tau}$$

- longest wavelength  $\approx$  spike separation (5 μm)

**melt depth  $d$  and melt duration  $\tau$  limit capillary wavelength**

$$\lambda = \left[ \frac{\sigma d}{\rho} \right]^{\frac{1}{4}} \sqrt{2\pi\tau}$$

- longest wavelength  $\approx$  spike separation (5 μm)
- spike spacing & capillary wavelength increase with fluence



① texturing

② doping

**two processes: melting and ablation**

**1** texturing

**2** doping

**different thresholds:**

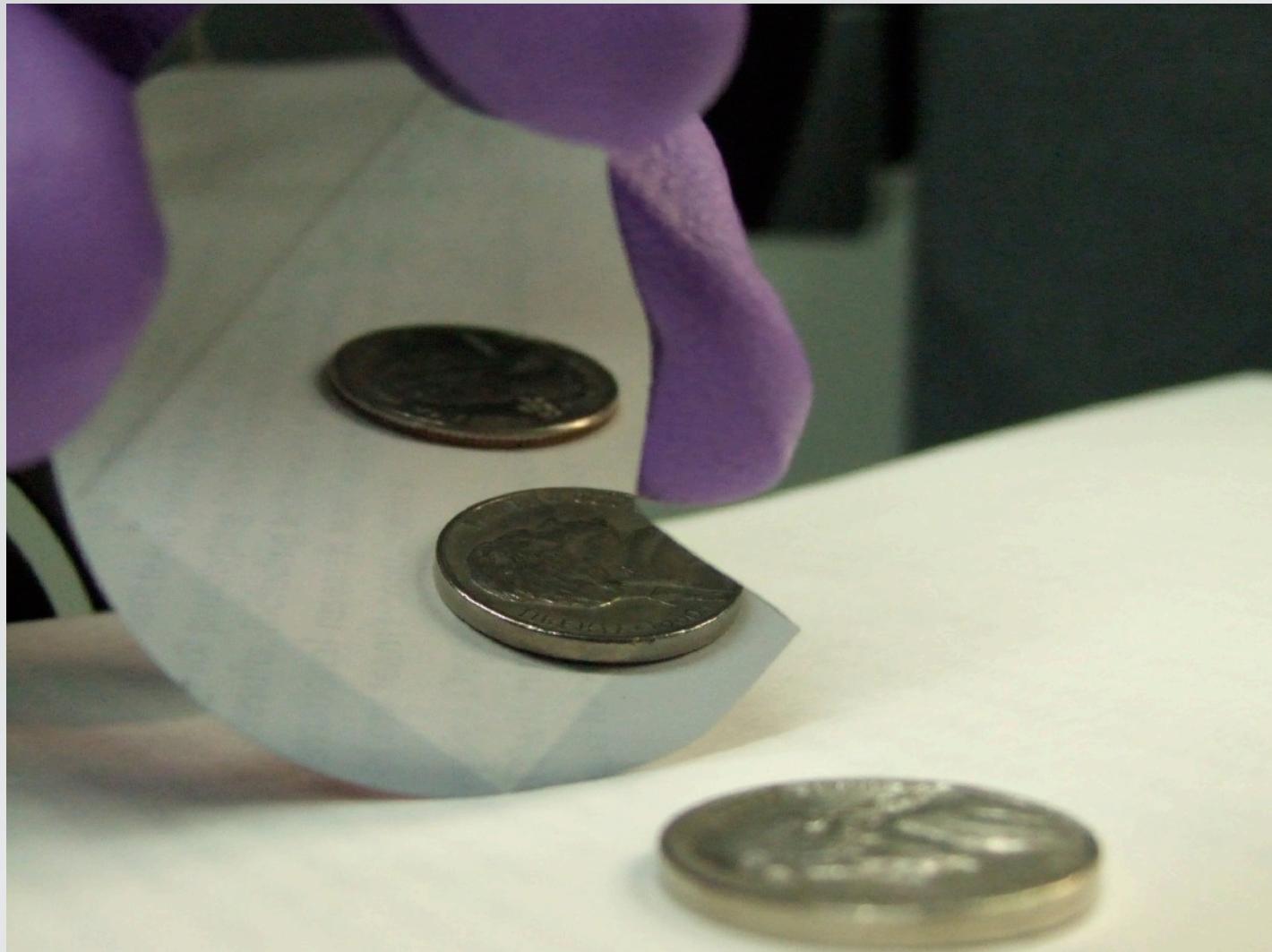
**melting:  $1.5 \text{ kJ/m}^2$**

**ablation:  $3.1 \text{ kJ/m}^2$**

**1** texturing

**2** doping

**decouple ablation from melting**

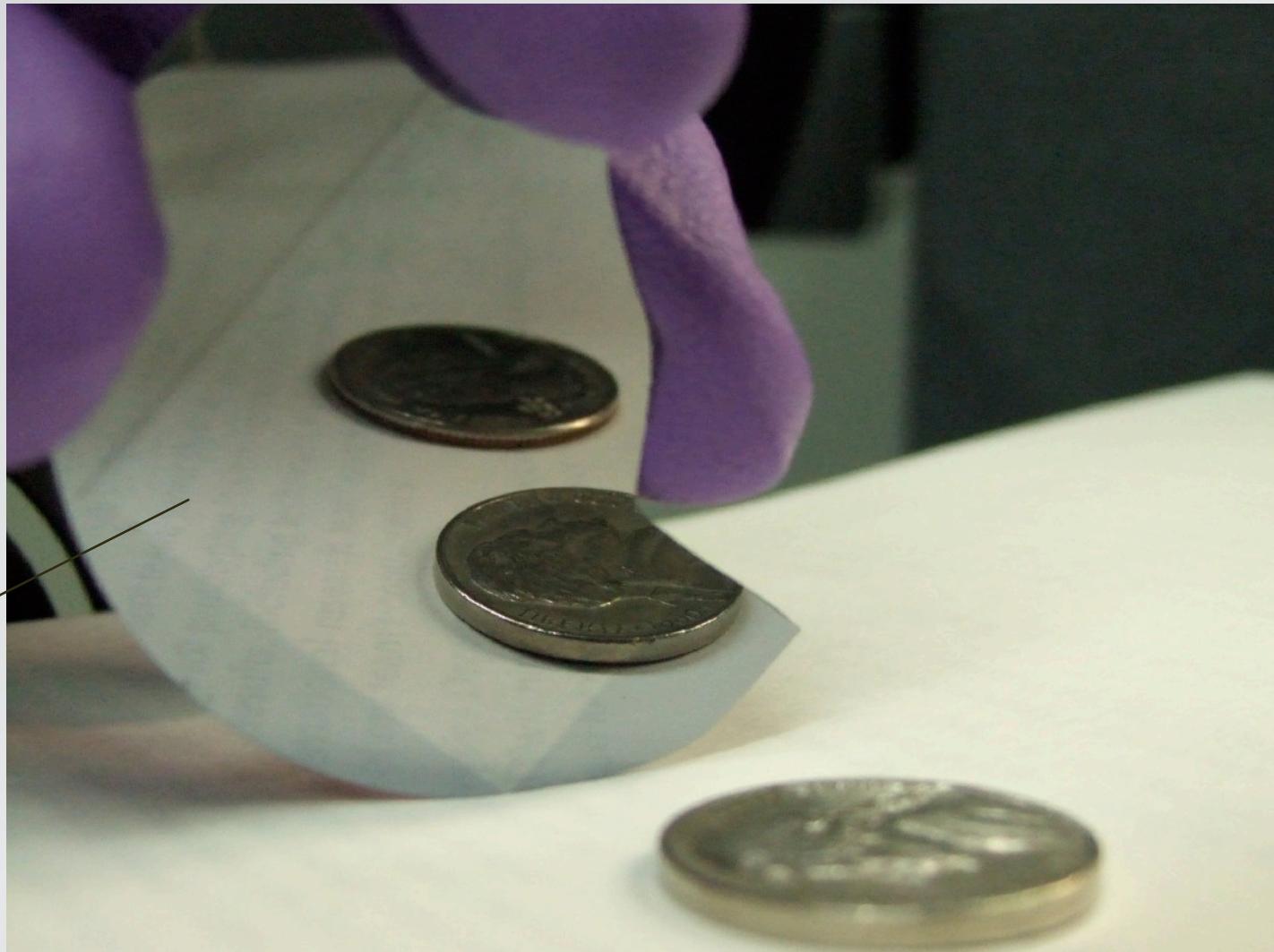


**1** texturing

**2** doping

# decouple ablation from melting

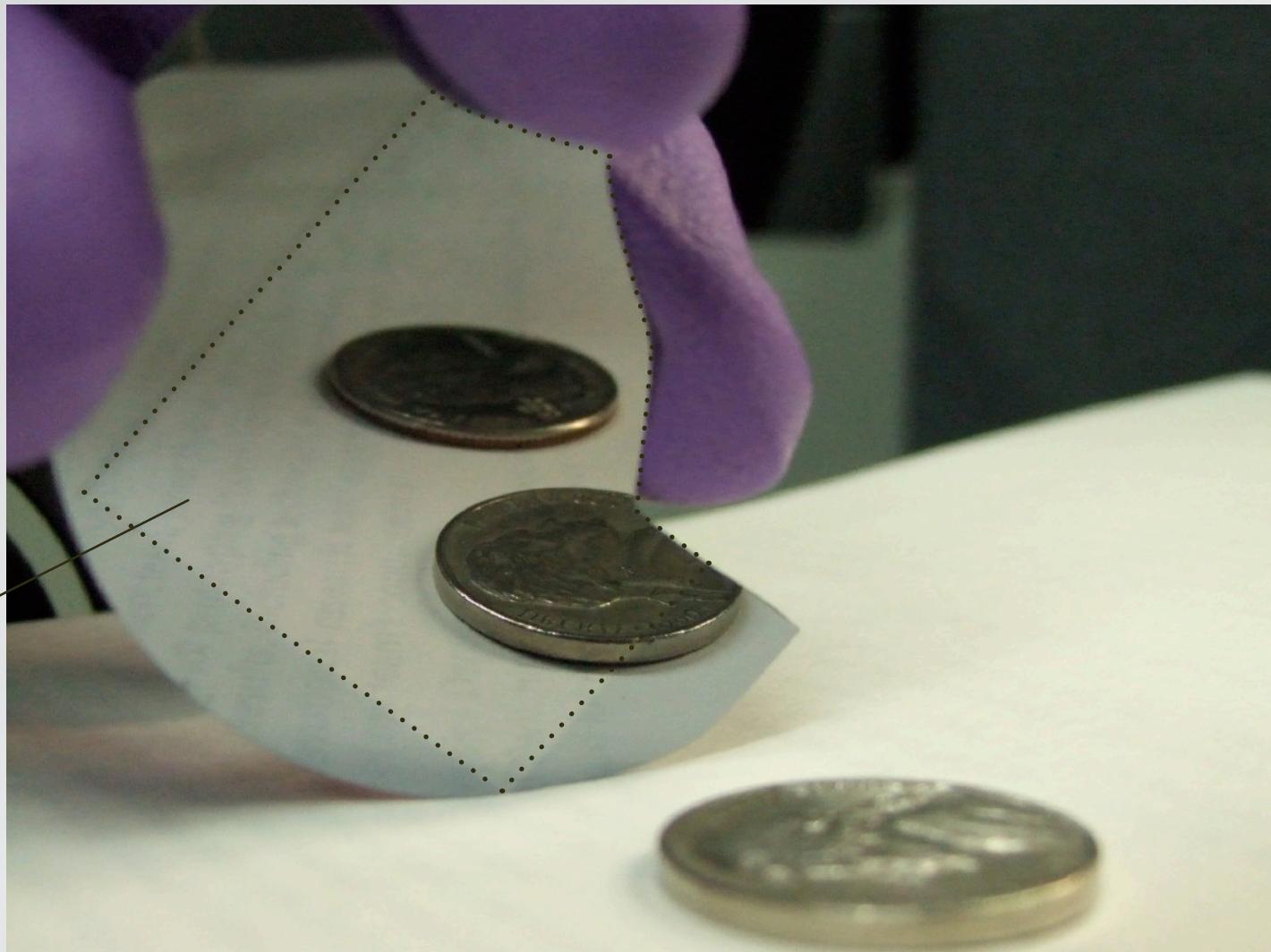
doped



1 texturing

2 doping

# decouple ablation from melting

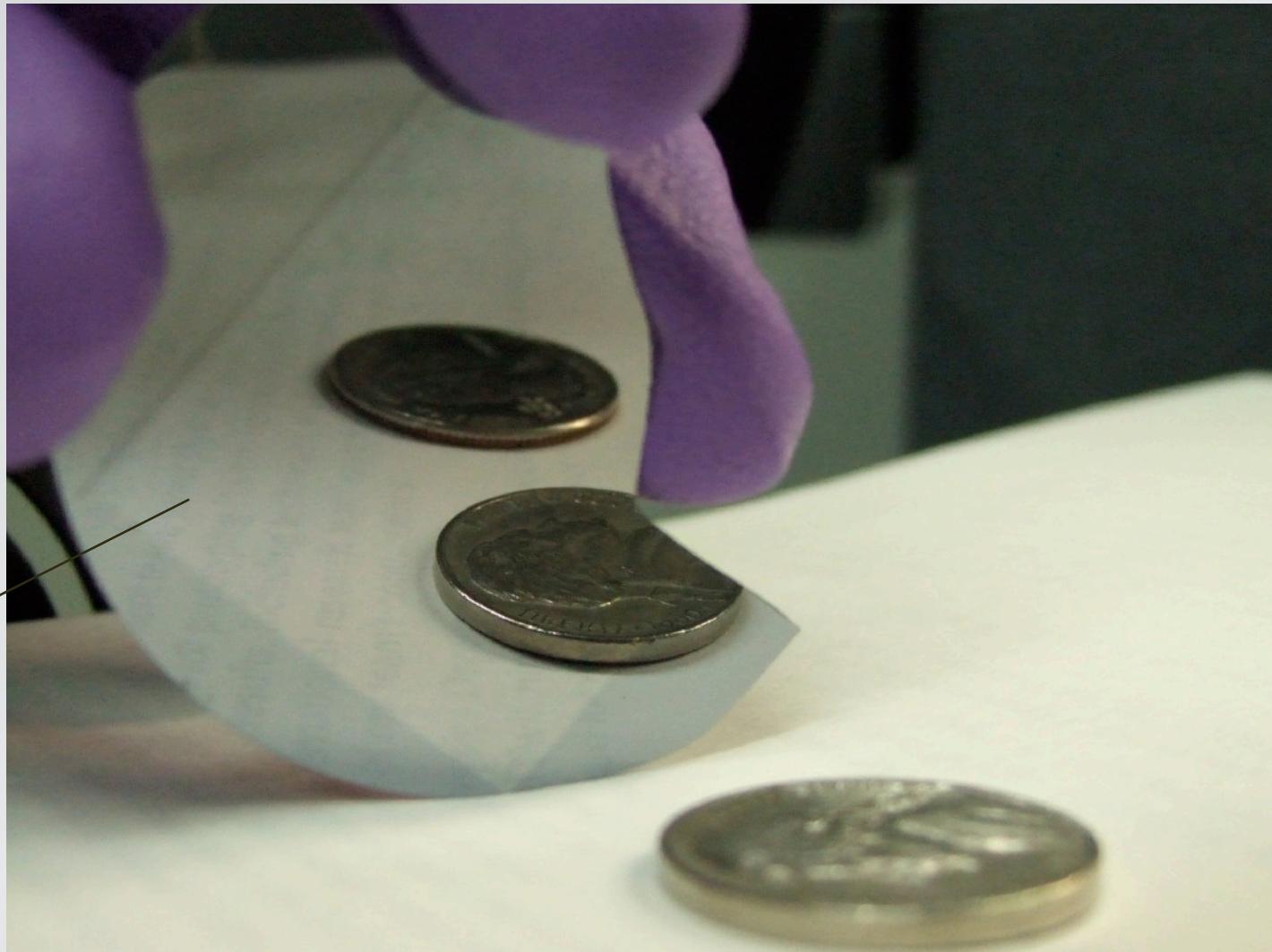


1 texturing

2 doping

# decouple ablation from melting

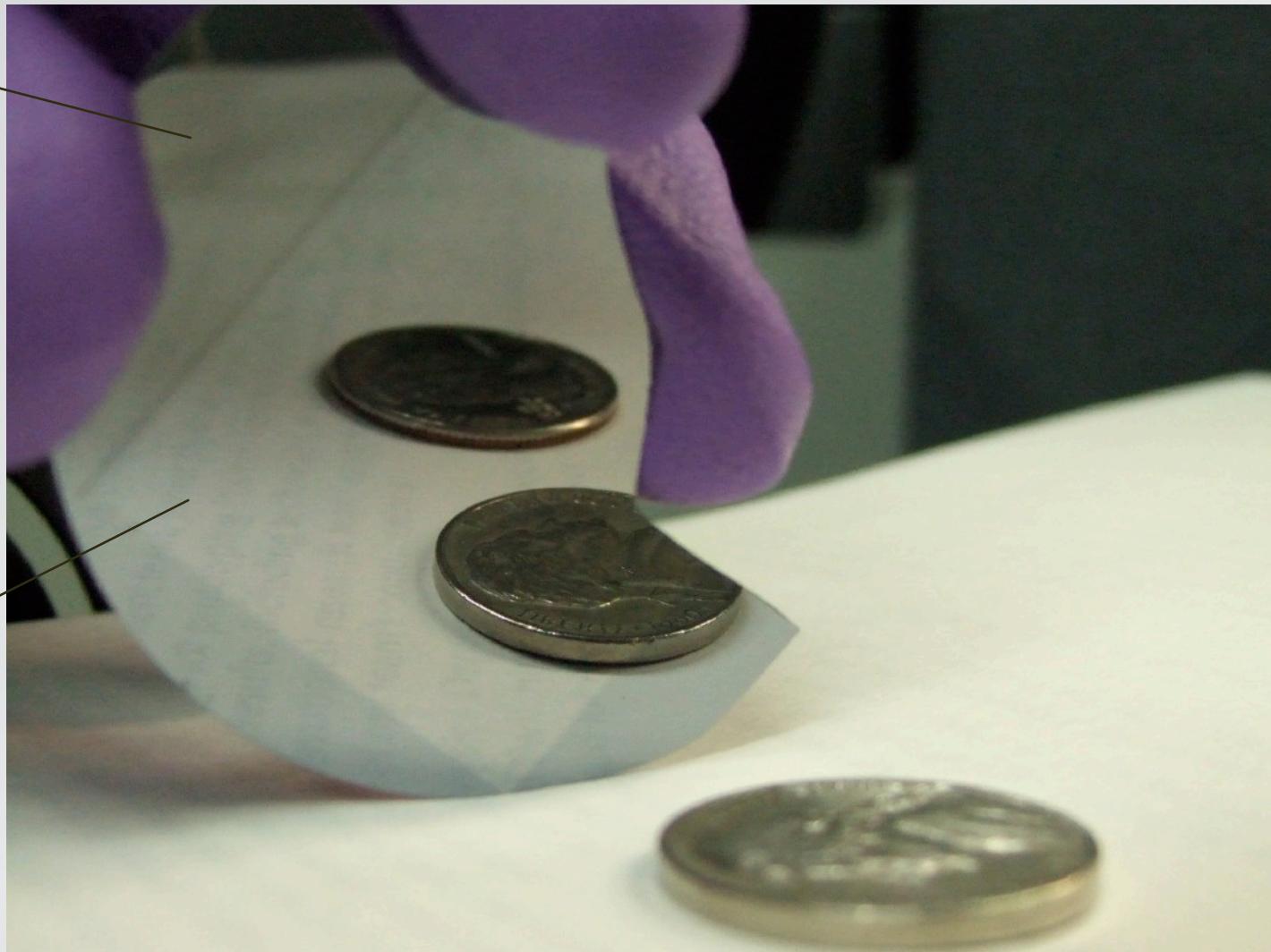
doped



1 texturing

2 doping

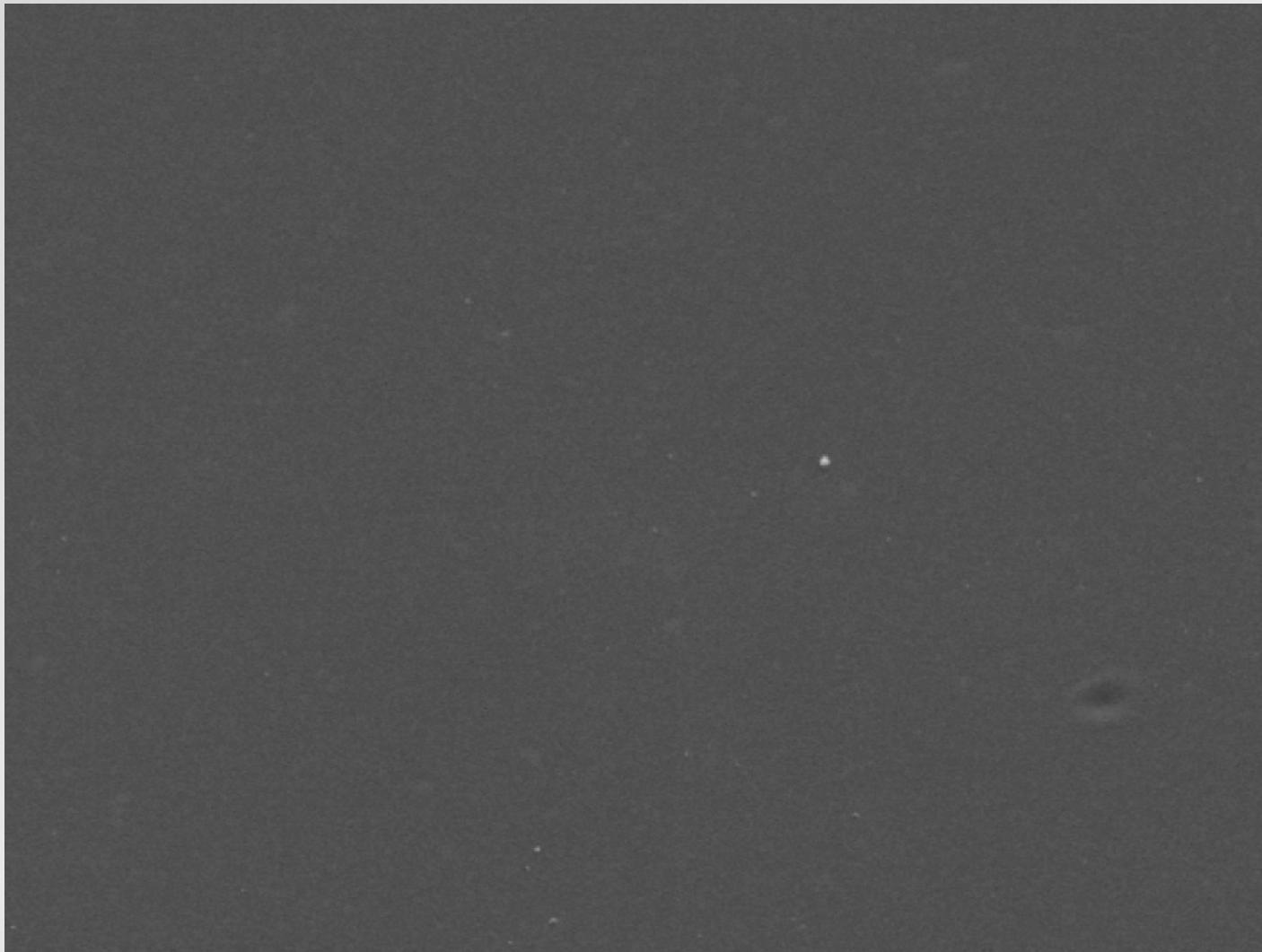
## decouple ablation from melting



1 texturing

2 doping

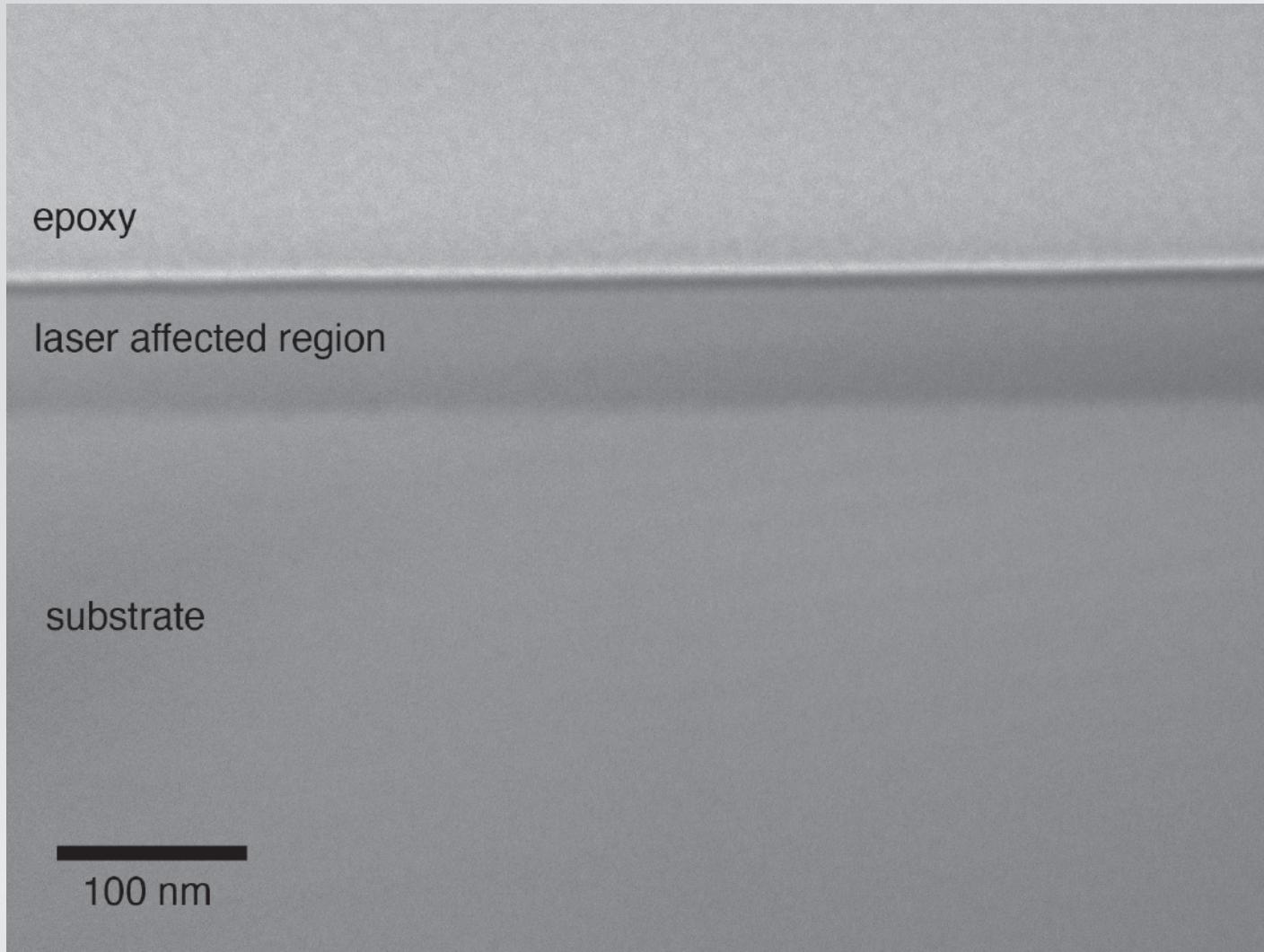
# **decouple ablation from melting**



**1** texturing

**2** doping

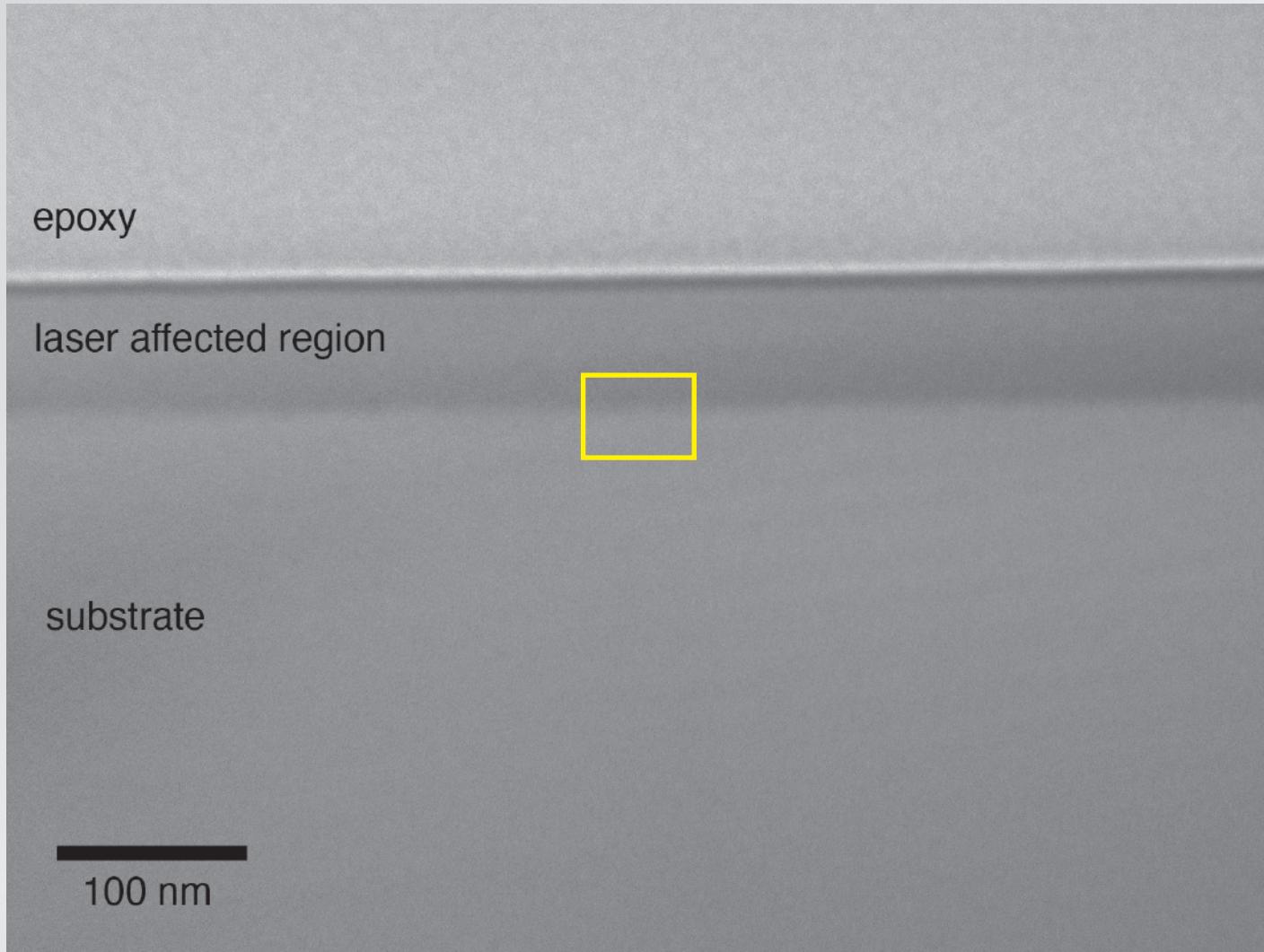
# decouple ablation from melting



1 texturing

2 doping

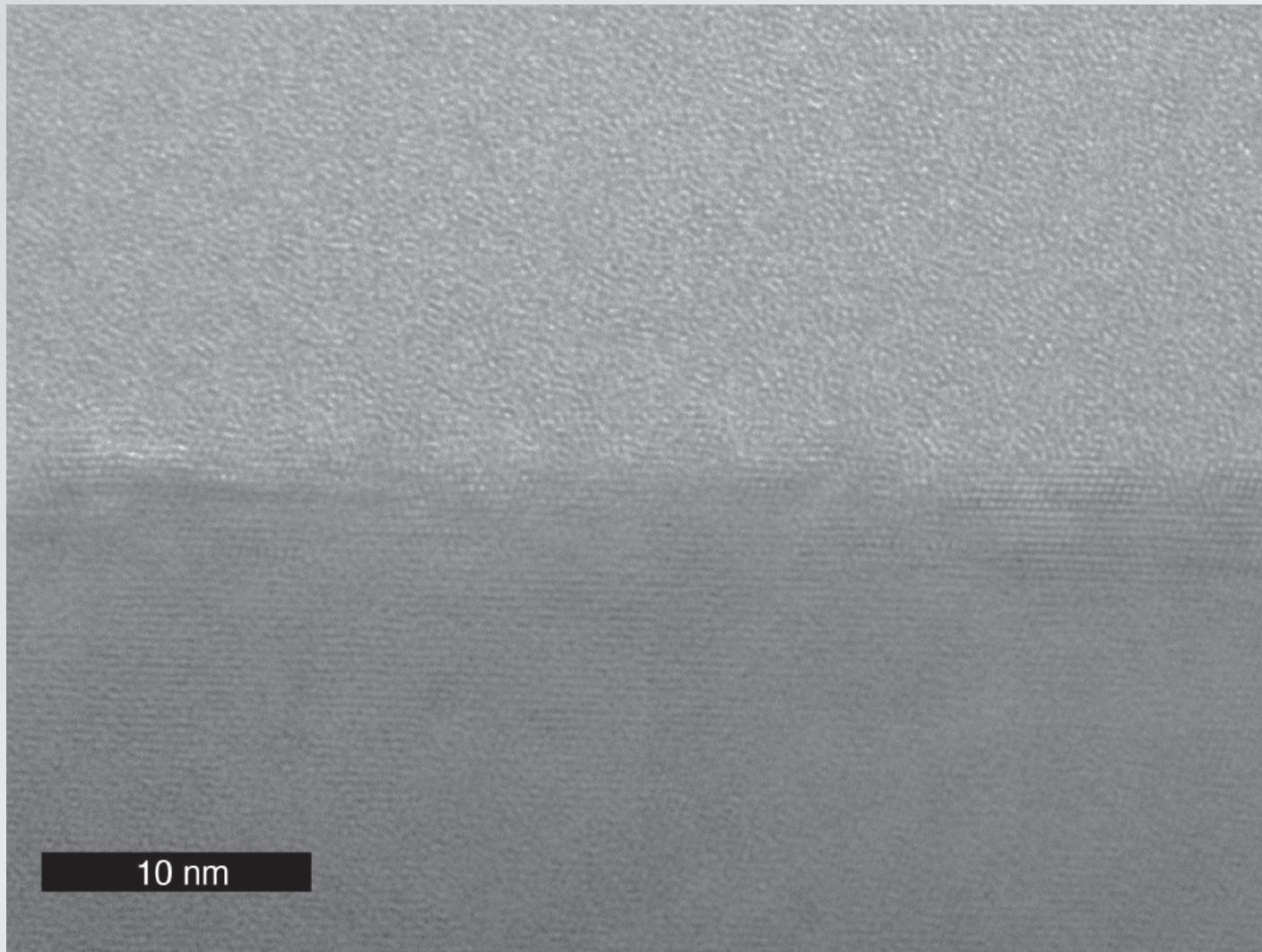
# decouple ablation from melting



1 texturing

2 doping

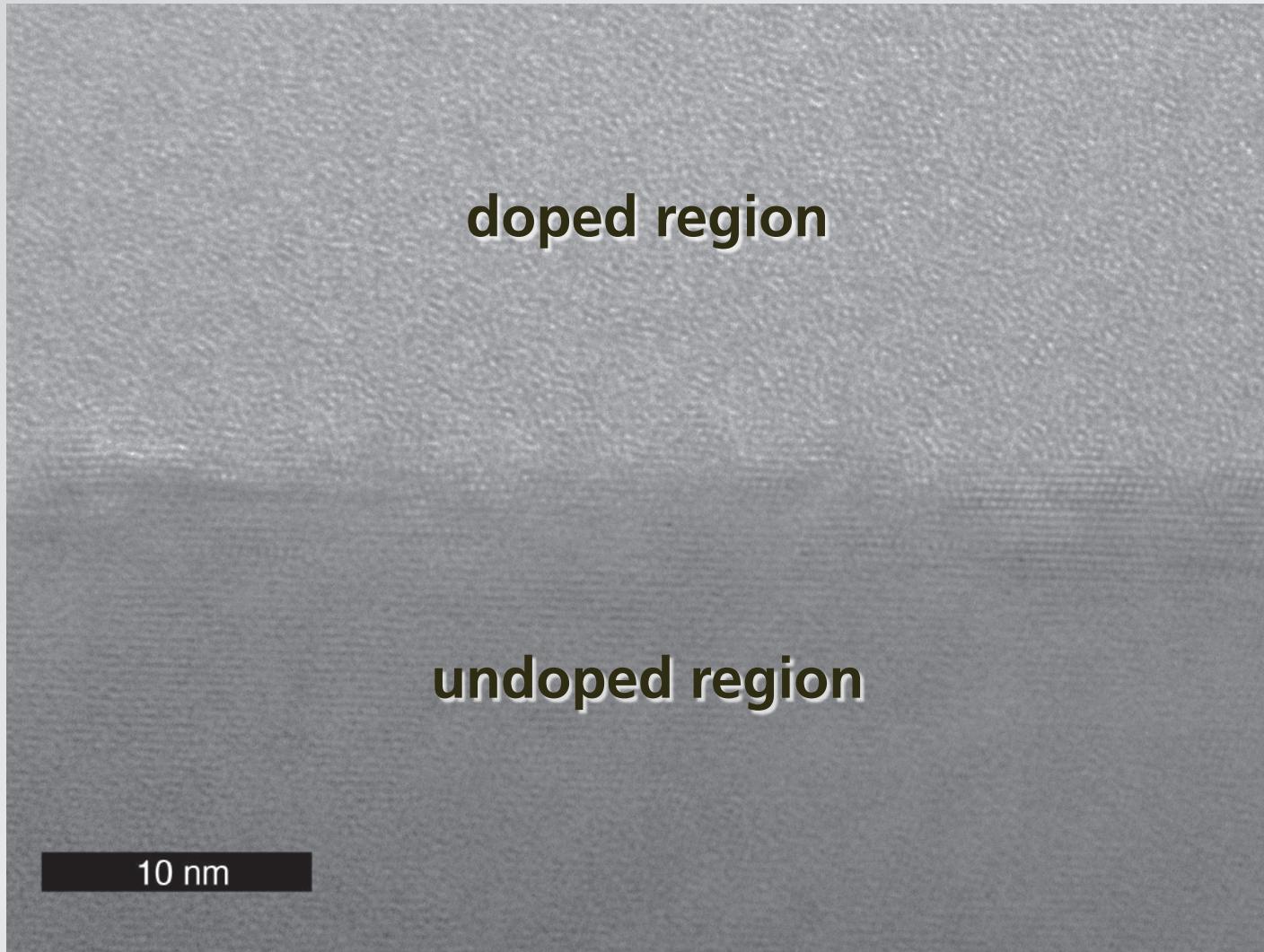
# decouple ablation from melting



1 texturing

2 doping

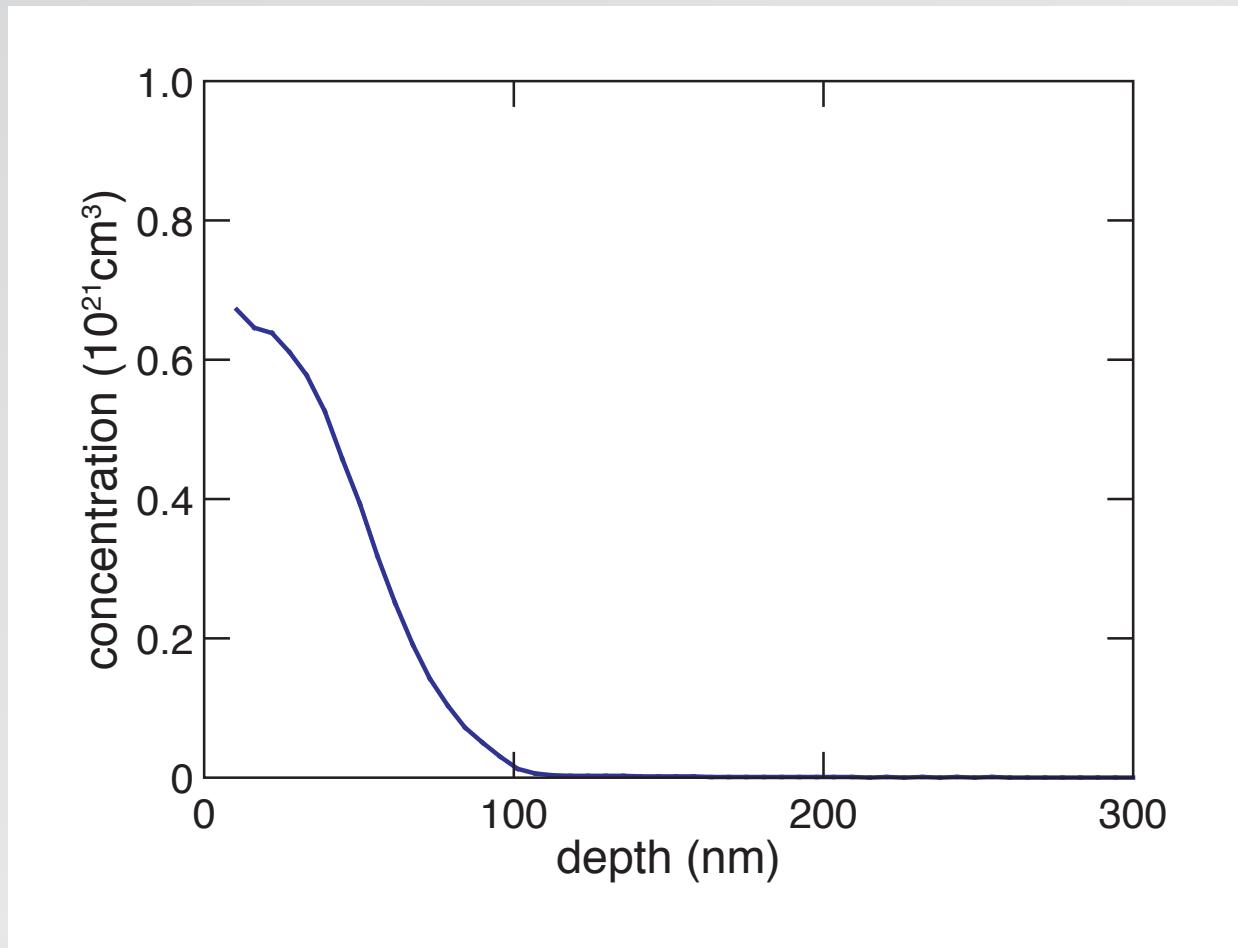
# **decouple ablation from melting**



**1** texturing

**2** doping

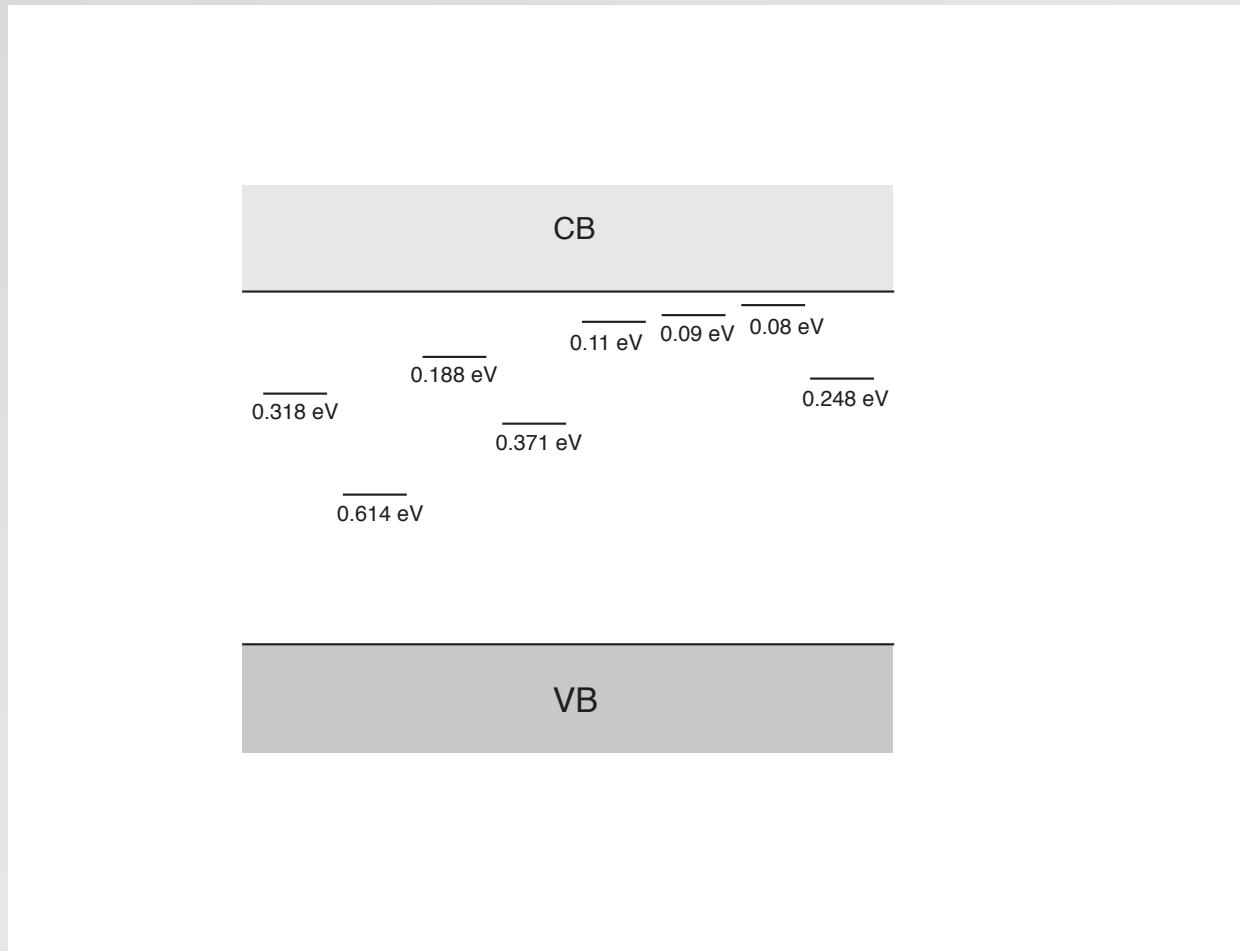
# secondary ion mass spectrometry



1 texturing

2 doping

**1 part in  $10^6$  sulfur introduces donor states in gap**

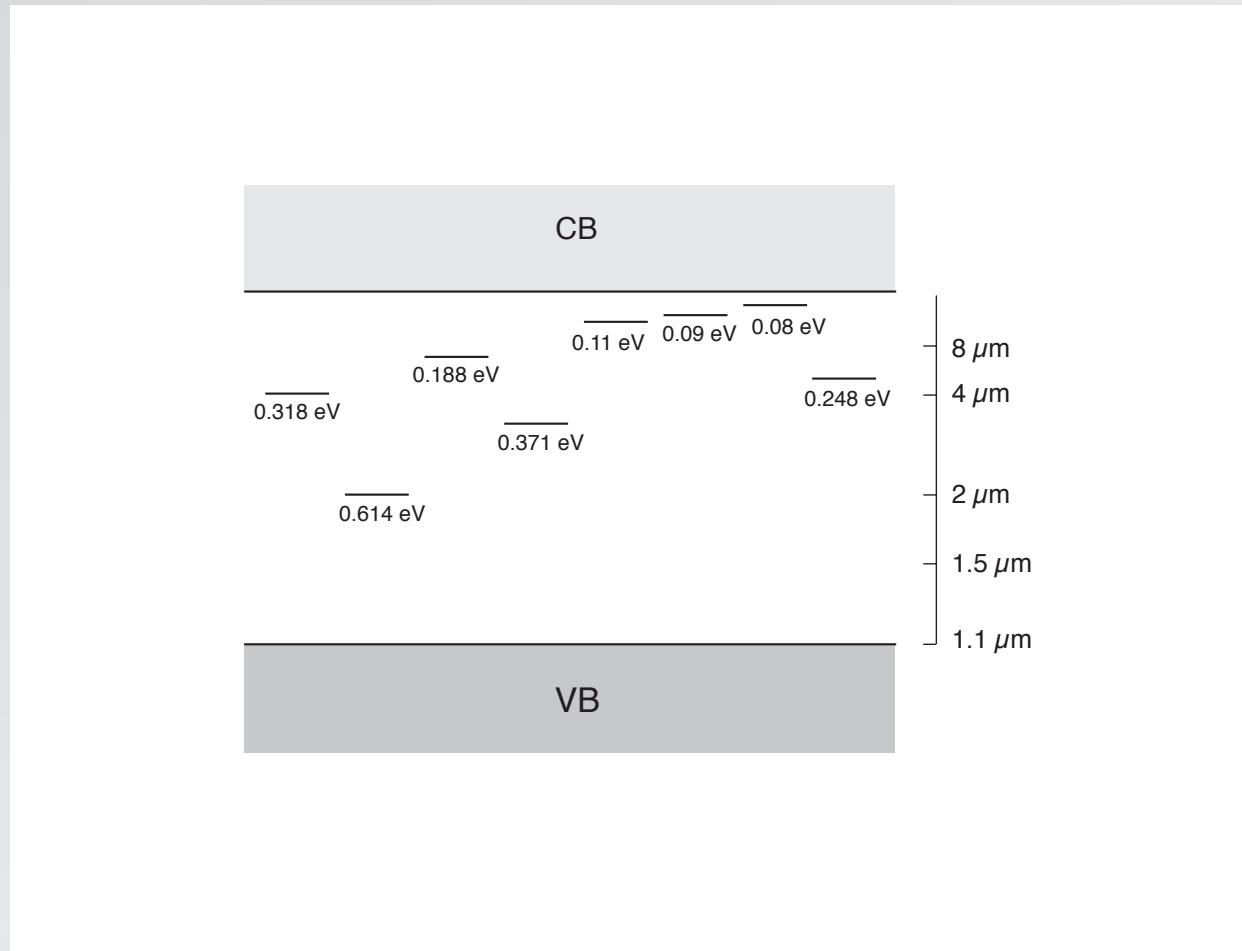


Janzén *et al.*, Phys. Rev. B 29, 1907 (1984)

**1** texturing

**2** doping

# 1 part in $10^6$ sulfur introduces donor states in gap

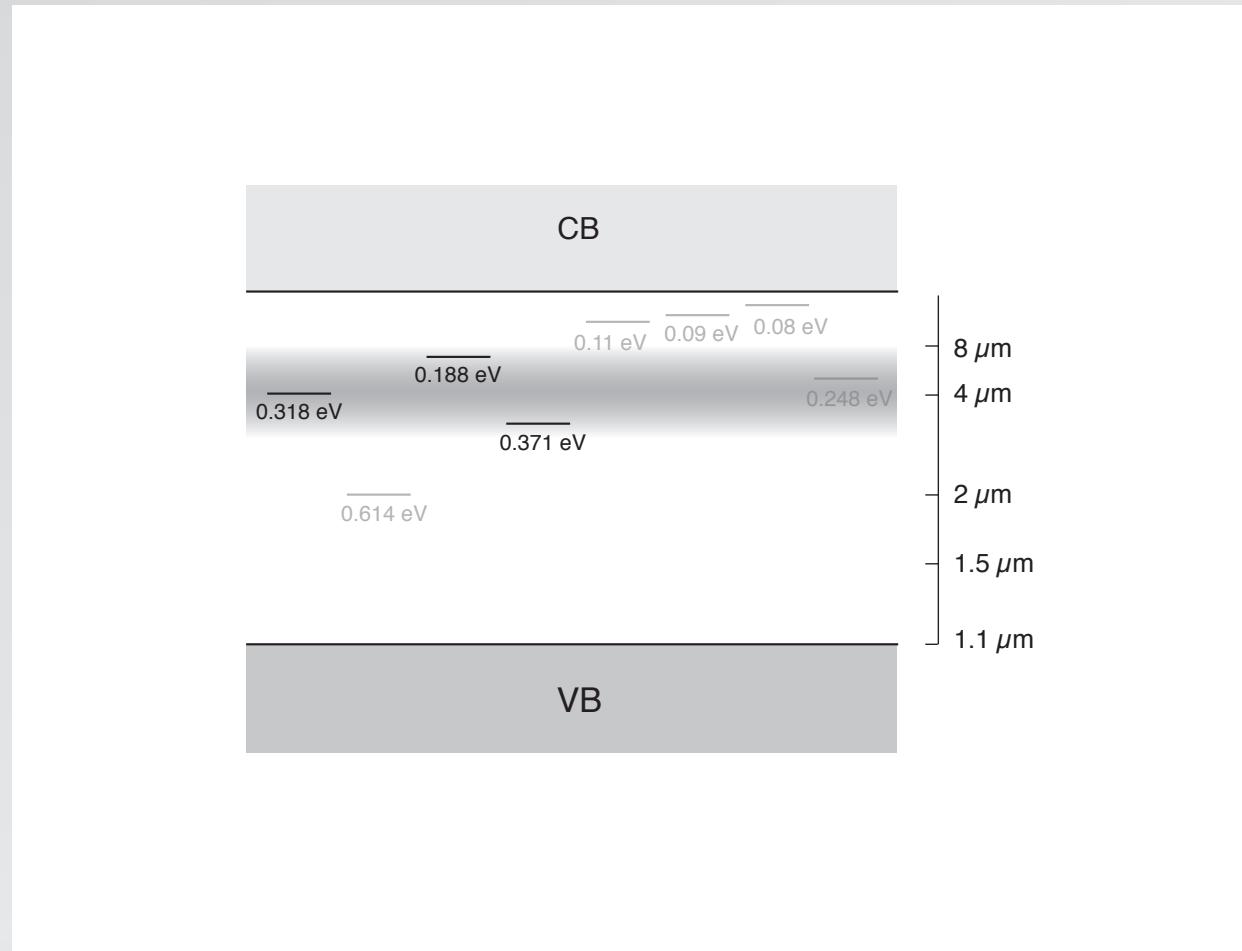


Janzén *et al.*, Phys. Rev. B 29, 1907 (1984)

1 texturing

2 doping

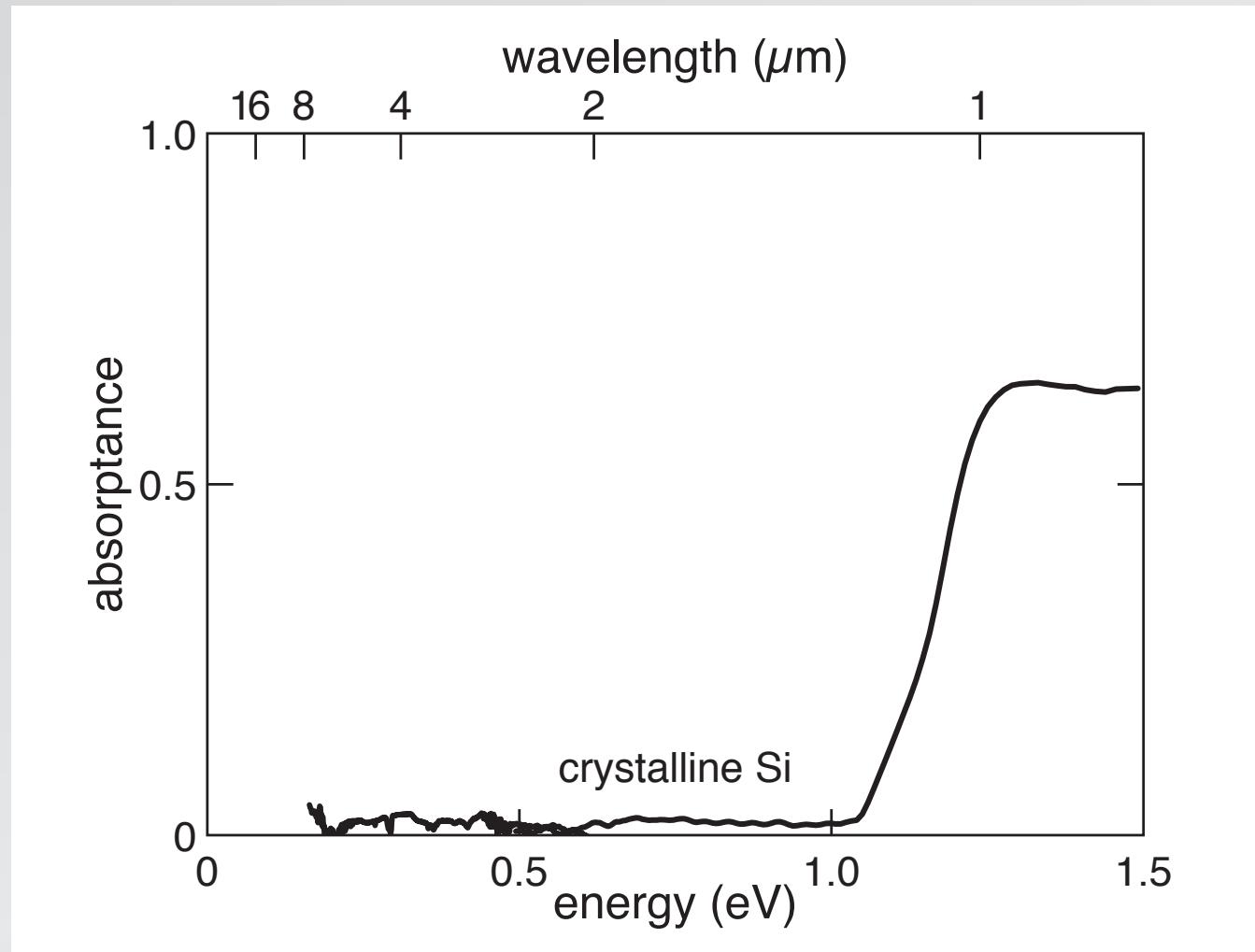
**at high concentration states broaden into band**



**1** texturing

**2** doping

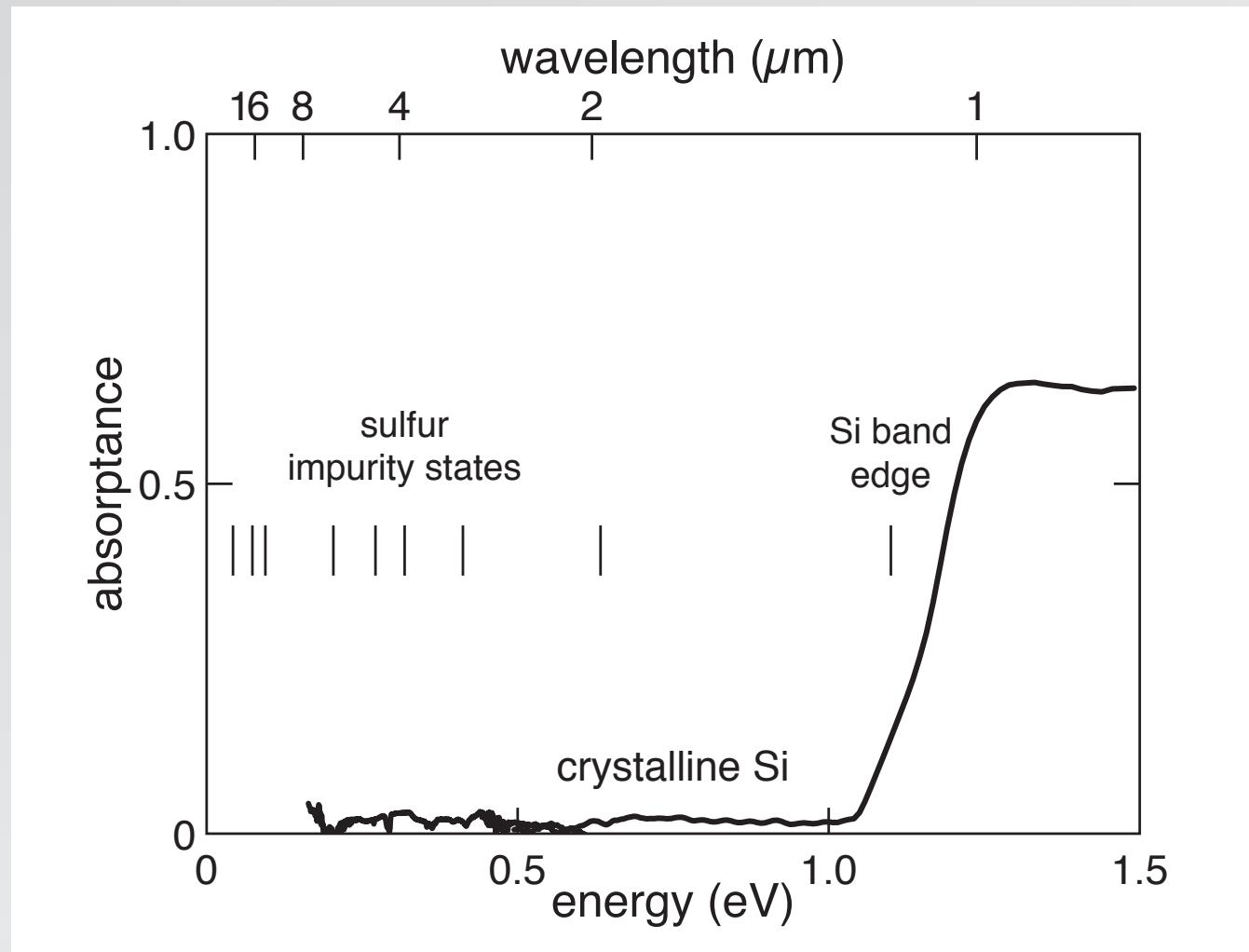
**absorptance ( $1 - R_{int} - T_{int}$ )**



1 texturing

2 doping

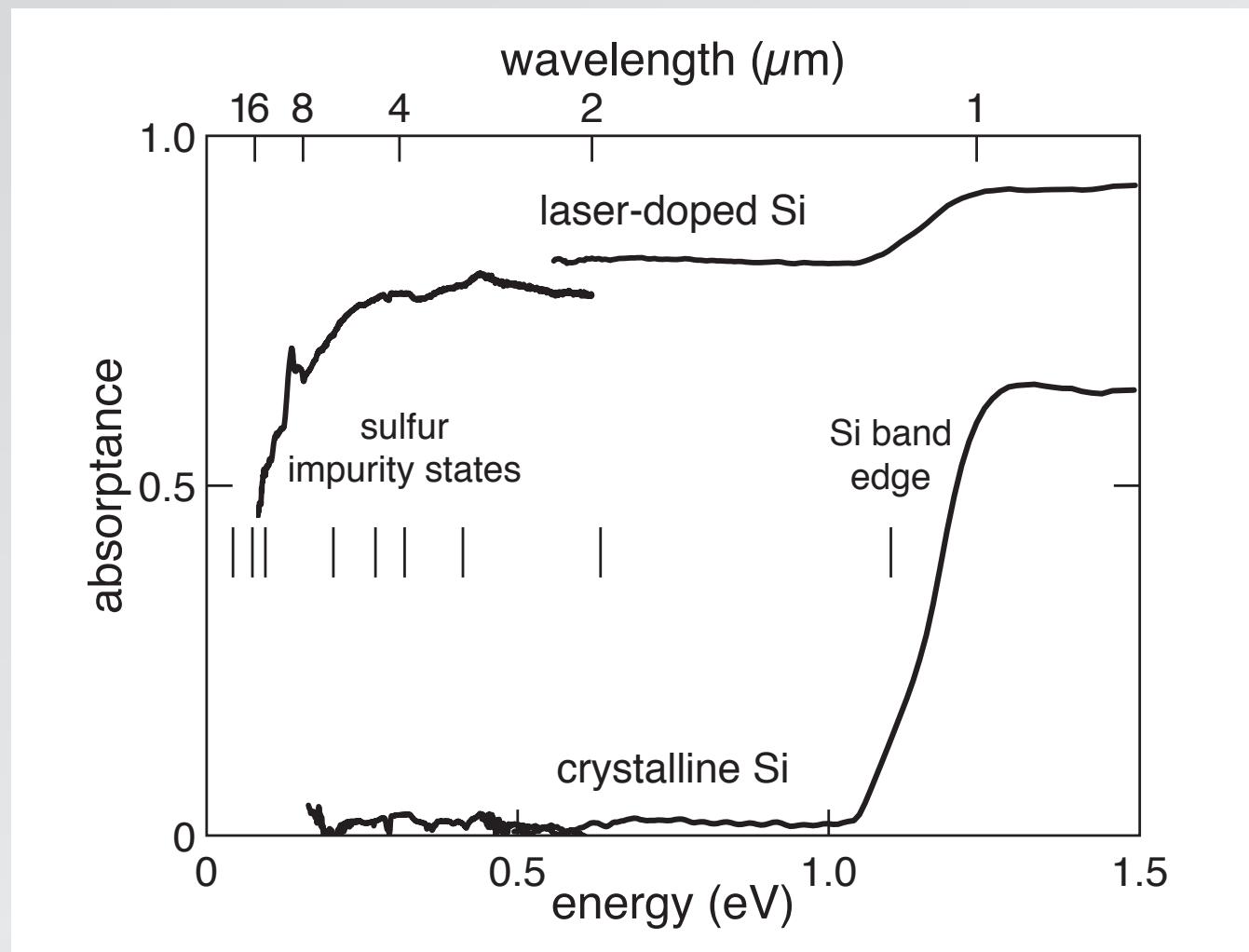
## $10^{-6}$ sulfur doping



1 texturing

2 doping

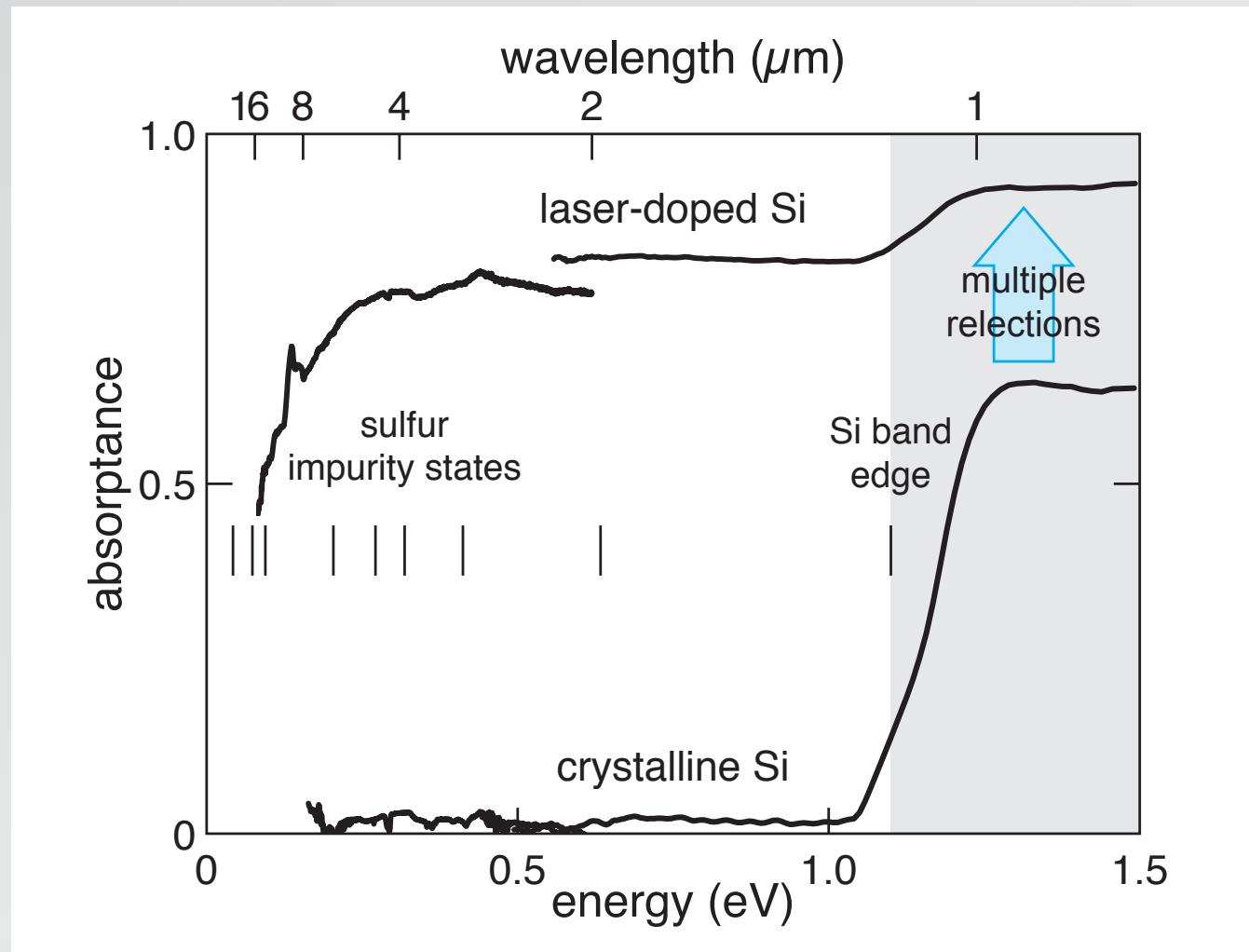
## **laser-doped S:Si**



**1** texturing

**2** doping

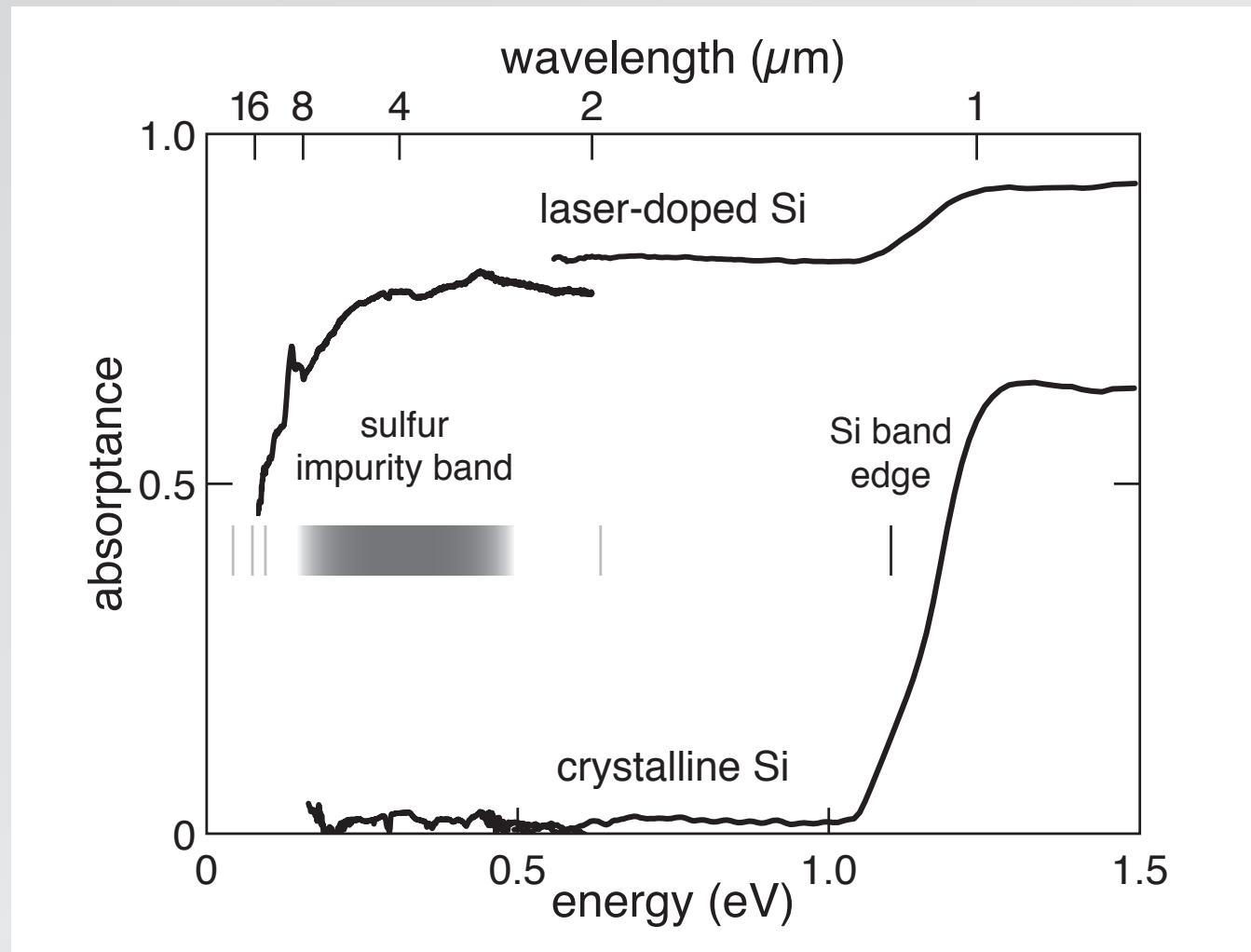
## **laser-doped S:Si**



**1** texturing

**2** doping

## **laser-doped S:Si**



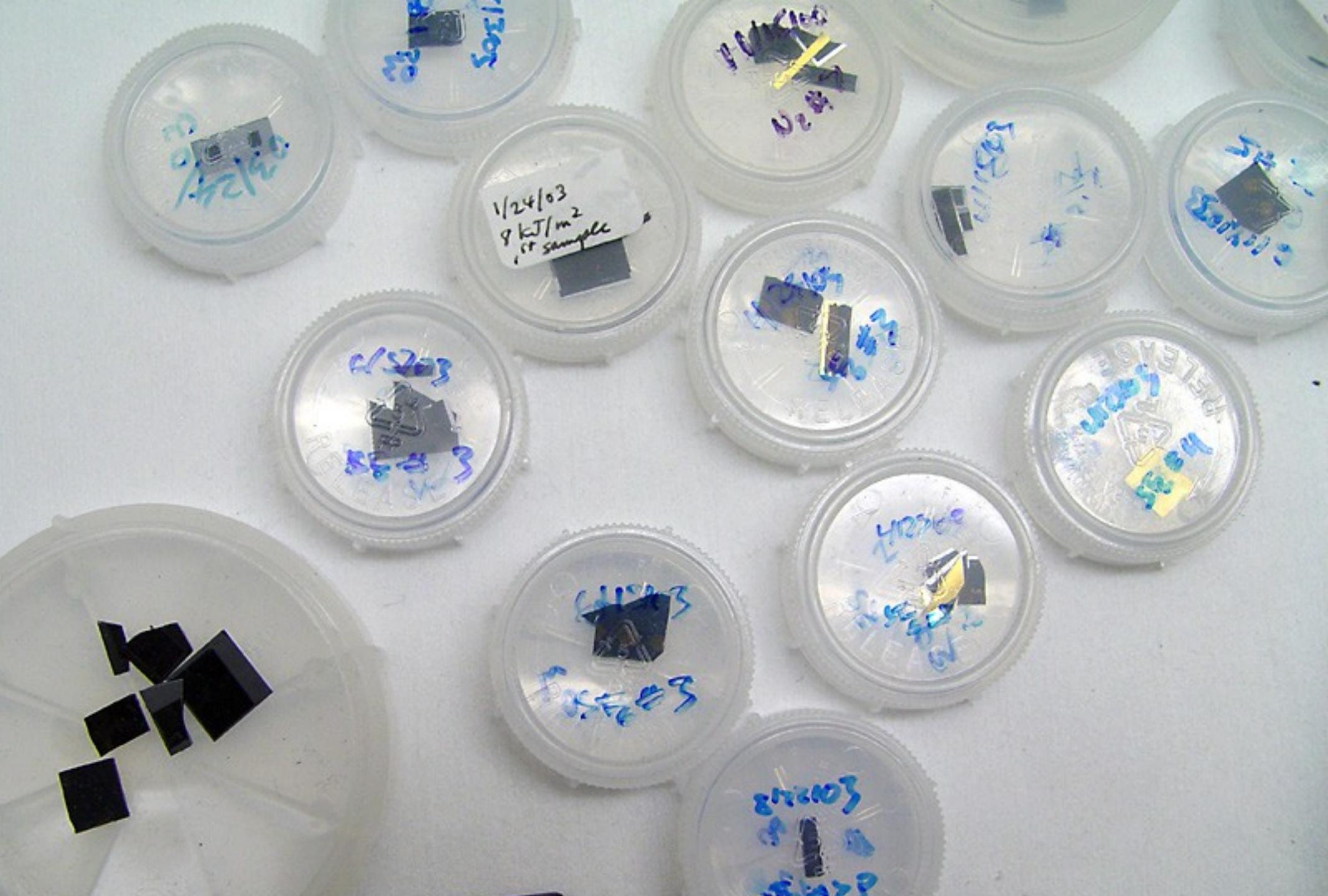
**1** texturing

**2** doping

**doping creates intermediate band**

**1** texturing

**2** doping

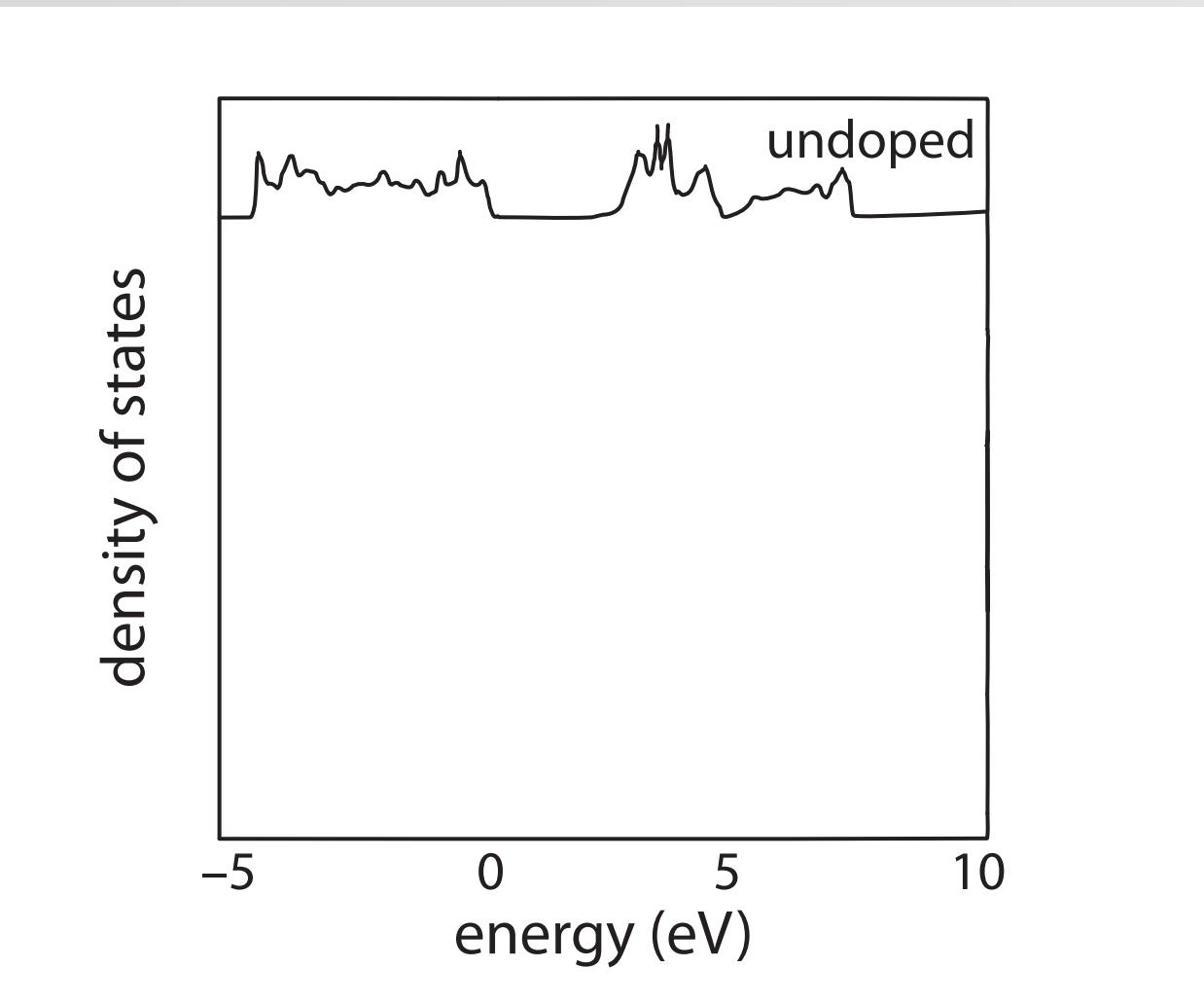


① texturing

② doping

③ X:TiO<sub>2</sub>

## TiO<sub>2</sub> density of states



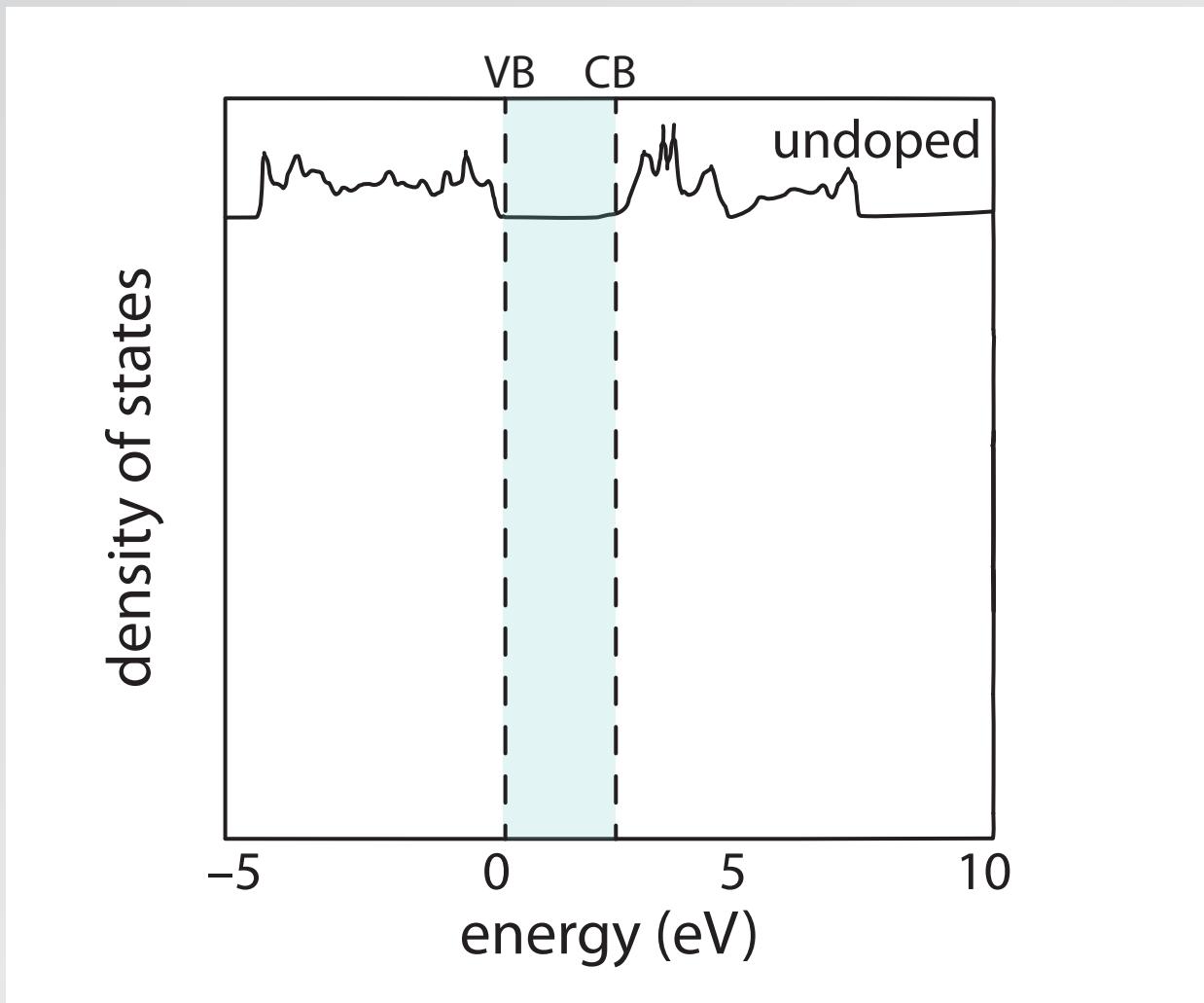
Asahi *et al.*, Science (2003)

1 texturing

2 doping

3 X:TiO<sub>2</sub>

need to create band(s) in gap



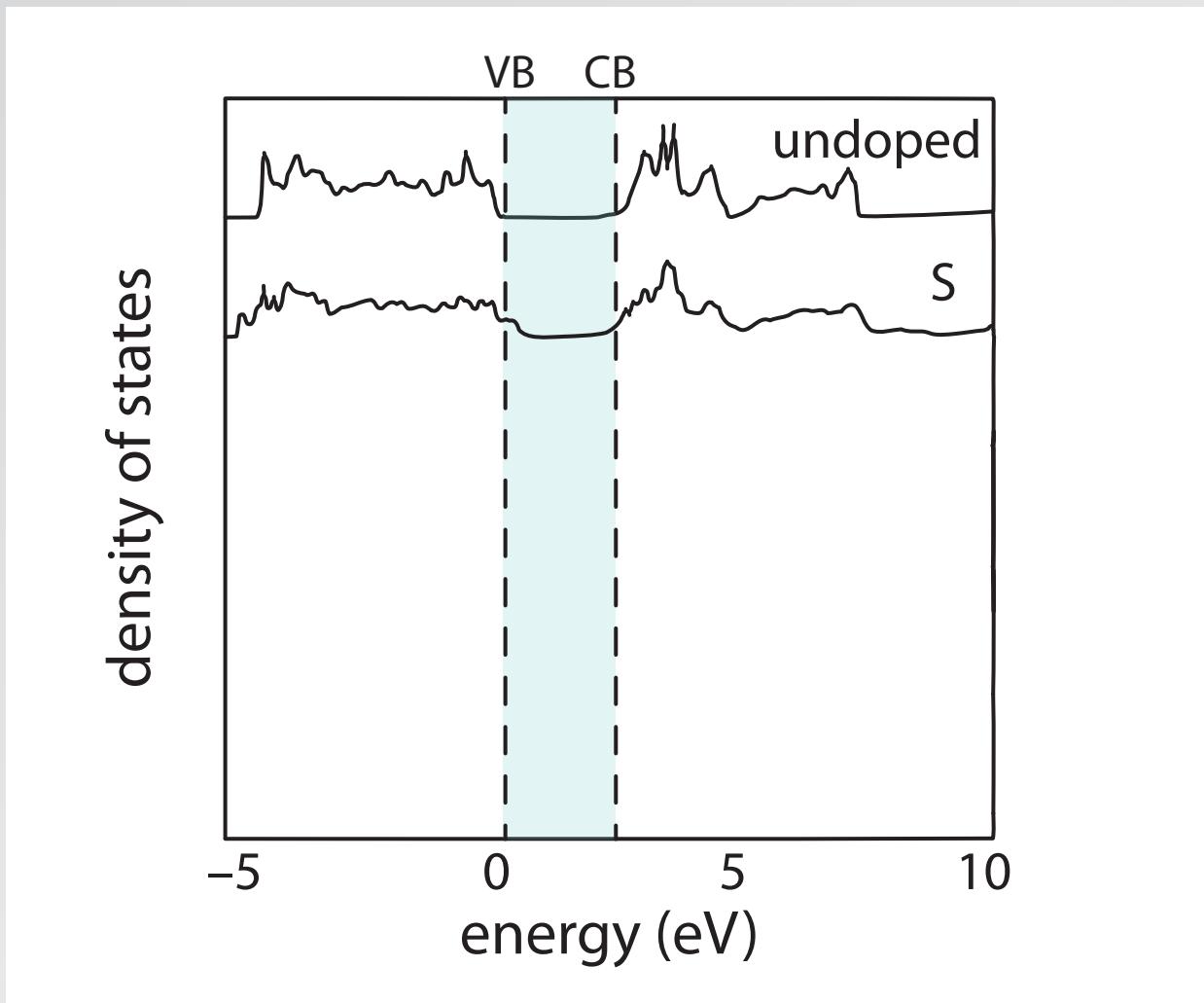
Asahi *et al.*, Science (2003)

1 texturing

2 doping

3 X:TiO<sub>2</sub>

need to create band(s) in gap



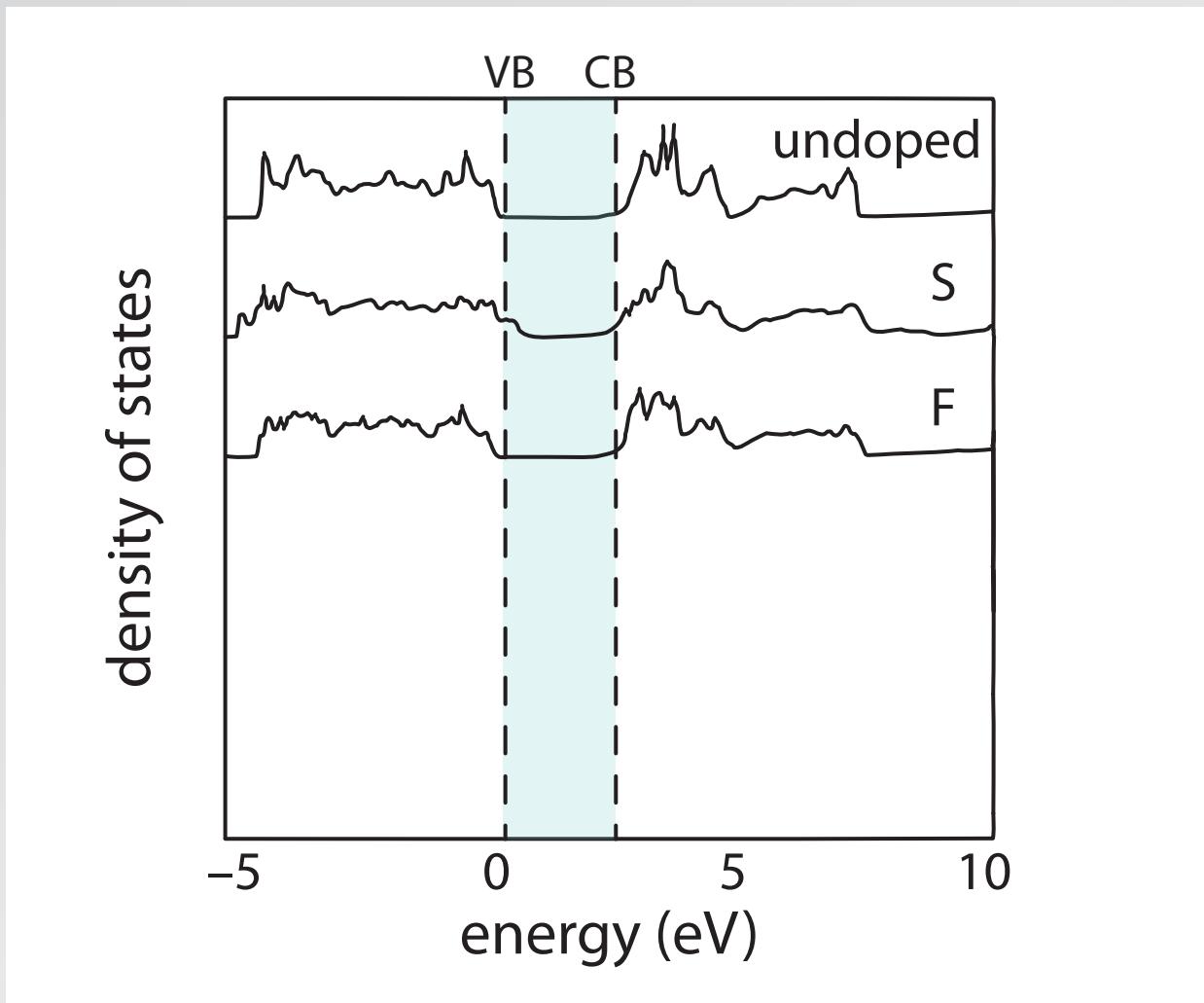
Asahi *et al.*, Science (2003)

1 texturing

2 doping

3 X:TiO<sub>2</sub>

need to create band(s) in gap



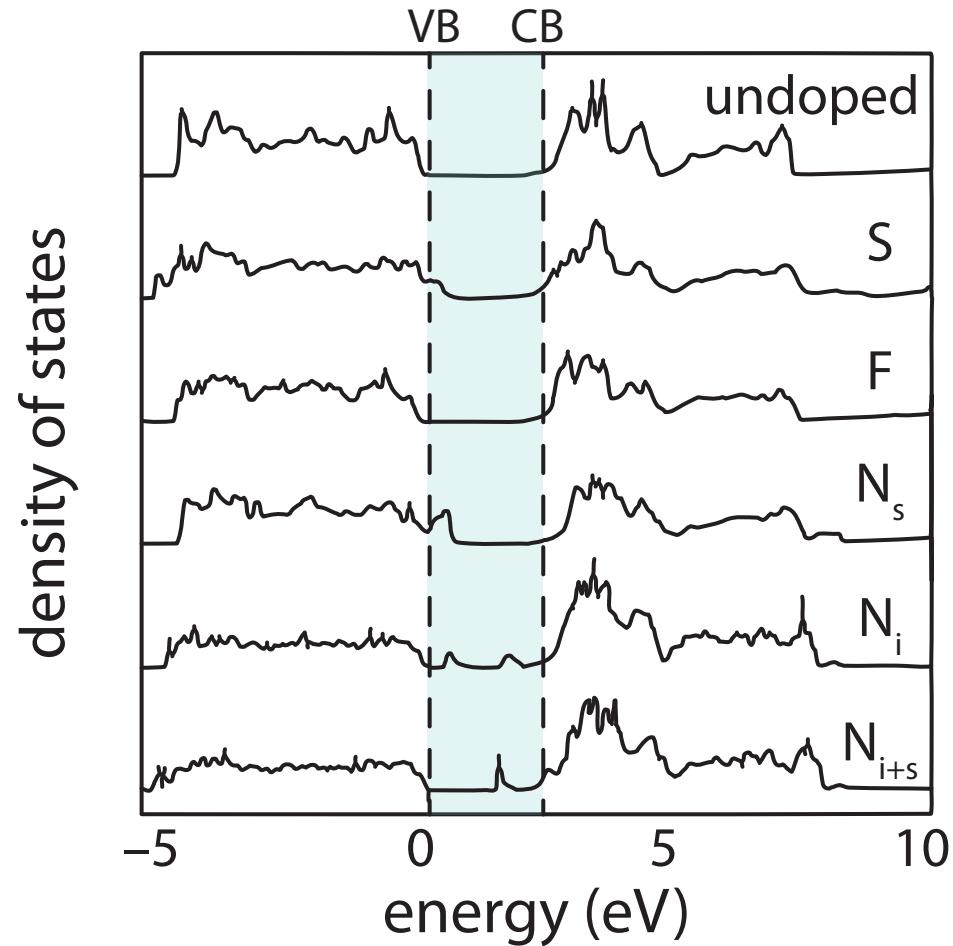
Asahi *et al.*, Science (2003)

1 texturing

2 doping

3 X:TiO<sub>2</sub>

need to create band(s) in gap



Asahi *et al.*, Science (2003)

1 texturing

2 doping

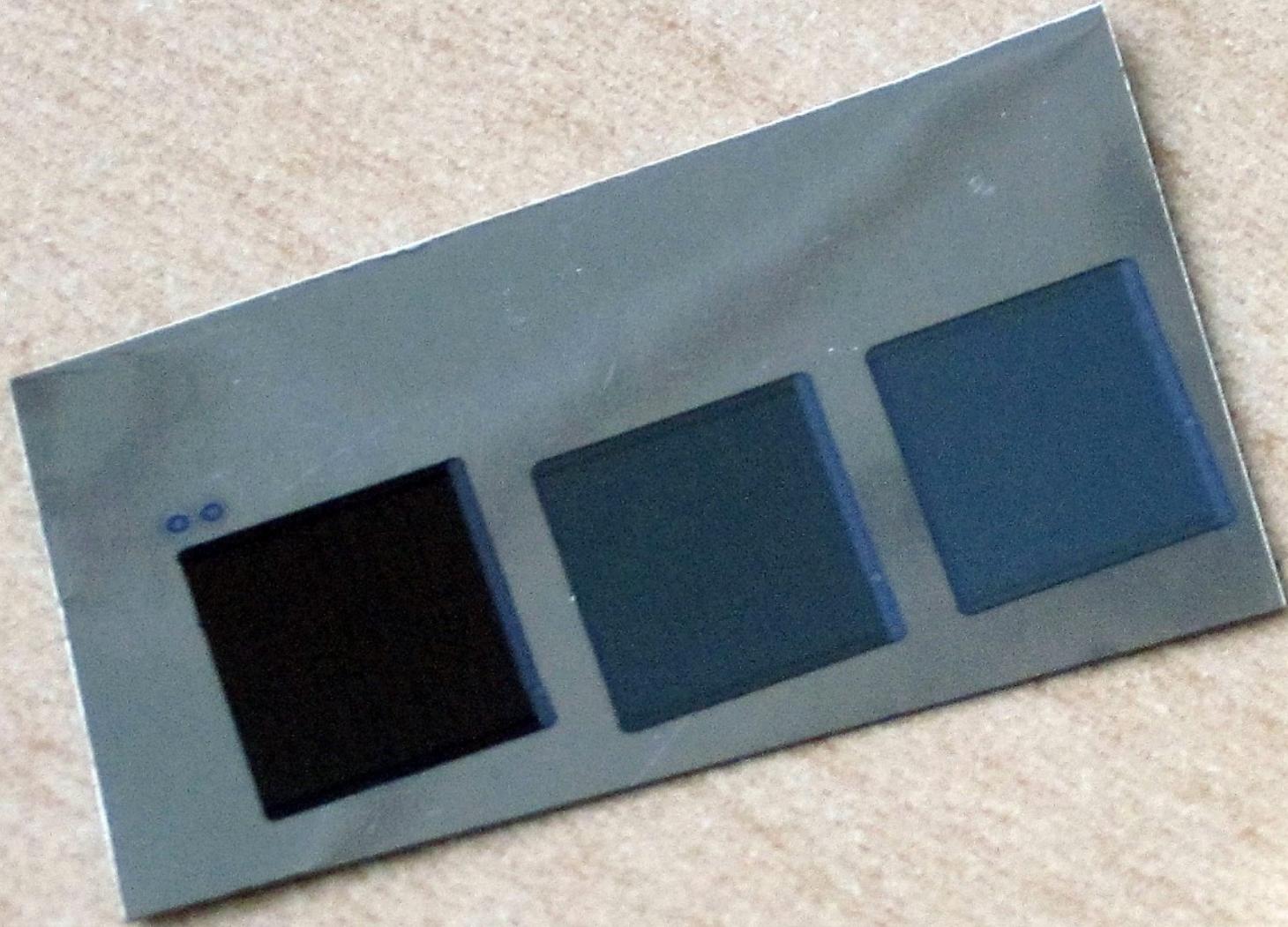
3 X:TiO<sub>2</sub>

**structuring  $\text{TiO}_2$  in  $\text{N}_2$  doesn't work**

**1** texturing

**2** doping

**3** X: $\text{TiO}_2$

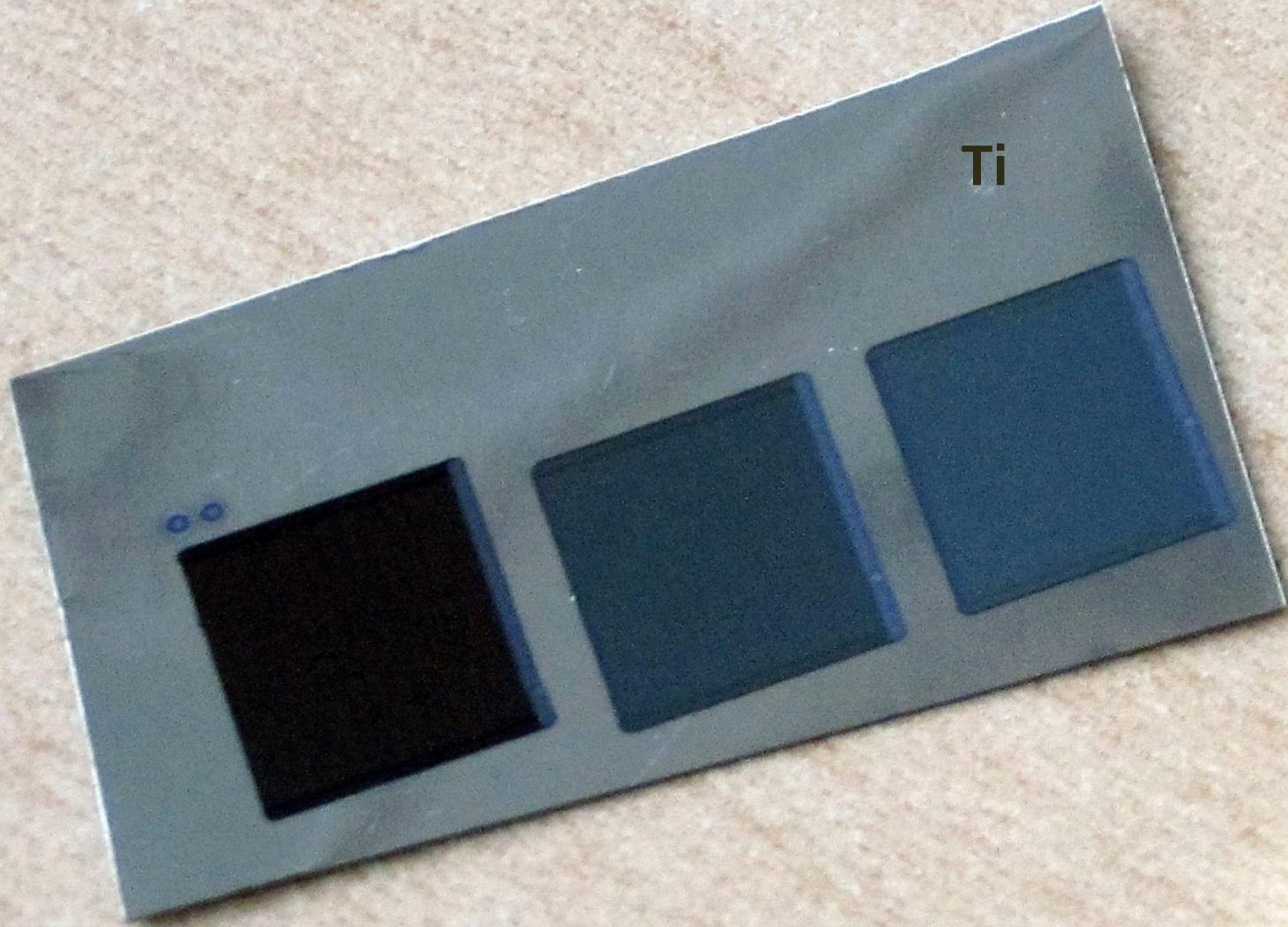


1 texturing

2 doping

3 X: $\text{TiO}_2$

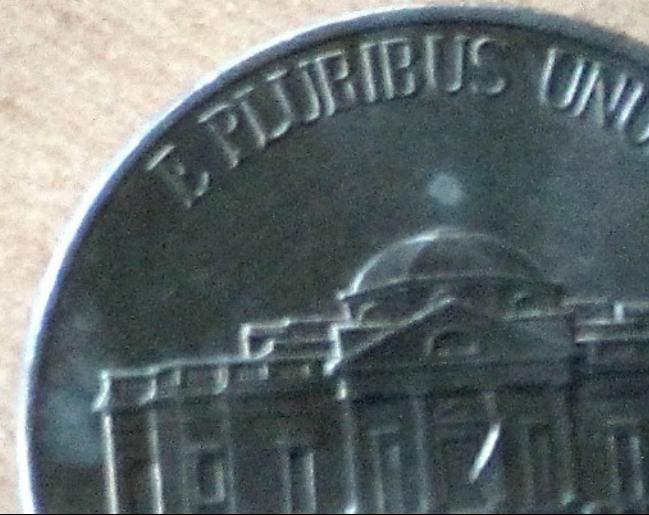


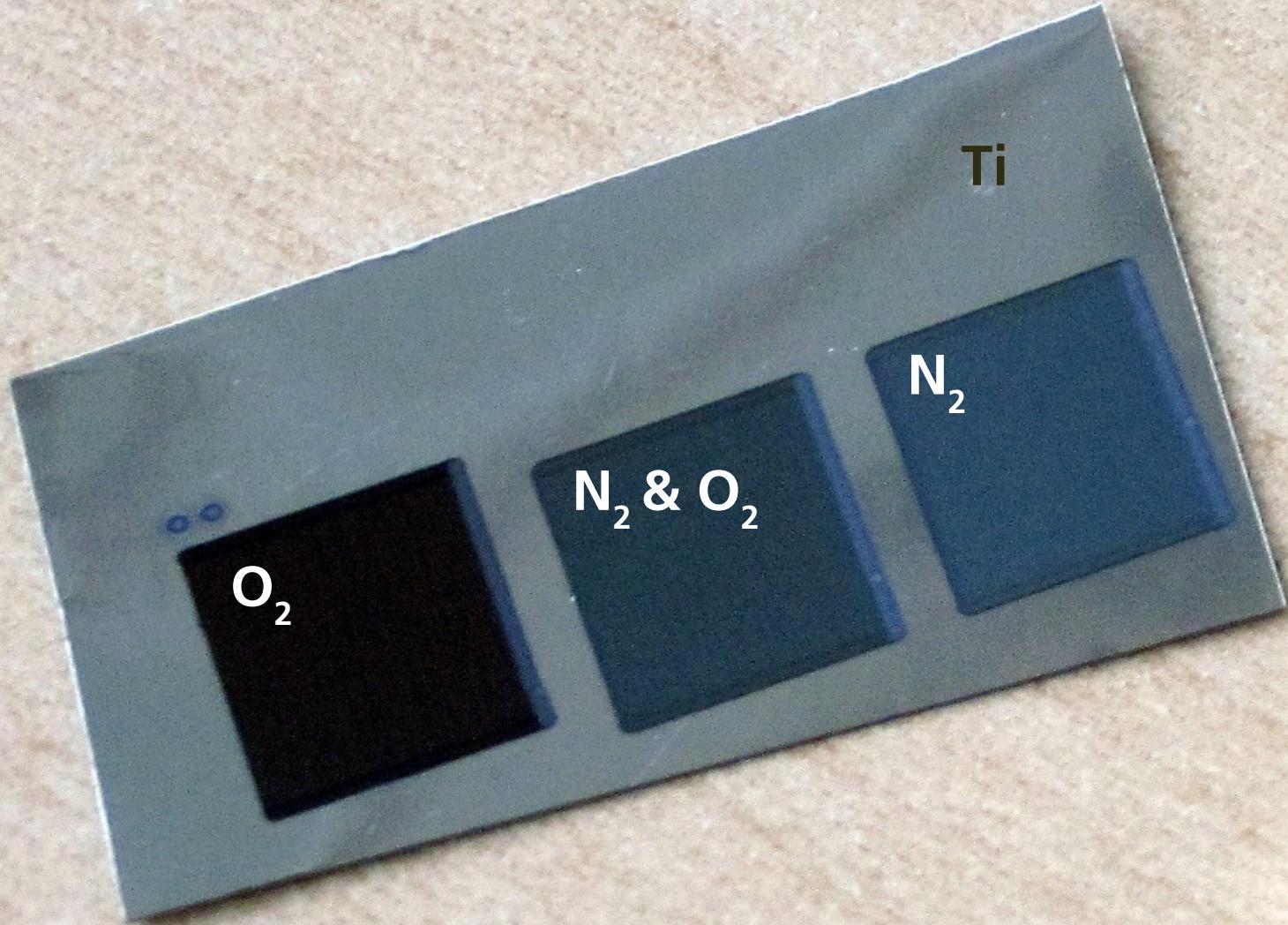


1 texturing

2 doping

3 X:TiO<sub>2</sub>



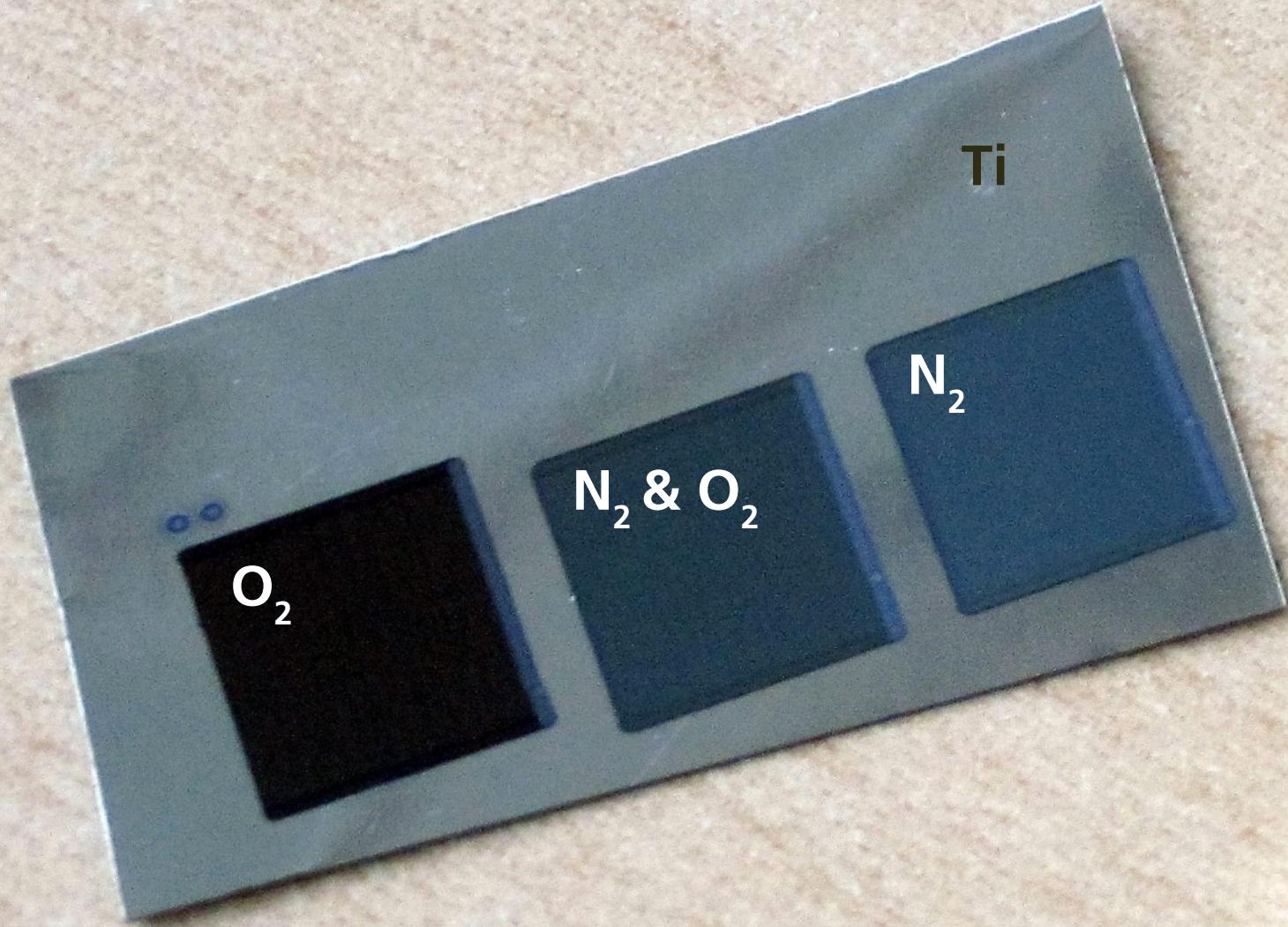


1 texturing

2 doping

3 X:TiO<sub>2</sub>





50 pulses @ 2.5 kJ/m<sup>2</sup>

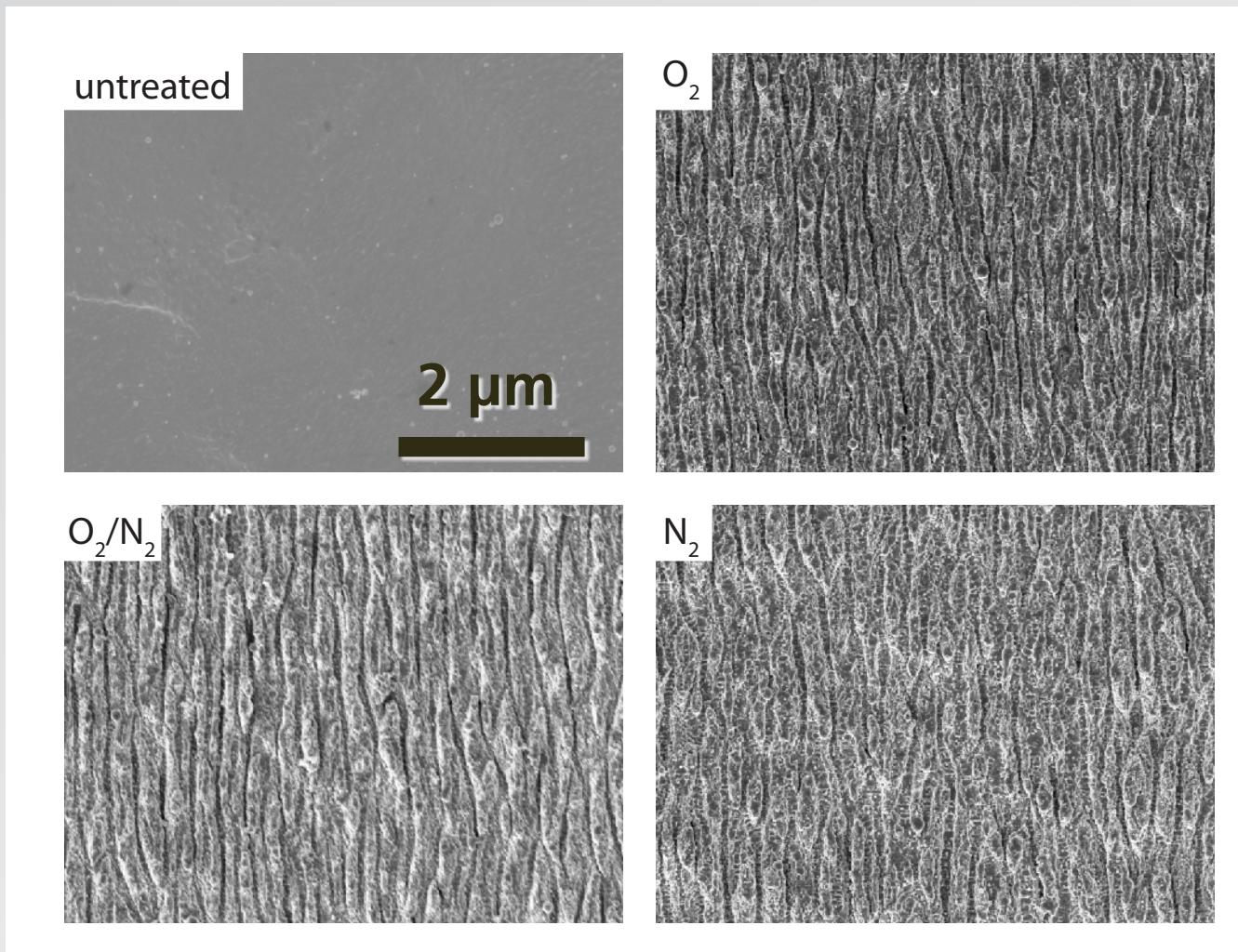
1 texturing

2 doping

3 X:TiO<sub>2</sub>



**50 pulses @ 2.5 kJ/m<sup>2</sup>**

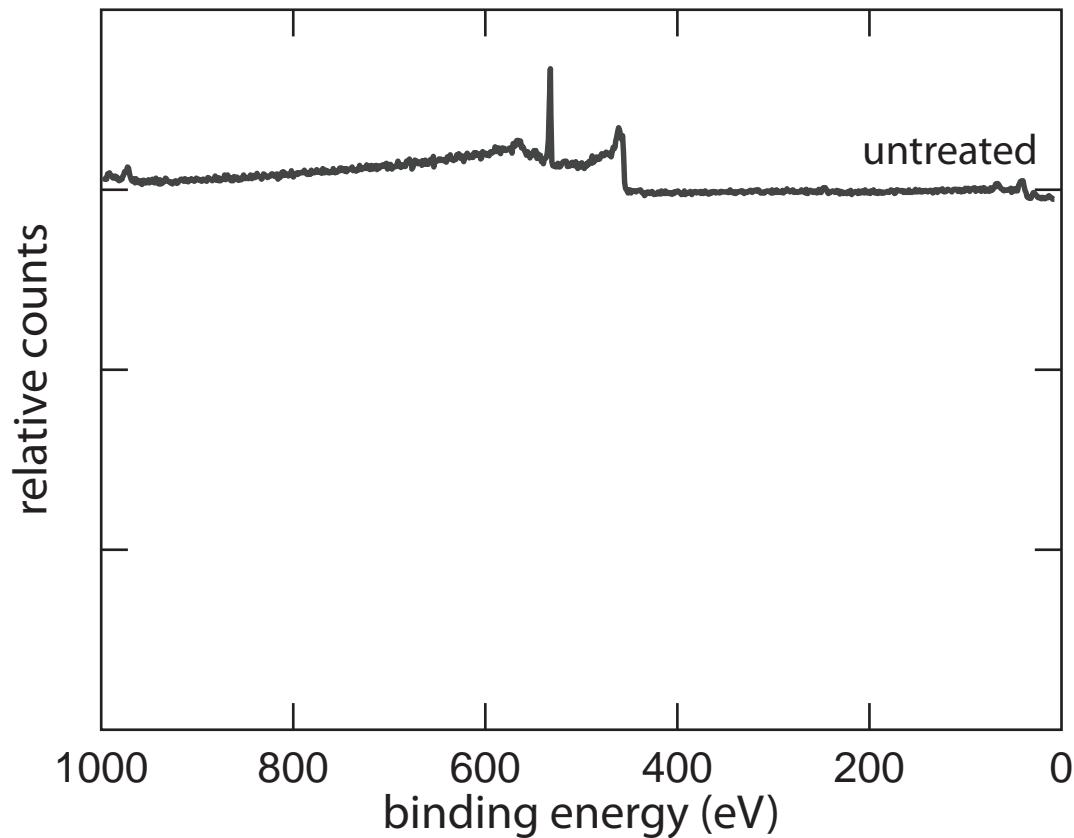


**1** texturing

**2** doping

**3** X:TiO<sub>2</sub>

# X-ray photoelectron spectroscopy

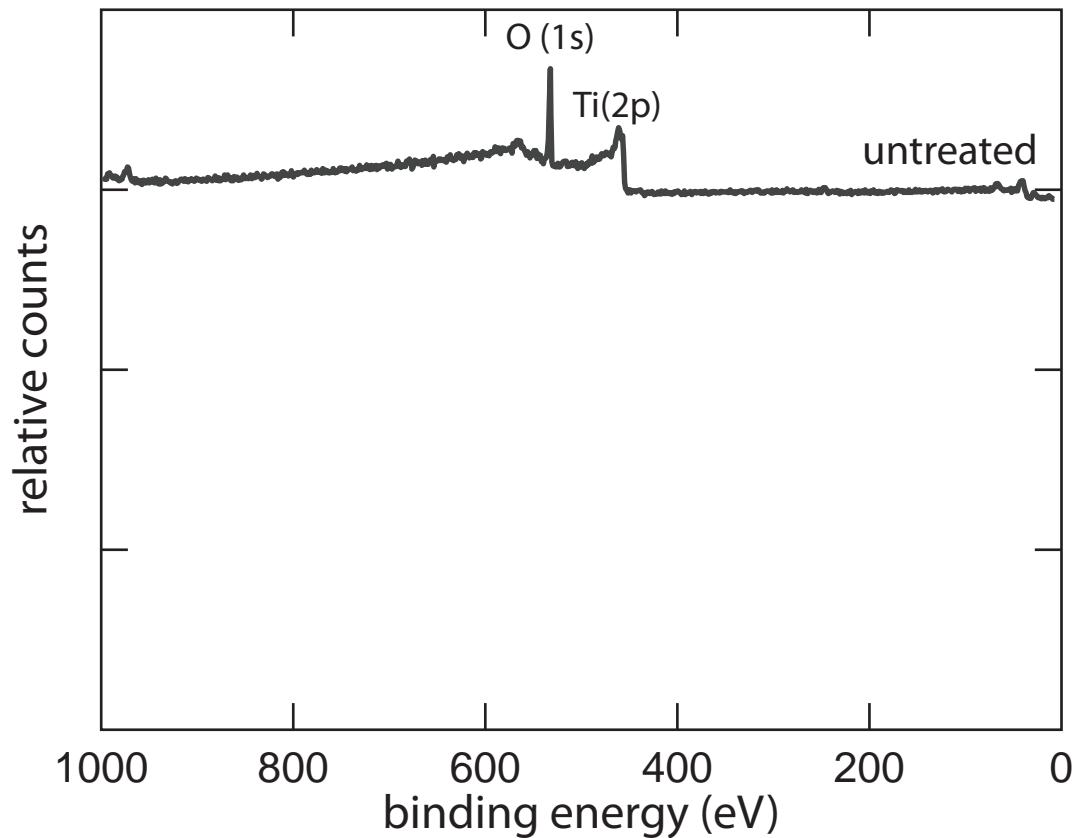


1 texturing

2 doping

3  $\text{X}:\text{TiO}_2$

# X-ray photoelectron spectroscopy

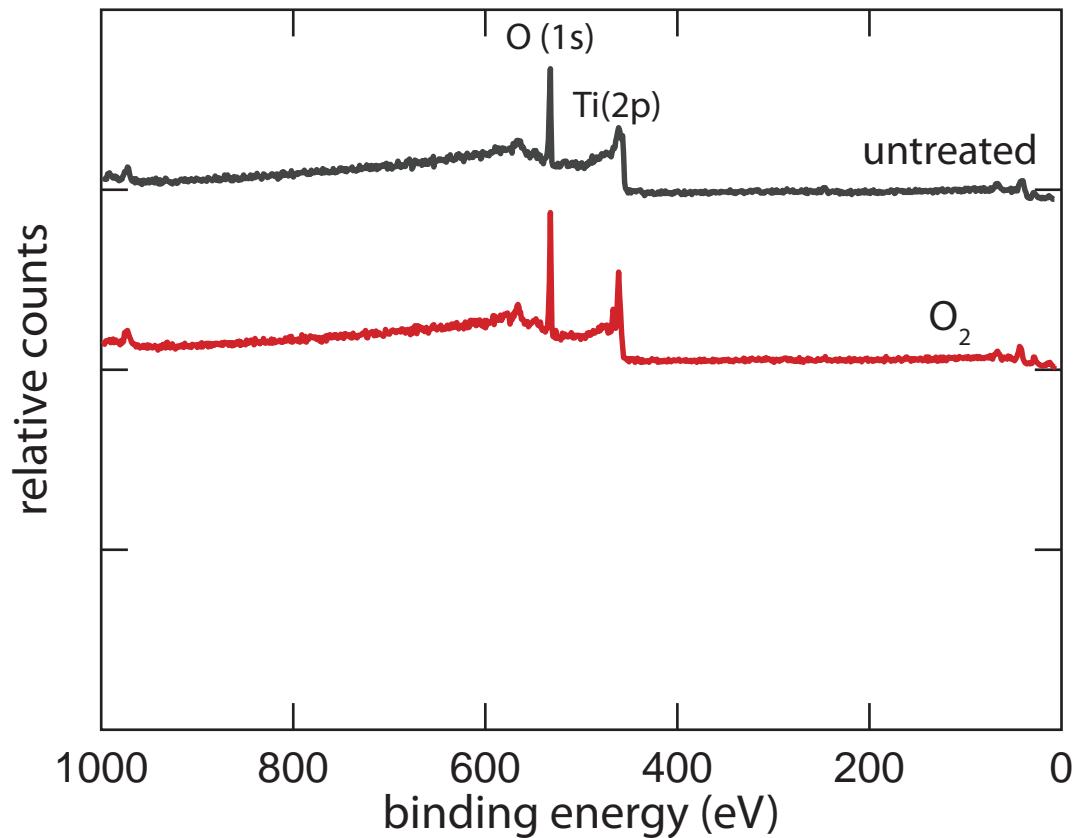


1 texturing

2 doping

3  $\text{X}:\text{TiO}_2$

# X-ray photoelectron spectroscopy

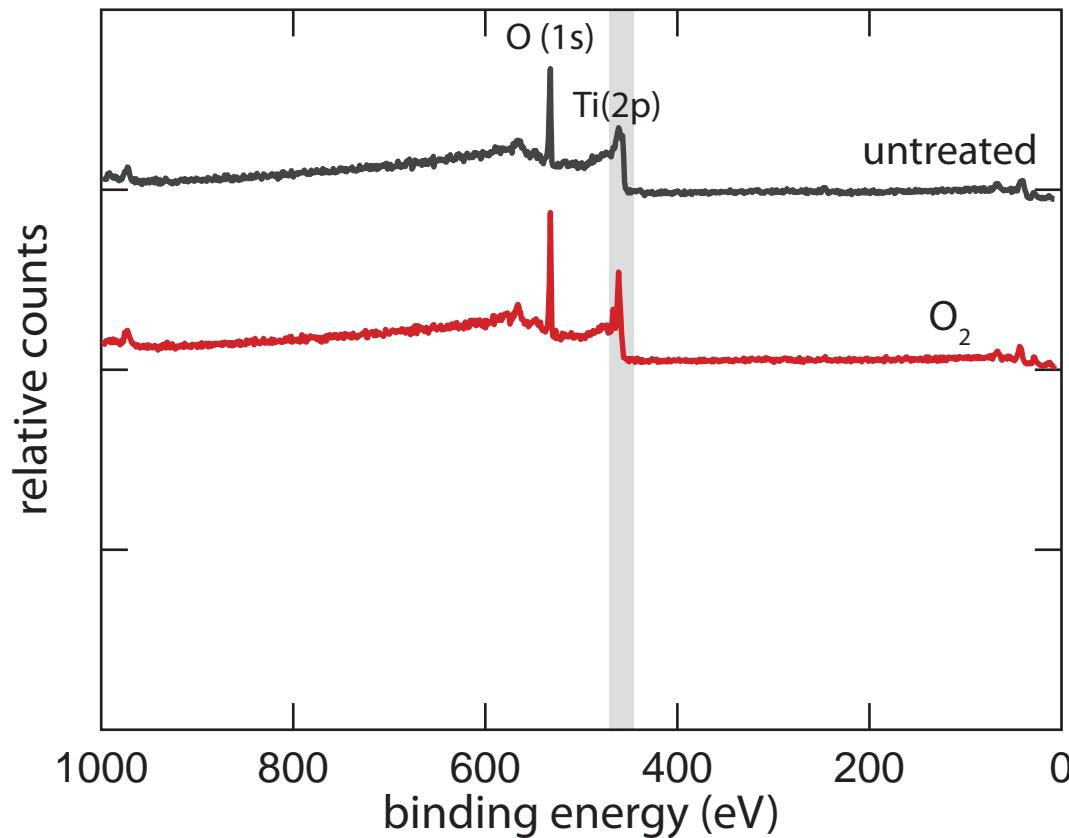


1 texturing

2 doping

3 X:TiO<sub>2</sub>

# X-ray photoelectron spectroscopy

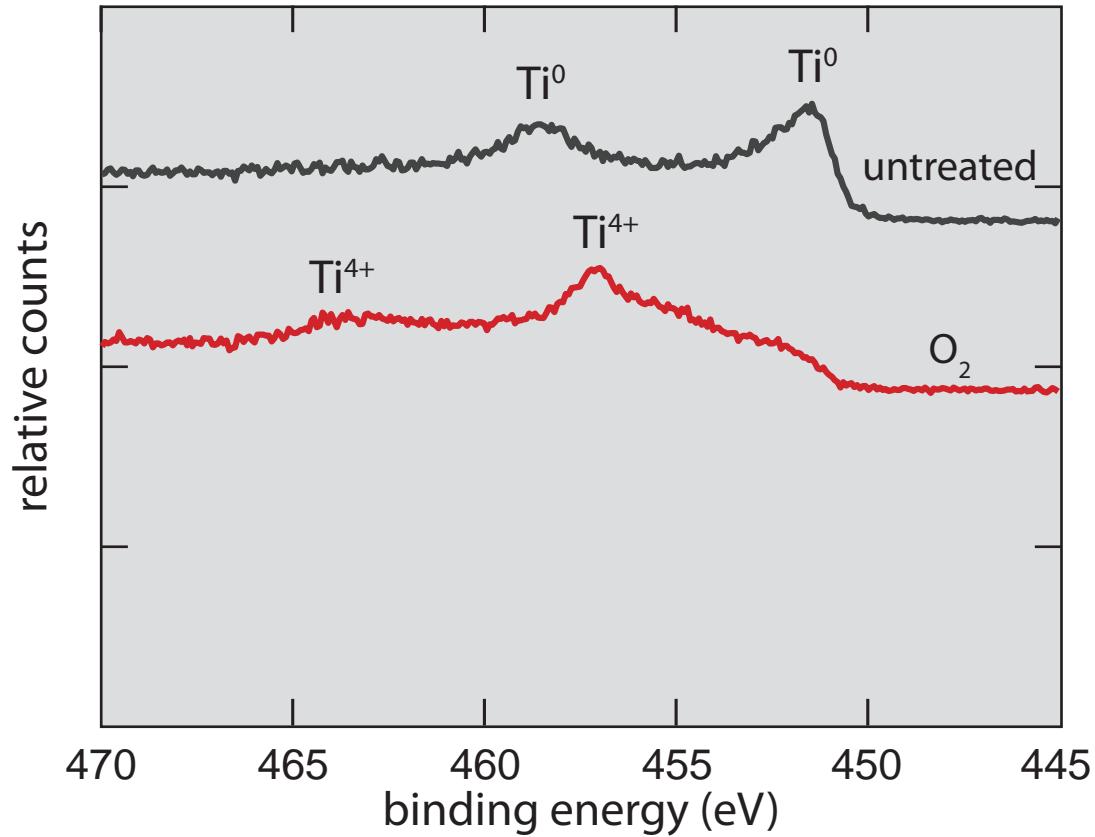


1 texturing

2 doping

3  $X:\text{TiO}_2$

**oxygen is incorporated!**

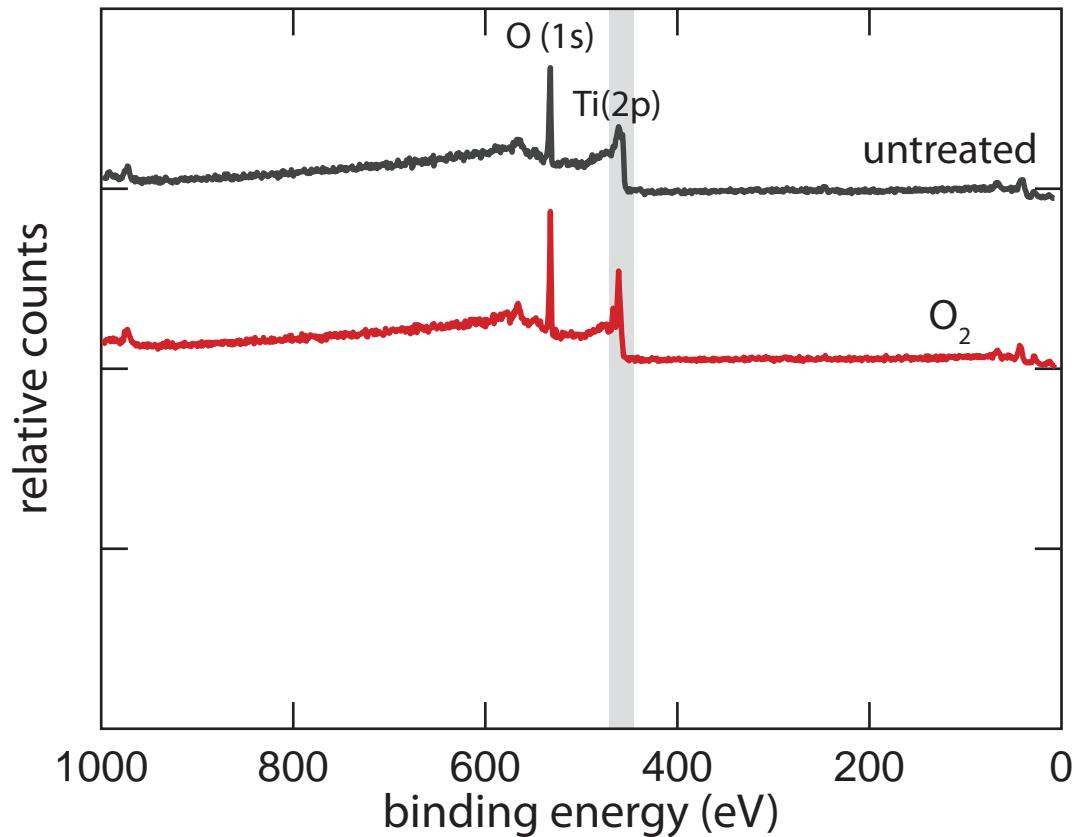


1 texturing

2 doping

3 X:TiO<sub>2</sub>

**oxygen is incorporated!**

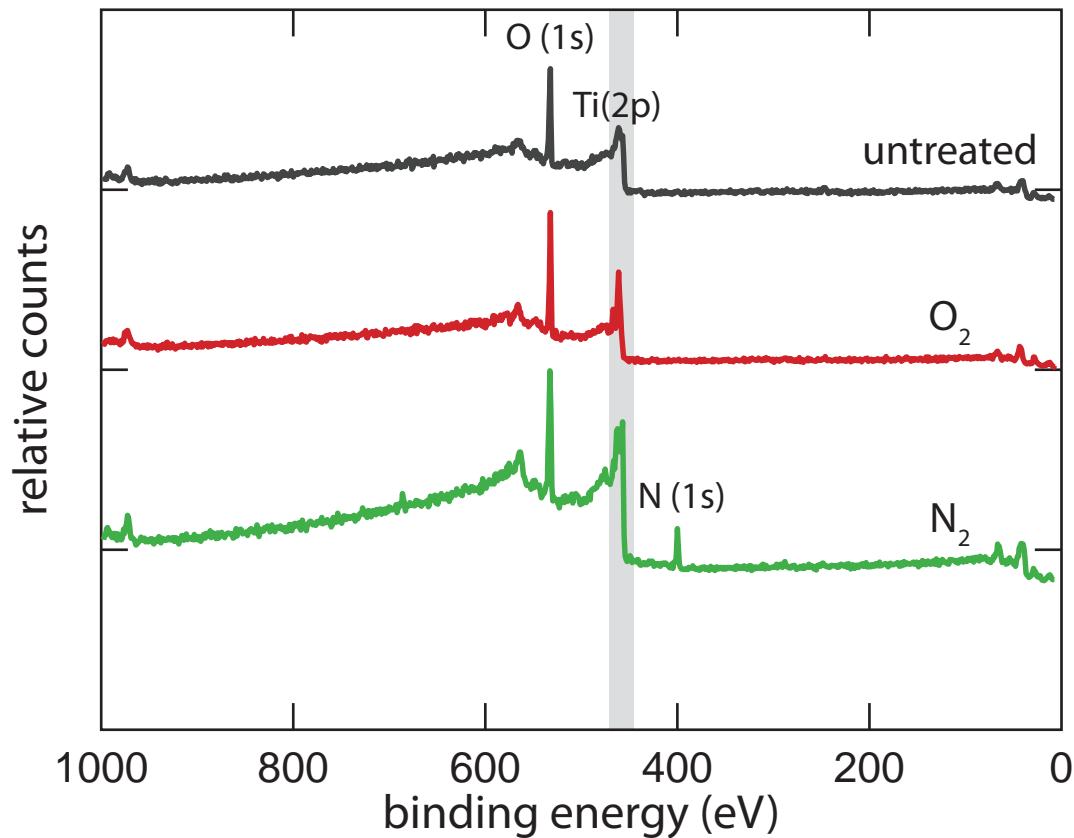


1 texturing

2 doping

3 X:TiO<sub>2</sub>

**nitrogen peak appears...**

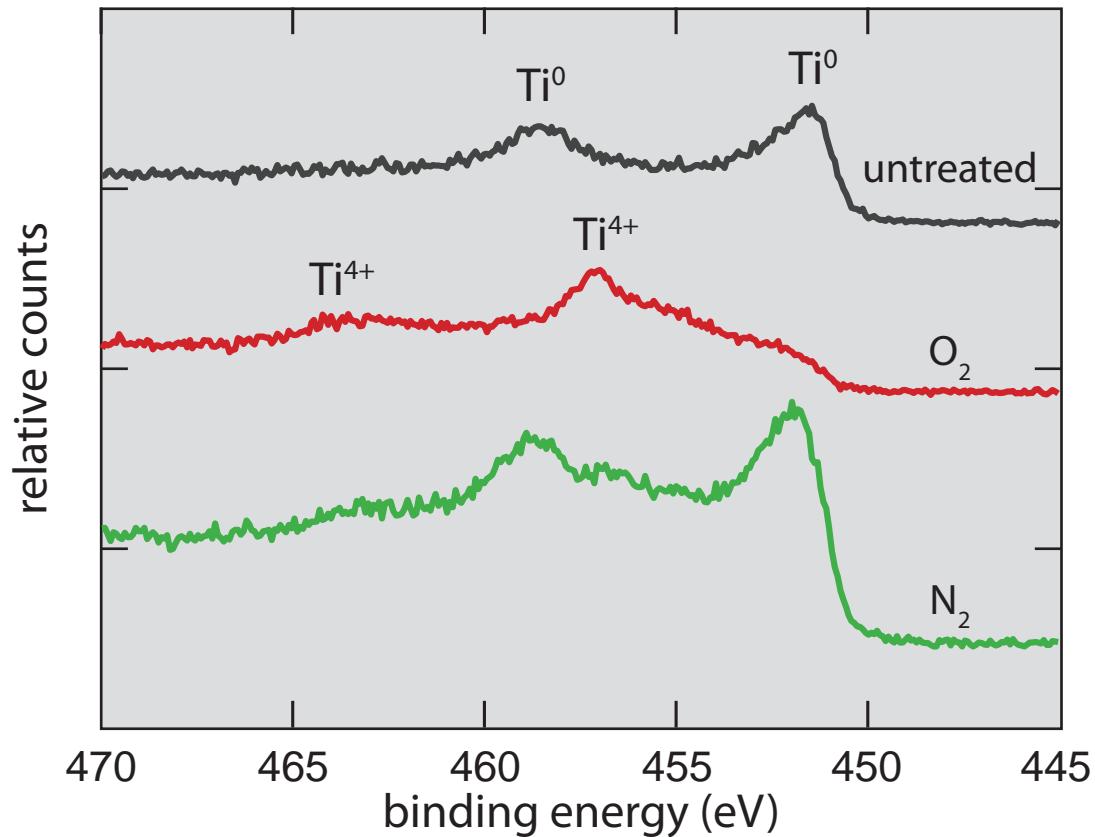


**1** texturing

**2** doping

**3**  $X:\text{TiO}_2$

... but nitrogen not chemically incorporated

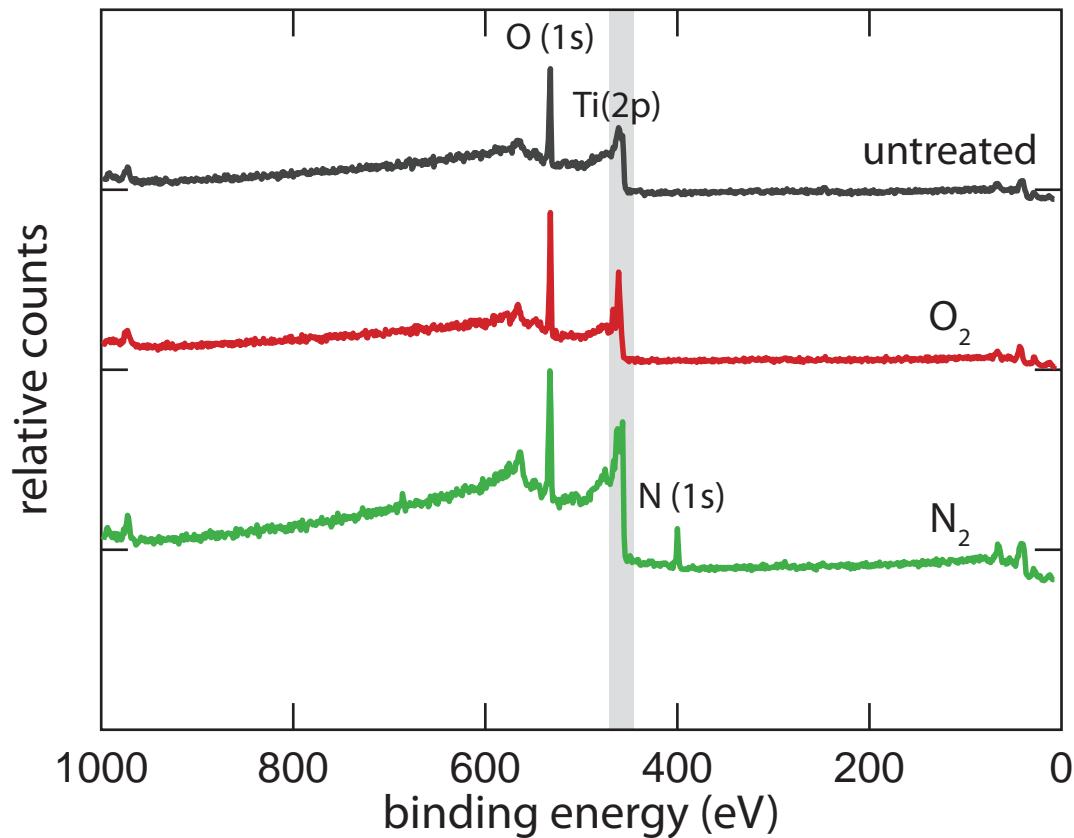


1 texturing

2 doping

3  $\text{X}:\text{TiO}_2$

... but nitrogen not chemically incorporated

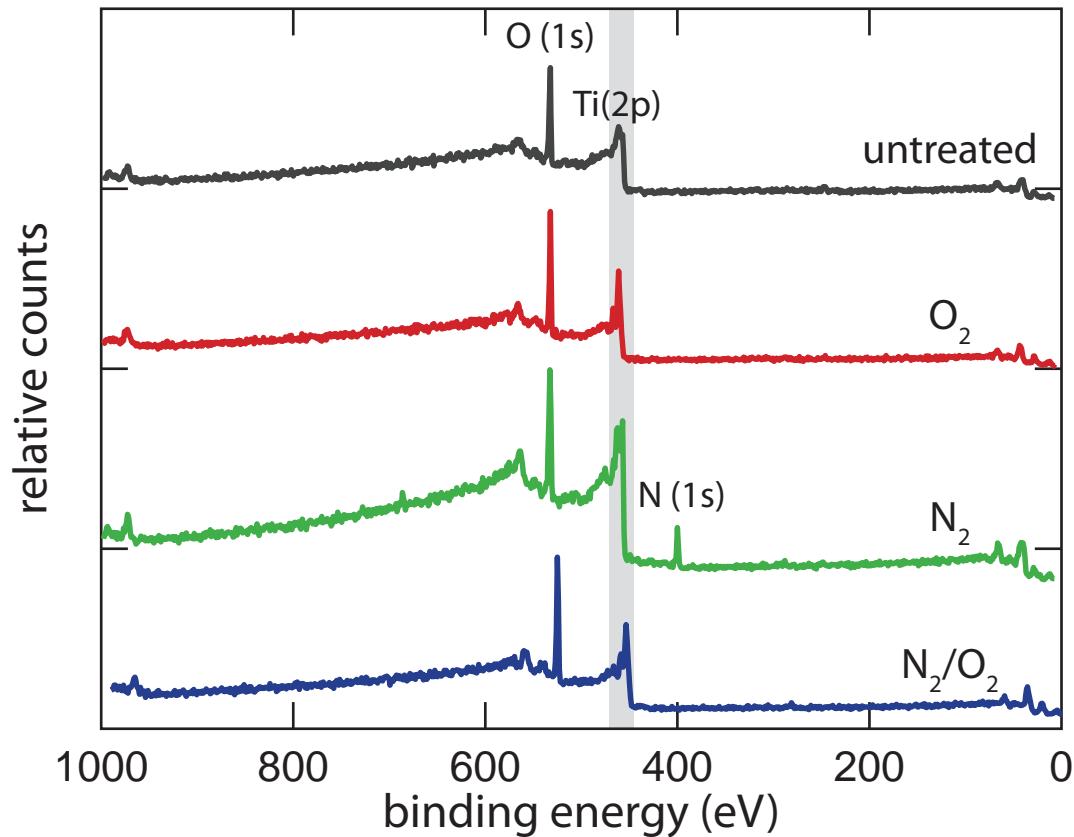


1 texturing

2 doping

3 X:TiO<sub>2</sub>

with both nitrogen and oxygen...

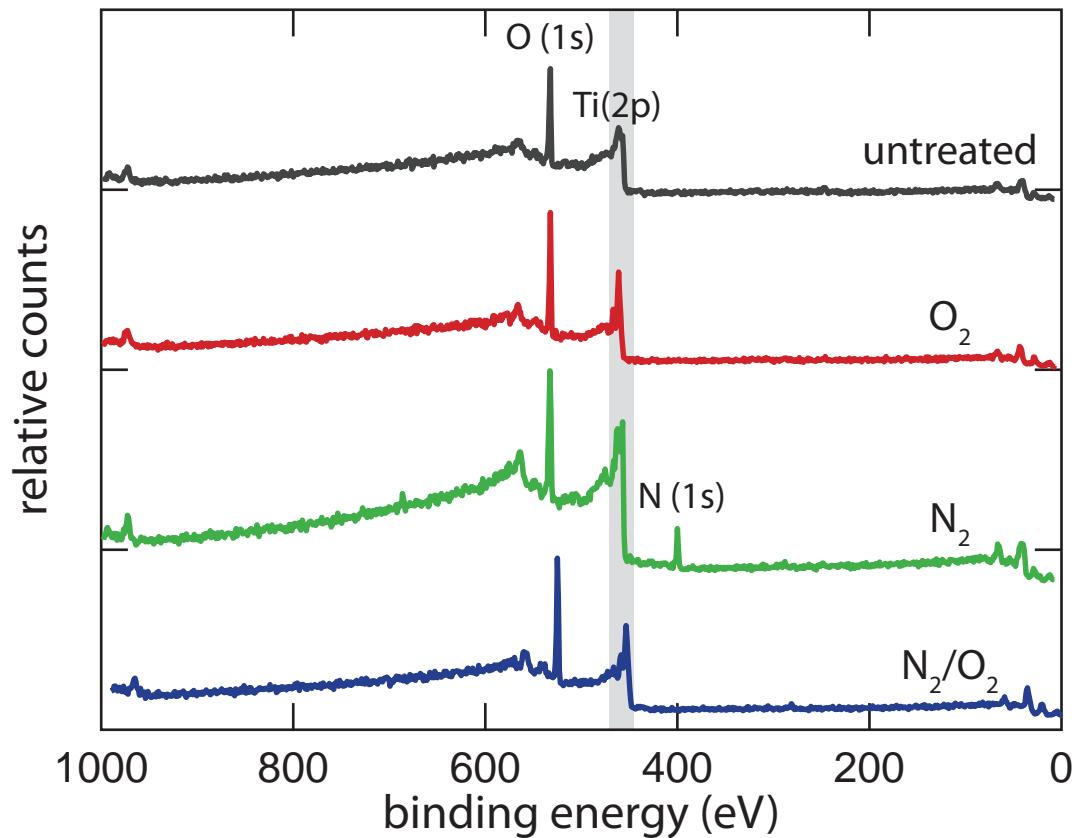


1 texturing

2 doping

3 X:TiO<sub>2</sub>

... just 1% of oxygen prevents nitrogen incorporation...

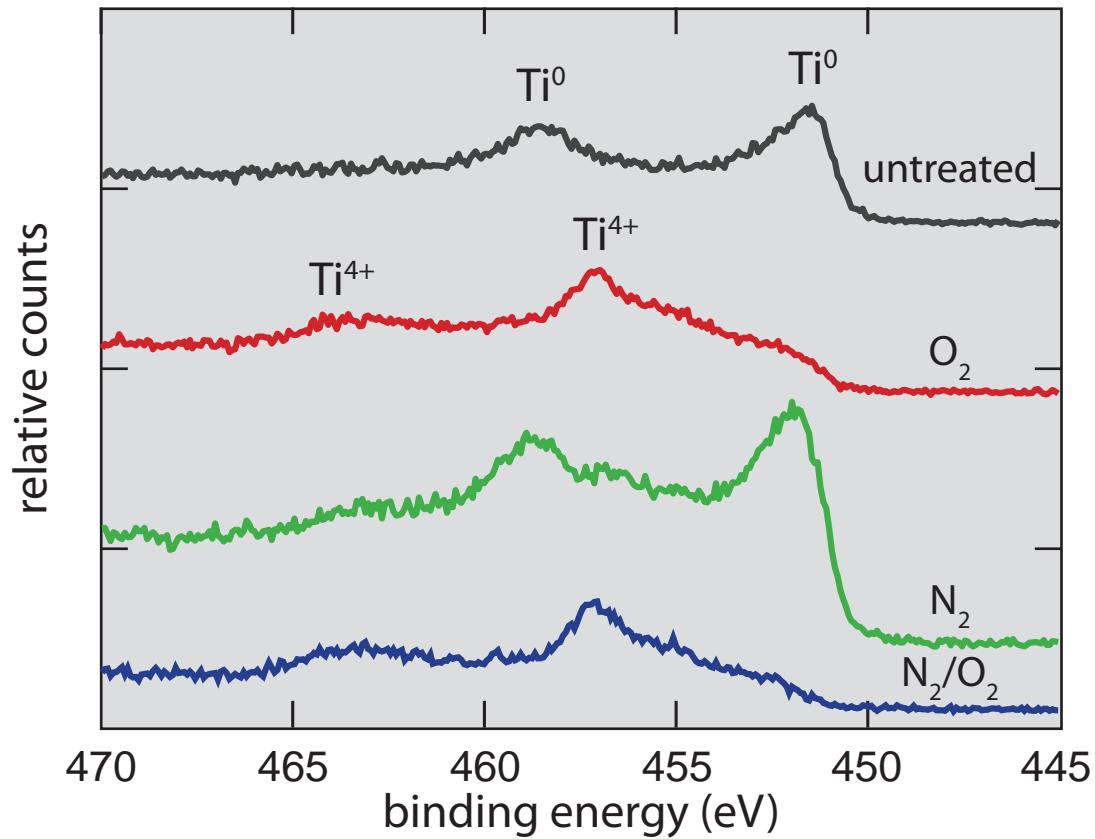


1 texturing

2 doping

3 X:TiO<sub>2</sub>

... although oxygen is incorporated



1 texturing

2 doping

3  $\text{X}:\text{TiO}_2$

**can get  $N_2$  or  $O_2$  incorporated, but not both**

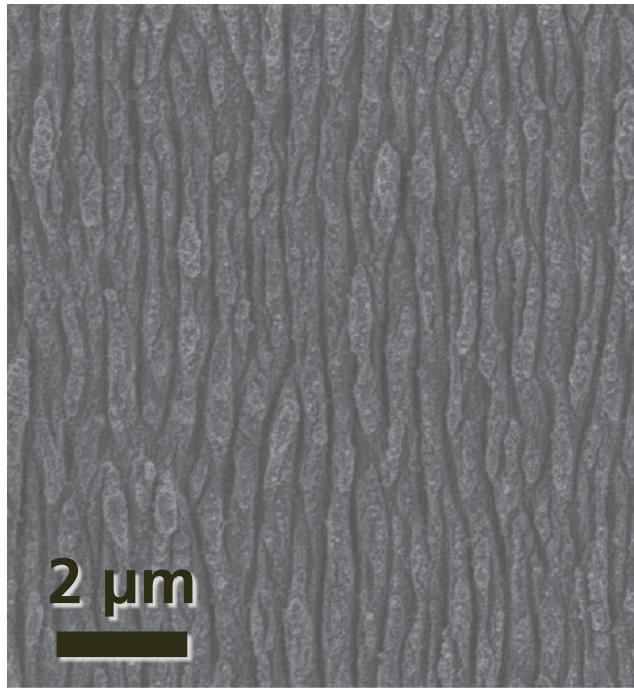
**1** texturing

**2** doping

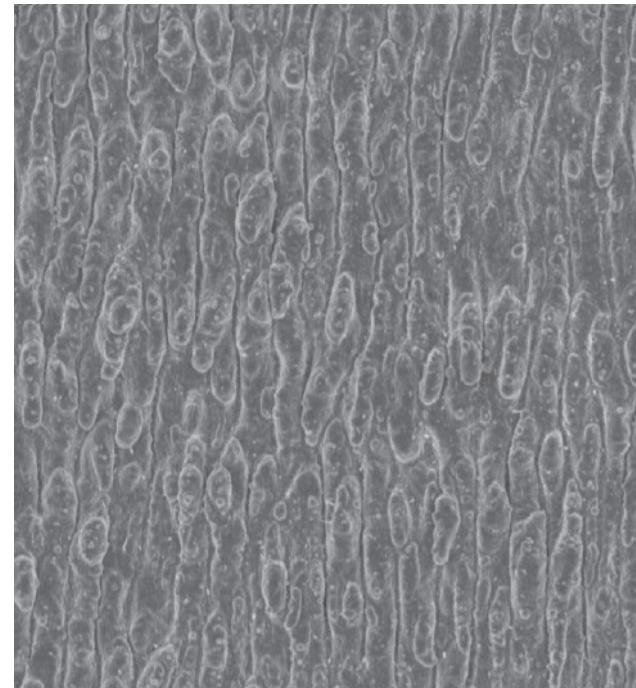
**3** X: $TiO_2$

anneal N:Ti sample in O<sub>2</sub> (1h @ 900 K)

before annealing



after annealing

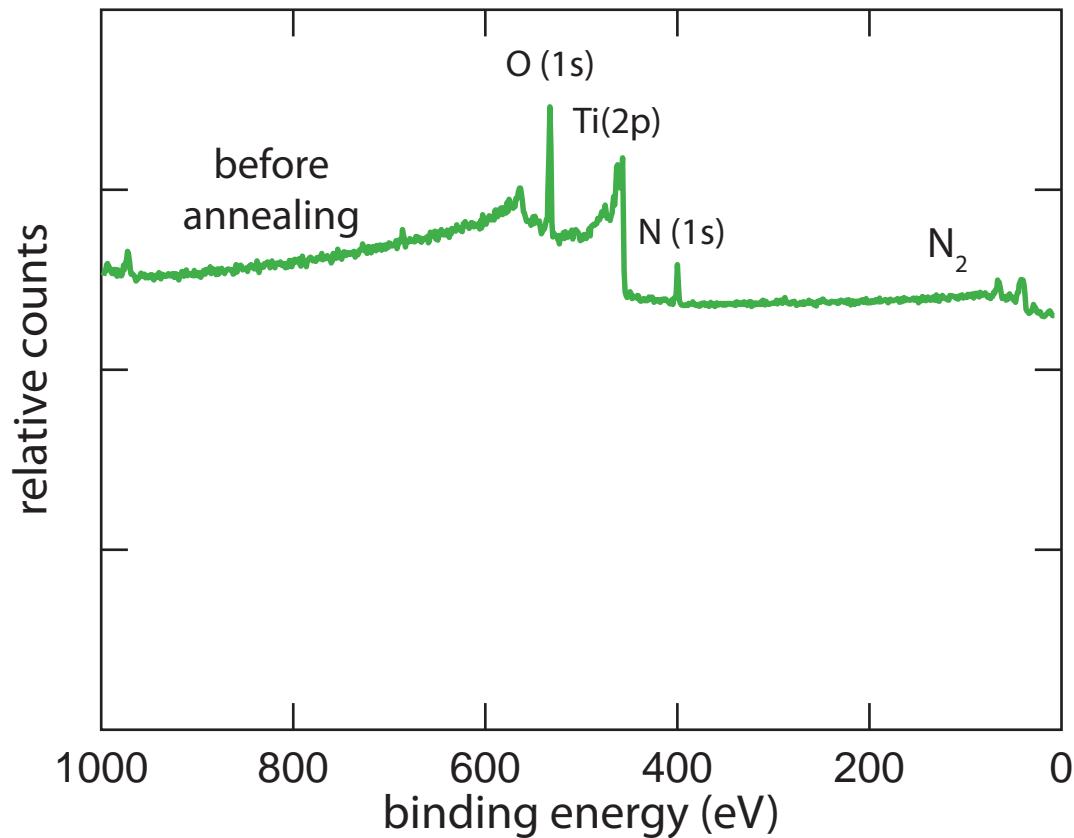


1 texturing

2 doping

3 X:TiO<sub>2</sub>

## anneal N:Ti sample in O<sub>2</sub> (1h @ 900 K)

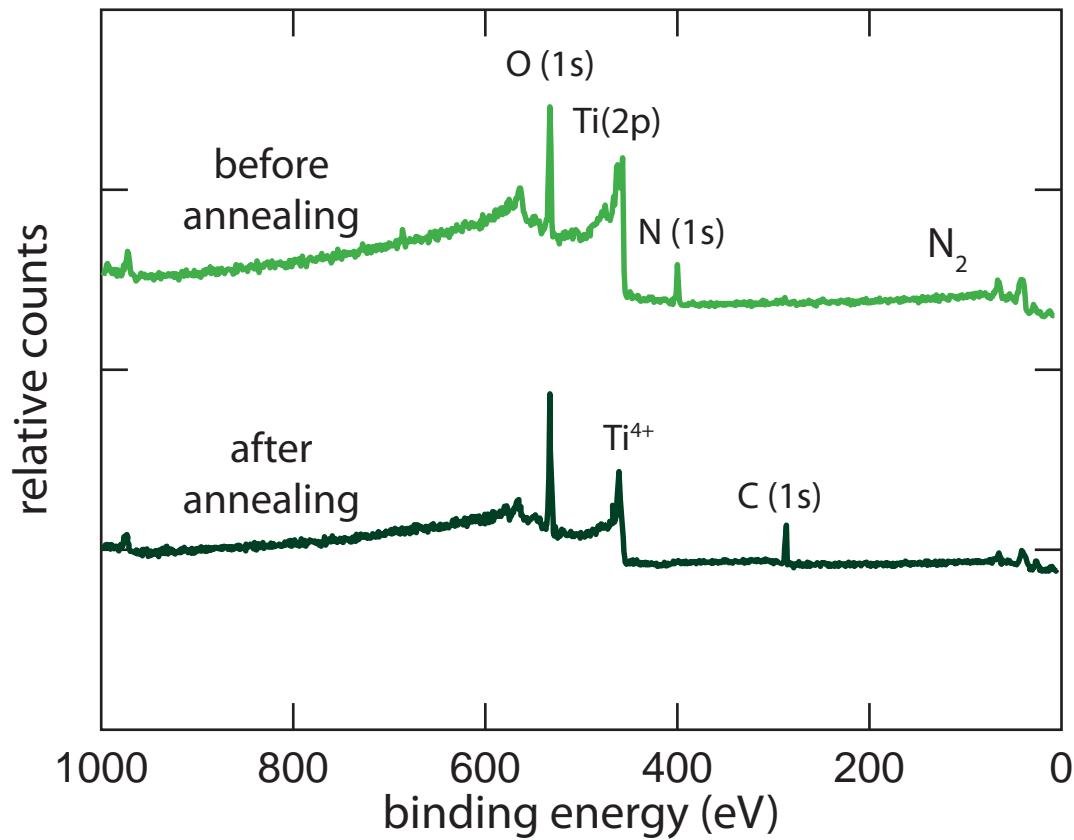


1 texturing

2 doping

3 X:TiO<sub>2</sub>

...nitrogen anneals out...

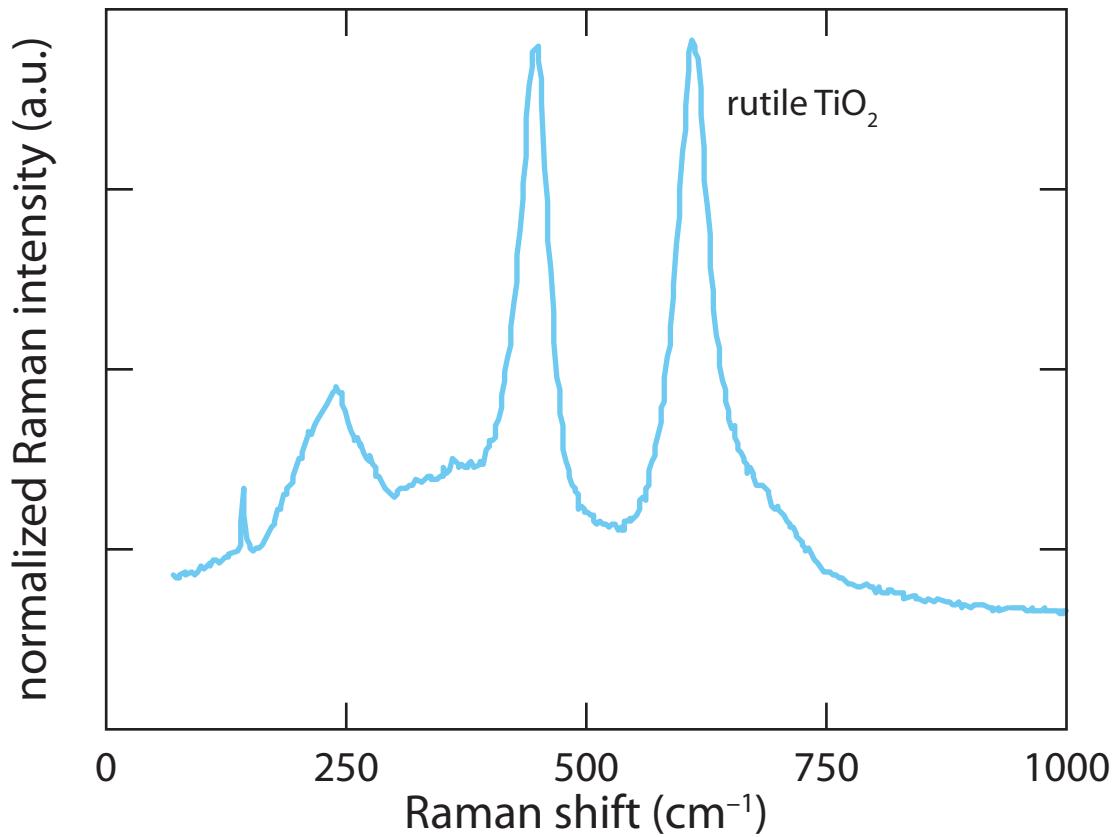


1 texturing

2 doping

3 X:TiO<sub>2</sub>

**...but Raman spectrum shows  $\text{TiO}_2$  is formed**

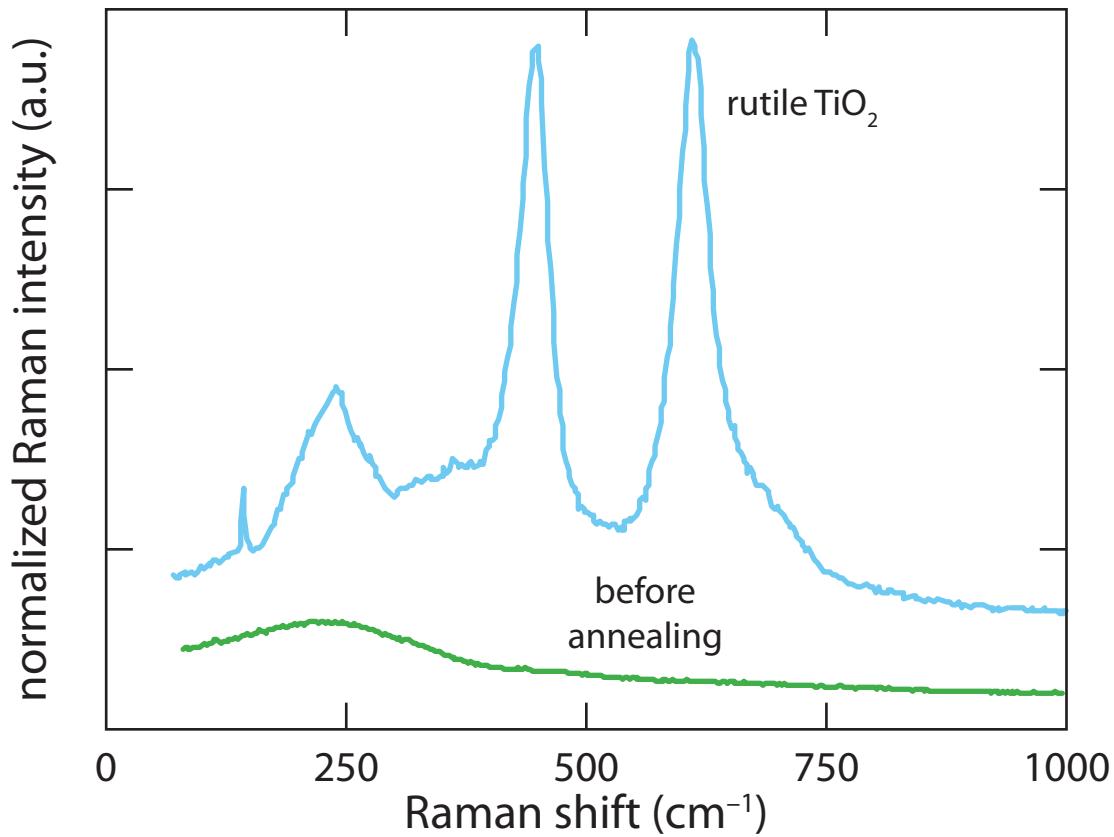


**1** texturing

**2** doping

**3** X: $\text{TiO}_2$

**...but Raman spectrum shows  $\text{TiO}_2$  is formed**

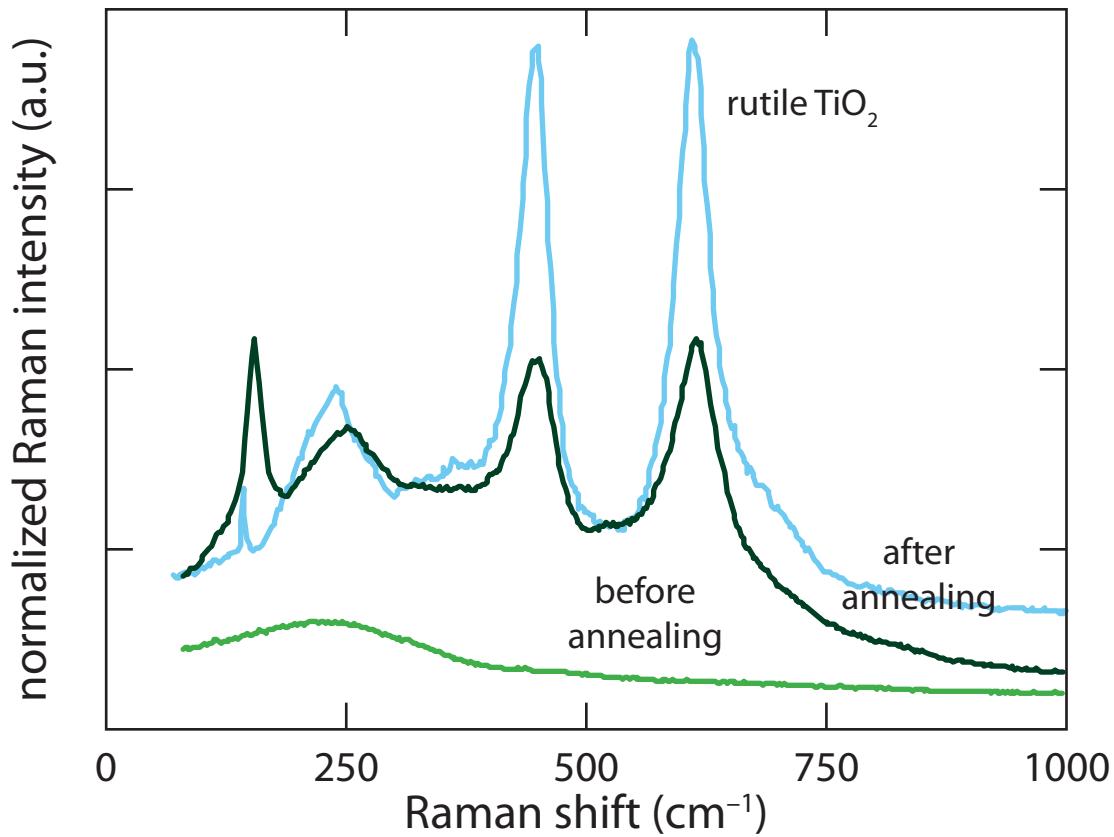


**1** texturing

**2** doping

**3** X: $\text{TiO}_2$

**...but Raman spectrum shows  $\text{TiO}_2$  is formed**



1 texturing

2 doping

3 X: $\text{TiO}_2$

# how about incorporating chromium with oxygen?



Ti

1 texturing

2 doping

3 X:TiO<sub>2</sub>

**evaporate 10 – 70 nm chromium on titanium...**

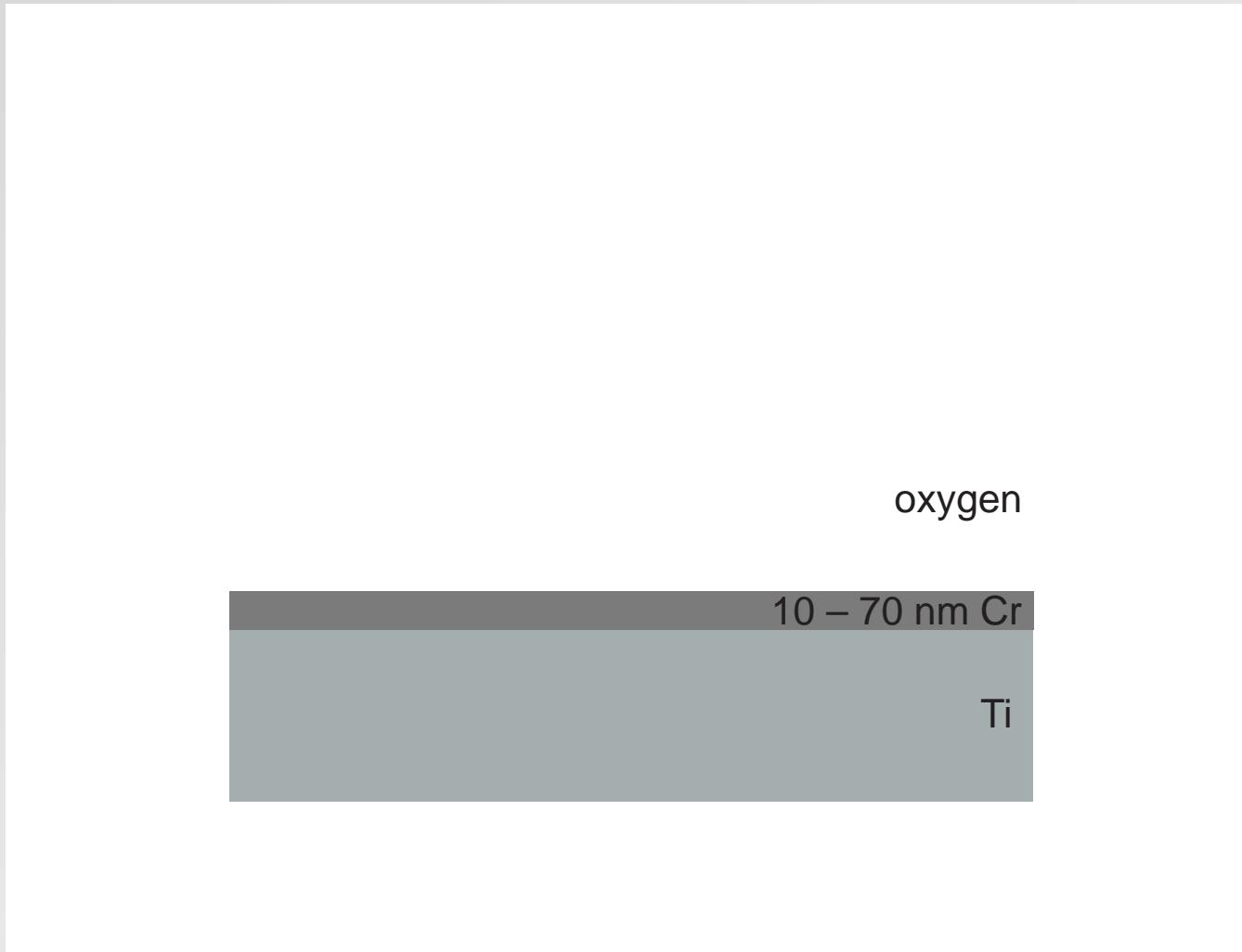


**1** texturing

**2** doping

**3** X:TiO<sub>2</sub>

**...place in oxygen atmosphere...**

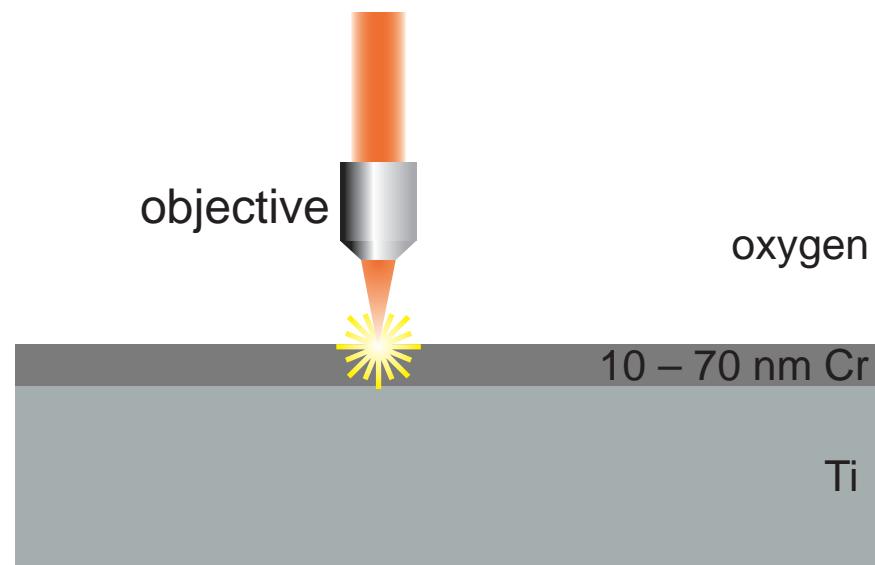


**1** texturing

**2** doping

**3** X:TiO<sub>2</sub>

...irradiate with laser...



1 texturing

2 doping

3 X:TiO<sub>2</sub>

**...and raster scan to structure**



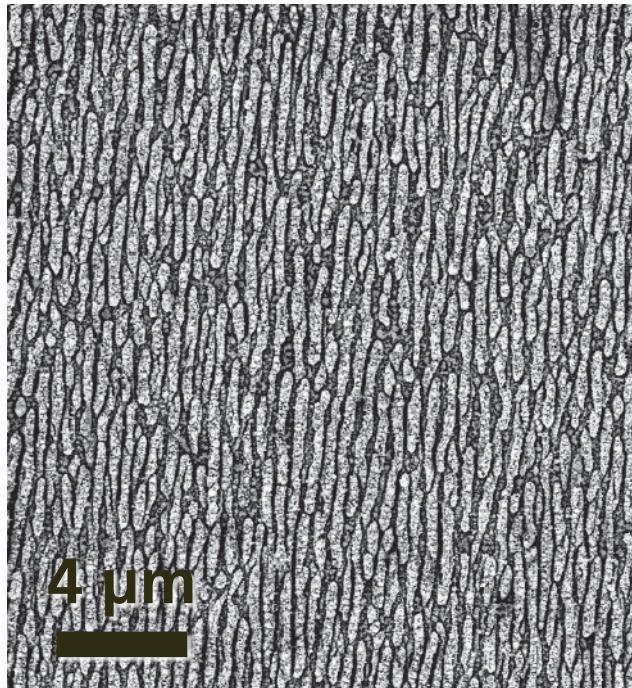
**1** texturing

**2** doping

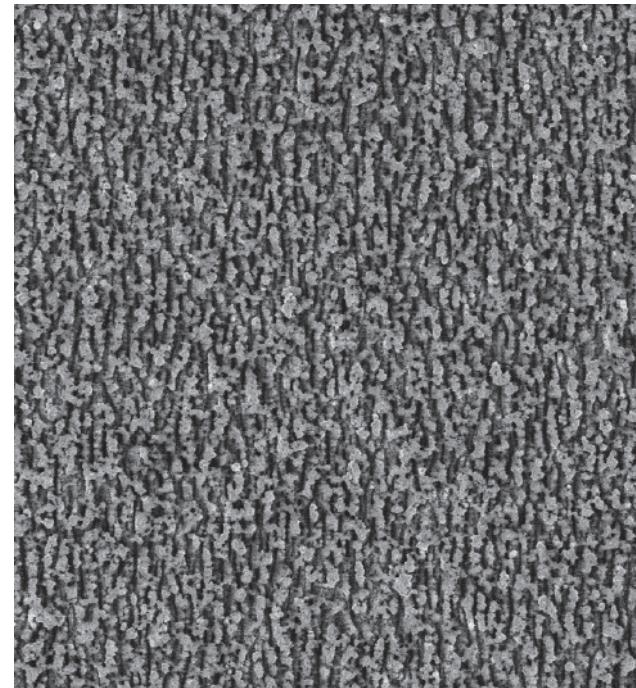
**3** X:TiO<sub>2</sub>

# titanium/chromium in oxygen

titanium only



titanium/chromium

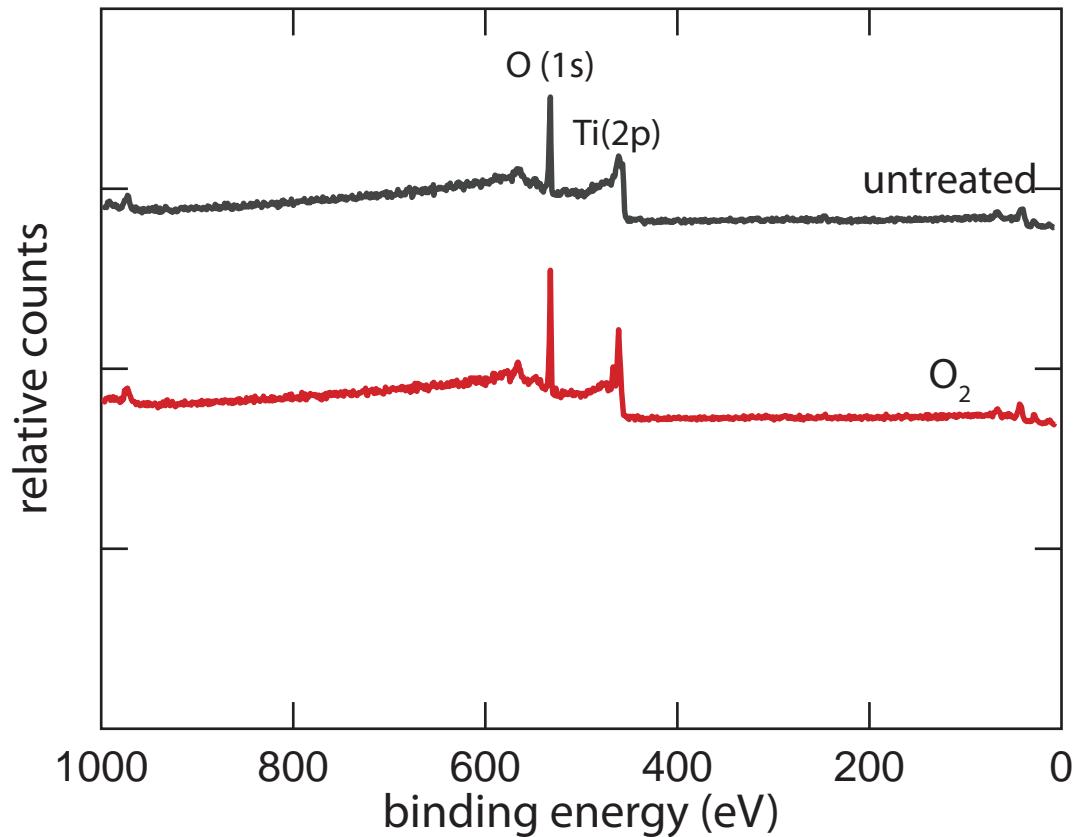


1 texturing

2 doping

3 X: $\text{TiO}_2$

# X-ray photoelectron spectroscopy

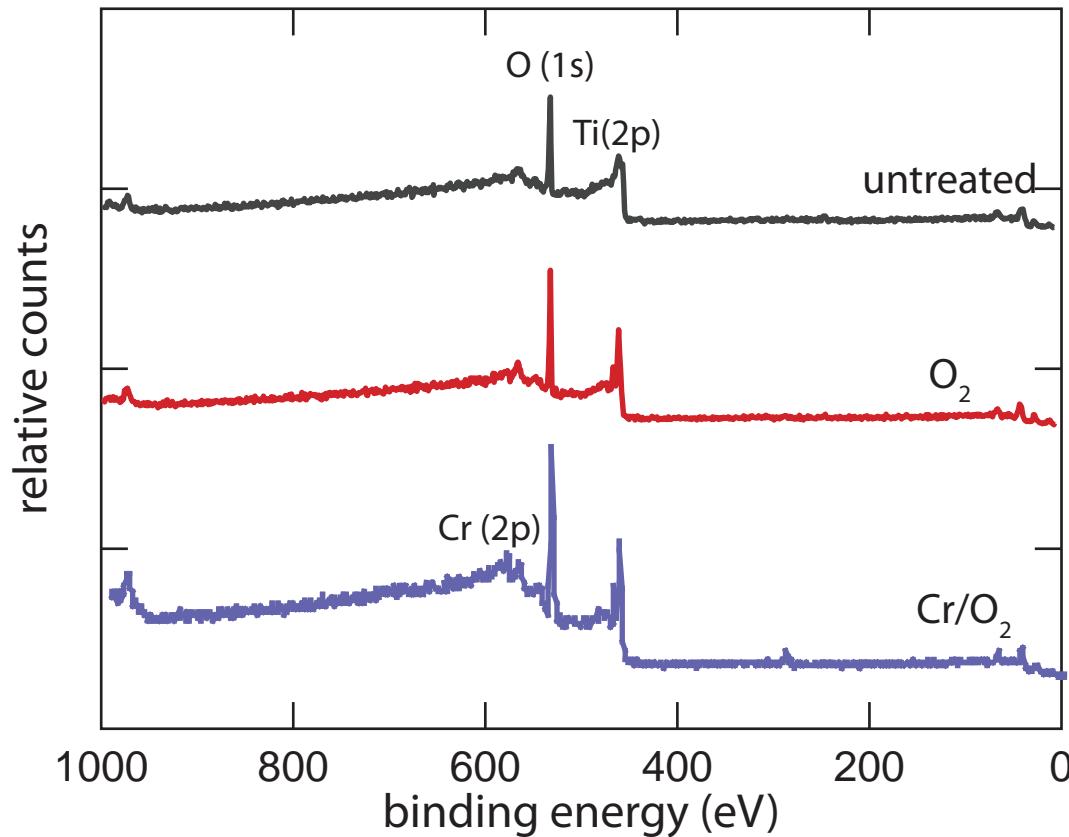


1 texturing

2 doping

3 X:TiO<sub>2</sub>

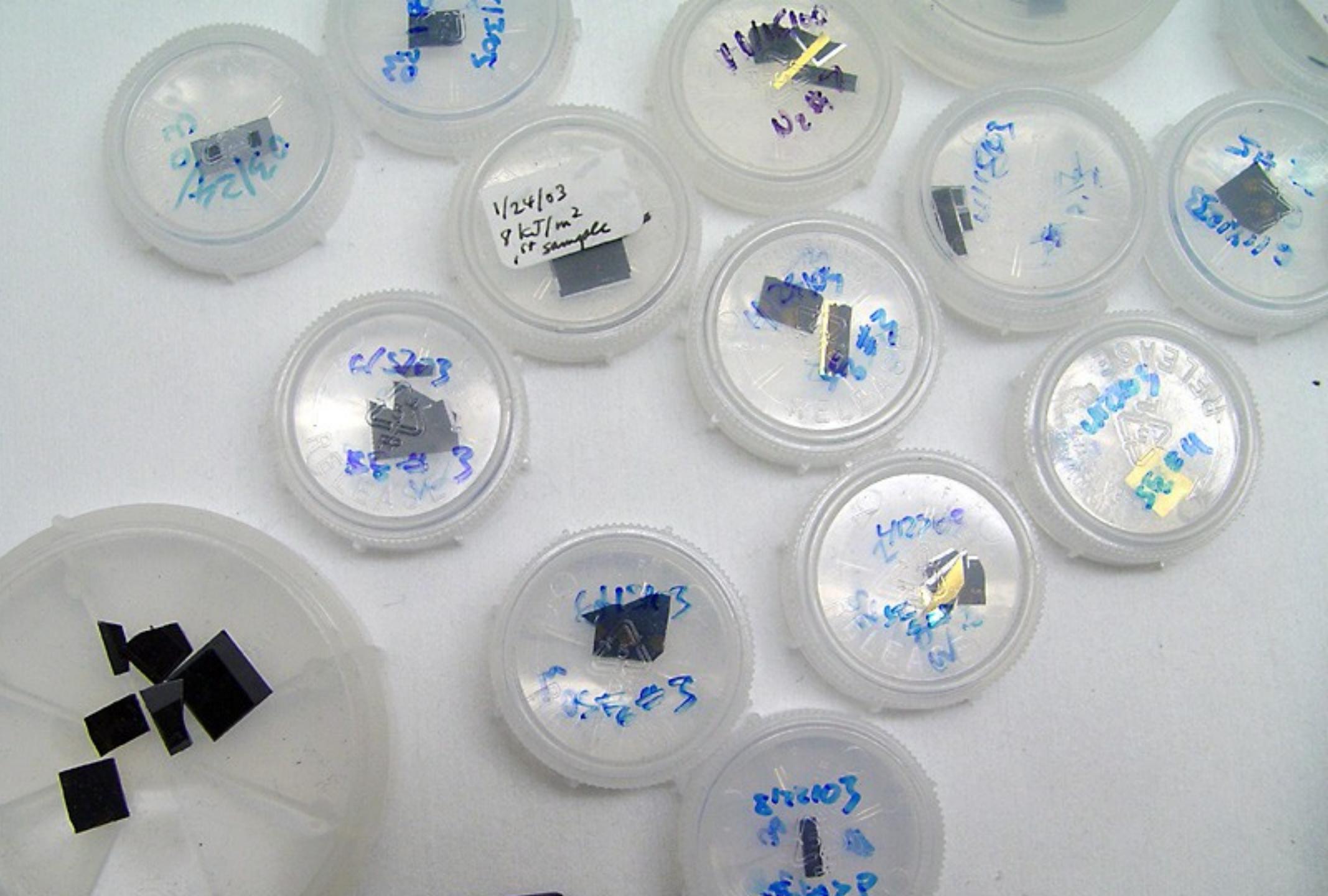
**both chromium and oxygen incorporated!**



1 texturing

2 doping

3  $X:TiO_2$



① texturing

② doping

③ X:TiO<sub>2</sub>

## Summary

Can produce:

- microstructured  $\text{TiO}_2$
- can dope  $\text{TiO}_2$  with Cr, but not N

1 texturing

2 doping

3 X: $\text{TiO}_2$





**Funding:**

**Army Research Office**

**DARPA**

**Department of Energy**

**NDSEG**

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